

146

12

146

: HAND WRITTEN NOTES:-

OF

①

ELECTRONICS & COMMUNICATION ENGINEERING

-: SUBJECT:-

MICROWAVE ENGINEERING

2

Microwave Engineering

1. Introduction
2. Microwave components
 - H-plane Tee
 - E-plane Tee
 - Directional coupler
 - Magic Tee
 - Rat Race Jn.
 - Ferrite devices (Isolator, Gyrotator, Circulator)
3. μ wave tubes
 - Two cavity klystron
 - Multi-cavity klystron
 - Reflex klystron
 - TWT (Travelling wave tube)
 - BWO (Backward wave oscillator)
 - Magnetron
4. Solid State devices
 - Tunnel diode
 - Gunn diode
 - Avalanche transit time device
(AMPATT, TRAPATT, BARITT)
5. Parametric amplifier
6. MASER
7. Cavity Resonator
8. μ wave communication
 - Terrestrial communication
9. μ wave measurement
10. μ wave antenna
11. Microstrip lines

Introduction :-

(4)

$f \rightarrow 300 \text{ MHz to } 300 \text{ GHz}$

But devices can use freqs upto 10^6 GHz

$$C = \lambda f$$

$$\lambda = \frac{C}{f}$$

where $f = 300 \text{ MHz}$ then $\lambda = \frac{3 \times 10^8}{300 \times 10^6} = 1 \text{ m}$

$f = 300 \text{ GHz}$ then $\lambda = \frac{3 \times 10^8}{300 \times 10^9} = 1 \text{ mm}$

$f = 10^6 \text{ GHz}$ then $\lambda = \frac{3 \times 10^8}{10^6 \times 10^9} = 0.3 \mu\text{m}$

* Microwaves are so called because they are defined in terms of their wavelength.

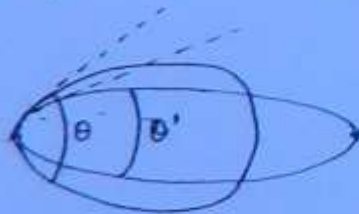
Advantage of Microwaves

1. Increased bandwidth availability.
2. Directivity of antenna increases.

$$\text{Beamwidth} \propto \lambda$$

$$\text{Directivity} \propto \frac{1}{\text{Beamwidth}}$$

$$\lambda \uparrow, \theta \downarrow, \text{BW} \downarrow, D \uparrow$$



$$\theta' < \theta$$

* So high gain & directive antenna can be designed & fabricated more easily at microwave freq.

3. Fading effect & reliability

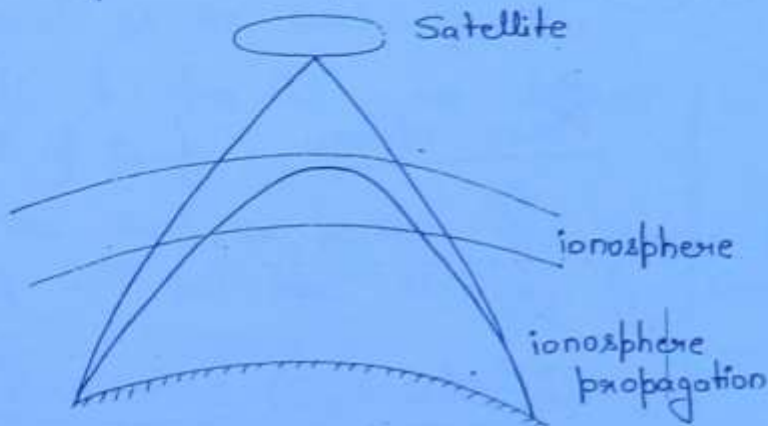
Due to line of sight (LOS) propagation & high freq., there is less fading effect & microwave communication is more reliable.

* Repeaters are placed at 50 km

4. Power Requirements

The Tx & Rx power requirements is very low at μ wave freq.

5. Transparency prop of μ wave.



6. Size of component $\propto \lambda$:

Since $\lambda \rightarrow$ is very small

So size \rightarrow is very small

& hence smaller system is possible

Applications of μ wave

1. Telecommunication - Inter continental telephone & T.V.

Space communication

Telemetry communication links for railways.

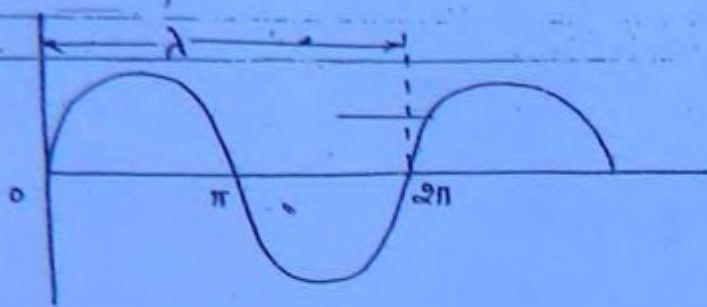
2. Radar

3. Commercial & industrial applications use heating property of μ wave.

Ex \Rightarrow μ wave oven, drying machine, machine / public works, food processing industries, biomedical application, electronic warfare.

$$\omega = \frac{d\theta}{dt} = \text{Rate of change of phase}$$

$$\omega = \frac{2\pi}{T} = 2\pi f$$



(6)

Path travelled	Phase change
λ	2π
$\lambda/2$	π
$\lambda/4$	$\pi/2$
l	$\frac{2\pi}{\lambda} \times l$

$f \rightarrow \text{low}$, $T \rightarrow \text{v. high}$, $\omega \rightarrow \text{low}$

Phase variation is negligible \rightarrow then lumped parameters are used.

$f \rightarrow \text{high}$, $\omega \rightarrow \text{high}$

Phase variation is very high \rightarrow then distributed parameters are used.

* When λ is large, there is negligible phase variation across the components ; so lumped parameters (R, L & C) or simple ckt. theory is applicable.

* When λ is small, there is high phase variation across the components & \therefore microwave components are distributed elements.

Band Designation

IEEE - Institute of Electrical & Electronics Engineering

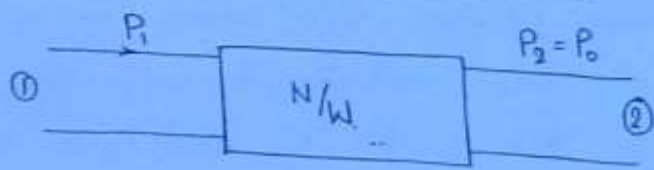
Band	Freq. Range
L	1-2 GHz
S	2-4 GHz
C	4-8 GHz
X	8-12 GHz
K _v	12-18 GHz
K	18-37 GHz
K _a	27-40 GHz

Microwave Components :-

If the freq. are in μ wave range, then h, y, z parameters can't be used for following reasons :-

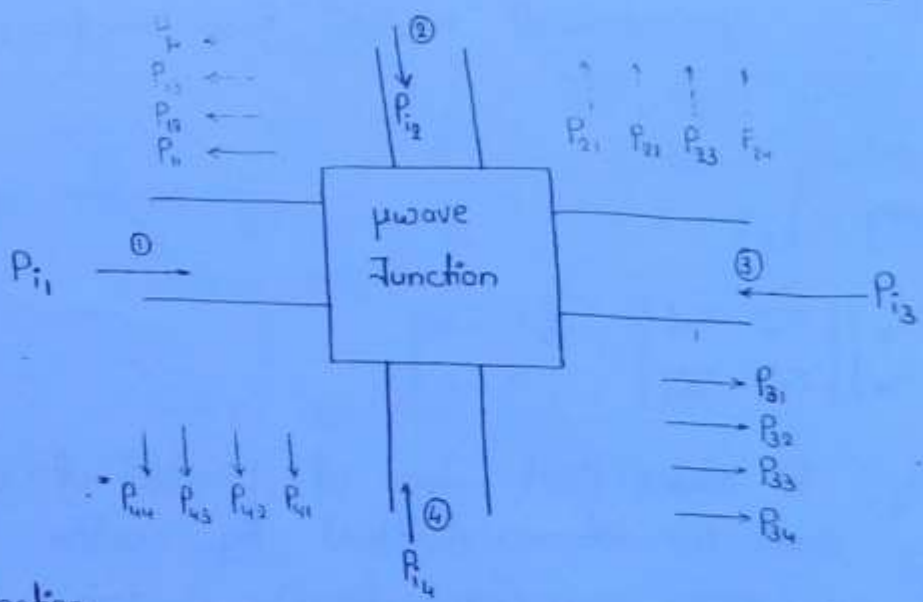
1. Equipment is not available to measure total voltage & total current at the port of N/w.
2. Short ckt. & open ckt. are difficult to achieve over broadband of freq.
3. Active device such as power transistors & tunnel diode frequently will not have stability for short or open ckt

Scattering Parameters (S-parameters)



$$S_{21} = S_{oi} = \sqrt{\frac{P_{o2}}{P_{i1}}} = \sqrt{\frac{P_{02}}{P_{i1}}}$$

o/p i/p



Reflection coefficient

$$[S] = \begin{bmatrix} S_{11} & S_{12} & S_{13} & S_{14} \\ S_{21} & S_{22} & S_{23} & S_{24} \\ S_{31} & S_{32} & S_{33} & S_{34} \\ S_{41} & S_{42} & S_{43} & S_{44} \end{bmatrix}_{4 \times 4}$$

$$S_{11} = \sqrt{\frac{P_{11}}{P_{11}}} = \sqrt{\frac{P_{ref,1}}{P_{11}}} = K_1 = \text{Reflection coefficient for port 1.}$$

$$S_{21} = \sqrt{\frac{P_{21}}{P_{11}}}$$

$$S_{43} = \sqrt{\frac{P_{43}}{P_{33}}}$$

$$S_{34} = \sqrt{\frac{P_{34}}{P_{44}}}$$

8

Conv. Properties of S-Matrix

1. It is a square matrix of size $n \times n$, where n is no. of ports.
2. Principle diagonal elements represent reflection coefficients of respective ports. For perfectly matched N/w, all the diagonal elements are zero.
i.e. $S_{11} = S_{22} = S_{33} = S_{44} = 0$
3. S-matrix is a symmetrical matrix for reciprocal N/w.
 $S_{12} = S_{21}$; $S_{43} = S_{34}$ etc.
4. [S] is a unitary matrix.

$$[S][S^*] = [I]$$

$$\underline{\text{Ex.}} \quad \begin{bmatrix} S_{11} & S_{12} \\ S_{21} & S_{22} \end{bmatrix} \begin{bmatrix} S_{11}^* & S_{12}^* \\ S_{21}^* & S_{22}^* \end{bmatrix} = \begin{bmatrix} 1 & 0 \\ 0 & 1 \end{bmatrix}$$

5. Zero property - It states that sum of product of each term of any row (or column) multiplied by complex conjugate of any other row (or column) is zero.

$$S_{11} S_{12}^* + S_{21} S_{22}^* + S_{31} S_{32}^* + S_{41} S_{42}^* = 0$$

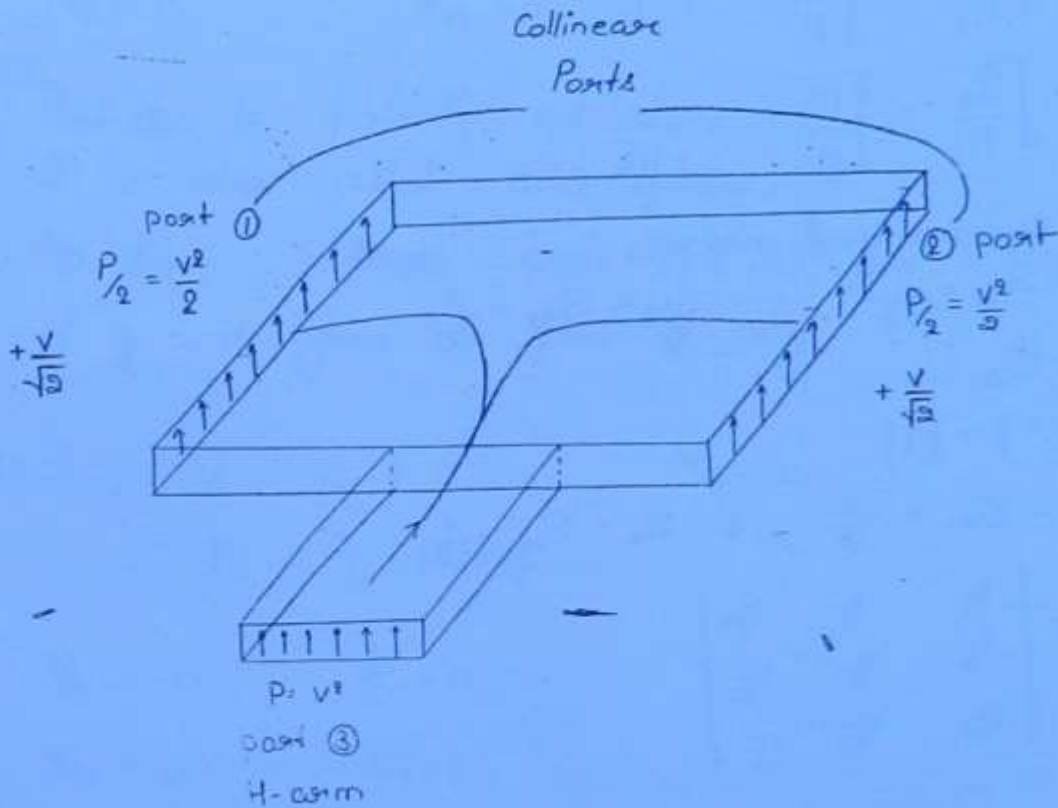
In general,

$$\boxed{\sum_{i=1}^n S_{ik} S_{ij}^* = 0 \text{ for } k \neq j}$$

6. If any of the pole or reference plane are moved away from the junction by an electronic distance pl then each of the coefficient of S-matrix will be multiplied by a factor of $e^{-j\beta l}$.

(9)

H-Plane Tee →



Magnetic field divided

↓
Current divided

↓
Shunt Junction

$$[S] = \begin{bmatrix} S_{11} & S_{12} & S_{13} \\ S_{21} & S_{22} & S_{23} \\ S_{31} & S_{32} & S_{33} \end{bmatrix}_{3 \times 3}$$

(10)

Port ③ or H-arm is perfectly matched.

$$\therefore S_{33} = 0$$

$$S_{13} = \sqrt{\frac{P_{13}}{P_{13}}} = \sqrt{\frac{P/2}{P}} = +\frac{1}{\sqrt{2}}$$

$$S_{23} = \sqrt{\frac{P_{23}}{P_{13}}} = \sqrt{\frac{P/2}{P}} = +\frac{1}{\sqrt{2}}$$

Since symmetrical matrix,

$$S_{13} = S_{31} = \frac{1}{\sqrt{2}} ; S_{23} = S_{32} = \frac{1}{\sqrt{2}}$$

$$S_{12} = S_{21}$$

$$[S][S^*] = [I]$$

$$\therefore S_{12} = S_{21} = -\frac{1}{2} \quad \& \quad S_{11} = S_{22} = \frac{1}{2}$$

$$[S] = \begin{bmatrix} 1/2 & -1/2 & 1/\sqrt{2} \\ -1/2 & 1/2 & 1/\sqrt{2} \\ 1/\sqrt{2} & 1/\sqrt{2} & 0 \end{bmatrix}$$

$$[V_o] = [S][V_i]$$

$$\begin{bmatrix} V_{o1} \\ V_{o2} \\ V_{o3} \end{bmatrix} = \begin{bmatrix} 1/2 & -1/2 & 1/\sqrt{2} \\ -1/2 & 1/2 & 1/\sqrt{2} \\ 1/\sqrt{2} & 1/\sqrt{2} & 0 \end{bmatrix} \begin{bmatrix} V_{i1} \\ V_{i2} \\ V_{i3} \end{bmatrix}$$

$$V_{o1} = \frac{1}{2} V_{i1} - \frac{1}{2} V_{i2} + \frac{1}{\sqrt{2}} V_{i3} \quad \text{--- ①}$$

$$V_{o2} = -\frac{1}{2} V_{i1} + \frac{1}{2} V_{i2} + \frac{1}{\sqrt{2}} V_{i3} \quad \text{--- ②}$$

$$V_{o3} = \frac{1}{\sqrt{2}} V_{i1} + \frac{1}{\sqrt{2}} V_{i2} \quad \text{--- ③}$$

Case 1. $V_{i3} = a$ $P_{i3} = a^2$ $V_{i1} = V_{i2} = 0$

$$V_{o1} = a/\sqrt{2}$$

$$P_{o1} = a^2/2 = P/2$$

$$V_{o2} = a/\sqrt{2}$$

$$P_{o2} = a^2/2 = P/2$$

$$V_{o3} = 0$$

$$P_{o3} = 0$$

Conclusion

1. Port ③ is perfectly matched.
2. It is also called 3dB splitter.
3. O/p from collinear ports (1 & 2) are in same phase if i/p is given to port ③ only.

Case 2. $V_{i1} = V_{i2} = 0$ $V_{i3} = 0$

$$P_{i1} = P_{i2} = P = a^2$$

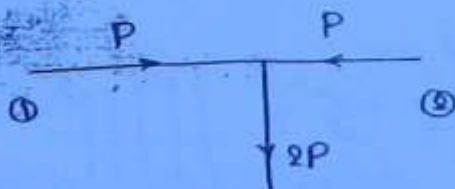
$$V_{o1} = 0$$

$$P_{o1} = 0$$

$$V_{o2} = 0$$

$$P_{o2} = 0$$

$$V_{o3} = \frac{2a}{\sqrt{2}} = \sqrt{2}a \Rightarrow P_{o3} = 2a^2$$



Port ③ (H-arm) is also called Additive port.

Case 3.

$$V_{i1} = 0 \quad V_{i2} = V_{i3} = 0$$

$$P_{i1} = P = a^2$$

$$V_{o1} = a/2 \quad P_{o1} = a^2/4 = P/4$$

$$V_{o2} = -a/2 \quad P_{o2} = a^2/4 = P/4$$

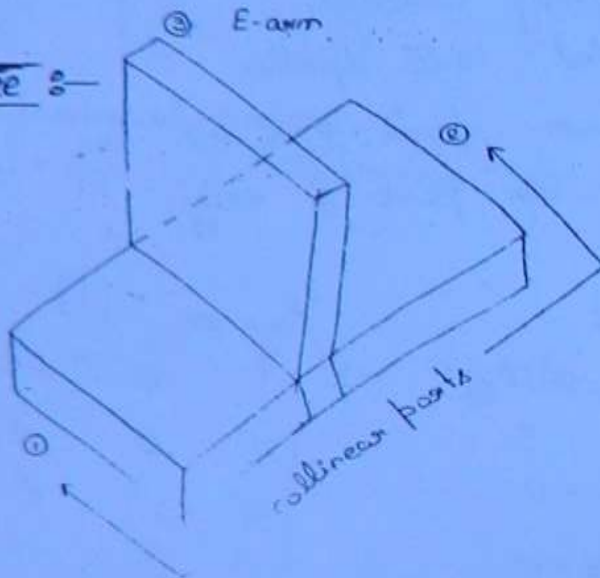
$$V_{o3} = -a/\sqrt{2} \quad P_{o3} = a^2/2 = P/2$$

Op from collinear ports are out of phase by 180° if
 if P is given to one of collinear ports.

(12)



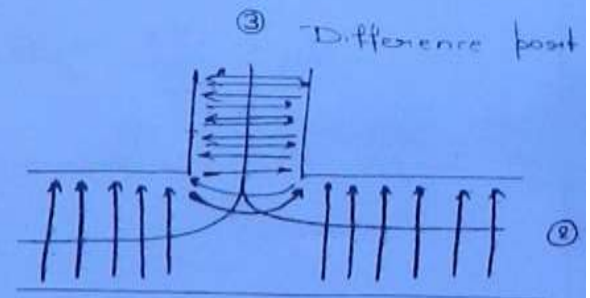
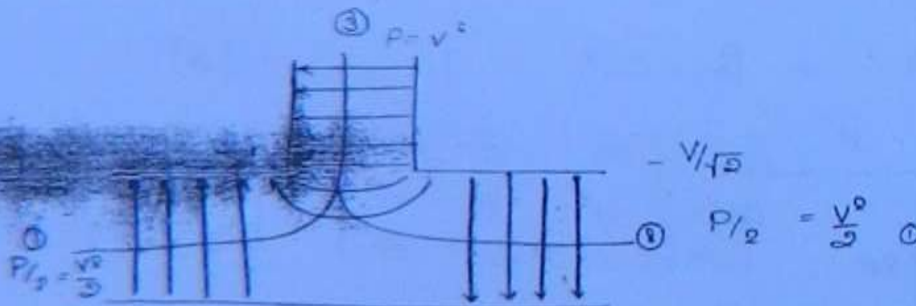
E-plane Tee :-



Electric field divided

↓
Voltage divided

↓
Series Junction



#

$$S = \begin{bmatrix} S_{11} & S_{12} & S_{13} \\ S_{21} & S_{22} & S_{23} \\ S_{31} & S_{32} & S_{33} \end{bmatrix}$$

port 3 on E-arm is perfectly matched.

$$S_{33} = 0$$

$$S_{13} = \sqrt{\frac{P_{01}}{P_3}} = \sqrt{\frac{P_{12}}{P}} = +\frac{1}{\sqrt{2}} = S_{31}$$

$$S_{23} = \sqrt{\frac{P_{02}}{P_{13}}} = \sqrt{\frac{P_{12}}{P}} = -\frac{1}{\sqrt{2}} = -S_{33}$$

(13)

$$[S][S^*] = [1]$$

$$S_{12} = S_{21}$$

$$S_{11} = S_{22} = S_{21} = S_{12} = \frac{1}{2}$$

$$\begin{bmatrix} V_{01} \\ V_{02} \\ V_{03} \end{bmatrix} = \begin{bmatrix} 1/2 & 1/2 & 1/\sqrt{2} \\ 1/2 & 1/2 & -1/\sqrt{2} \\ 1/\sqrt{2} & -1/\sqrt{2} & 0 \end{bmatrix} \begin{bmatrix} V_{i1} \\ V_{i2} \\ V_{i3} \end{bmatrix}$$

$$V_{01} = \frac{1}{2} V_{i1} + \frac{1}{2} V_{i2} + \frac{1}{\sqrt{2}} V_{i3}$$

$$V_{02} = \frac{1}{2} V_{i1} + \frac{1}{2} V_{i2} - \frac{1}{\sqrt{2}} V_{i3}$$

$$V_{03} = \frac{1}{\sqrt{2}} V_{i1} - \frac{1}{\sqrt{2}} V_{i2}$$

Case 1. $V_{i1} = V_{i2} = 0$ $V_{i3} = a \Rightarrow P = a^2$

$$V_{01} = \frac{a}{\sqrt{2}} \Rightarrow P_{01} = \frac{a^2}{2} = P_{12}$$

$$V_{02} = -\frac{a}{\sqrt{2}} \Rightarrow P_{02} = \frac{a^2}{2} = P_{12}$$

$$V_{03} = 0 \Rightarrow P_{03} = 0$$

- port ③ (E-arm) is perfectly matched
- dp from collinear ports [1 & 2] are out of phase by 180° if ilp is given to port ③ (E-arm) only.
- 3-dB splitter.

Case 2 $V_{i1} = V_{i2} = 0$ $V_{i3} = 0$

$$P_{i1} = P_{i2} = a^2 = P$$

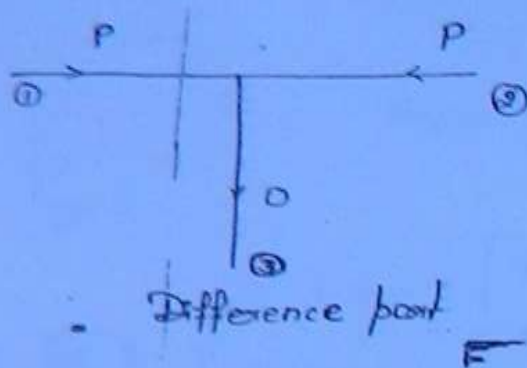
$$V_{01} = a \quad P_{01} = a^2 = P$$

$$V_{a2} = a \quad P_{a2} = a^2 = P$$

$$V_{a3} = 0$$

$$P_{a3} = 0$$

(14)



Case 3.

$$V_{i1} = a$$

$$V_{i2} = V_{i3} = 0$$

$$V_{o1} = a/\sqrt{2}$$

$$P_{o1} = a^2/4 = P/4$$

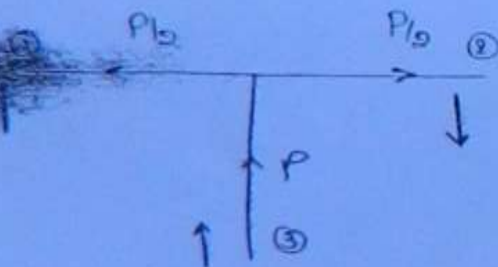
$$V_{o2} = a/\sqrt{2}$$

$$P_{o2} = a^2/4 = P/4$$

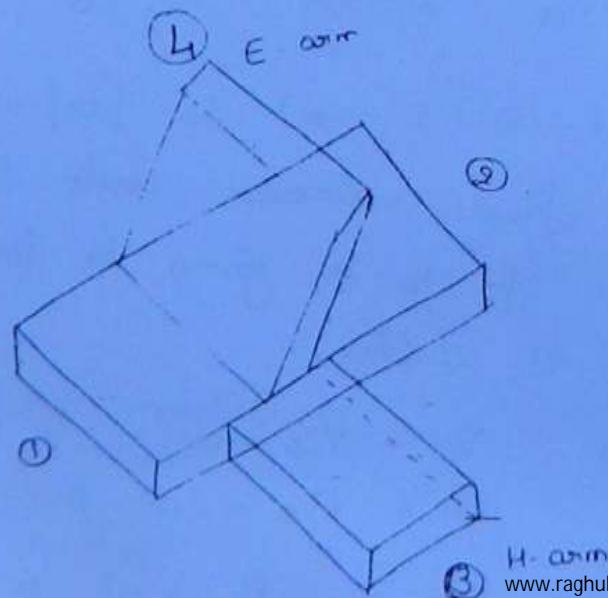
$$V_{o3} = a/\sqrt{2}$$

$$P_{o3} = a^2/2 = P/2$$

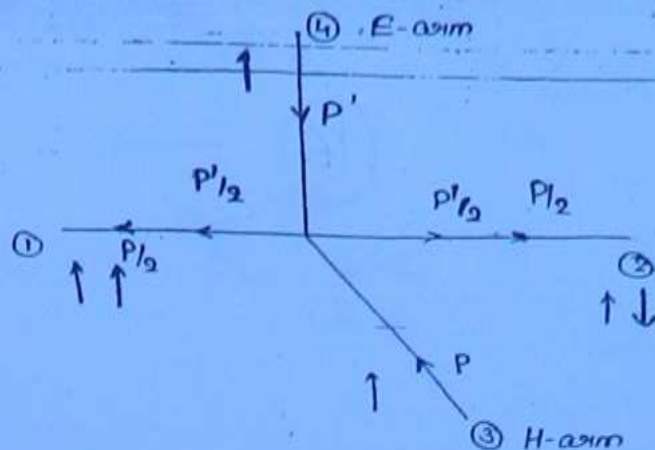
a_p from collinear ports - are in phase if i/p is given to any of collinear ports.



Hybrid Tee [E-H plane Tee]



3.



(15)

$$S = \begin{bmatrix} S_{11} & S_{12} & S_{13} & S_{14} \\ S_{21} & S_{22} & S_{23} & S_{24} \\ S_{31} & S_{32} & S_{33} & S_{34} \\ S_{41} & S_{42} & S_{43} & S_{44} \end{bmatrix}$$

* All four ports are perfectly matched.

$$S_{11} = S_{22} = S_{33} = S_{44} = 0$$

∴ It is called Magic Tee.

$$S_{13} = S_{31} = \frac{1}{\sqrt{2}}$$

$$S_{23} = S_{32} = \frac{1}{\sqrt{2}}$$

$$S_{14} = S_{41} = \frac{1}{\sqrt{2}}$$

$$S_{24} = S_{42} = -\frac{1}{\sqrt{2}}$$

* H-arm port ③ & E-arm port ④ are isolated ports

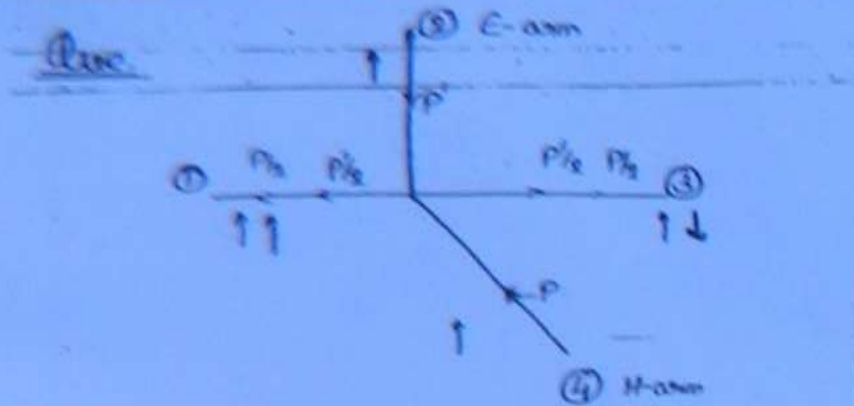
$$S_{34} = S_{43} = 0$$

$$S_{12} = S_{21}$$

$$S_{12} = S_{21} = 0$$

$$S = \begin{bmatrix} 0 & 0 & \frac{1}{\sqrt{2}} & \frac{1}{\sqrt{2}} \\ 0 & 0 & \frac{1}{\sqrt{2}} & \frac{1}{\sqrt{2}} \\ \frac{1}{\sqrt{2}} & \frac{1}{\sqrt{2}} & 0 & 0 \\ \frac{1}{\sqrt{2}} & \frac{1}{\sqrt{2}} & 0 & 0 \end{bmatrix}$$

∴ collinear ports [1 & 2] are isolated ports.



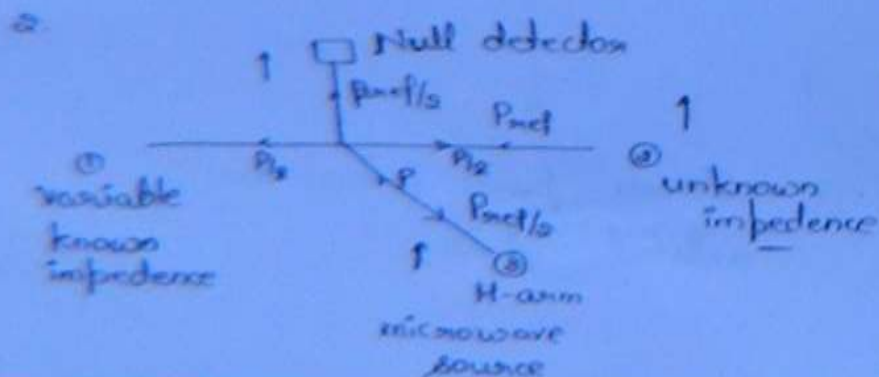
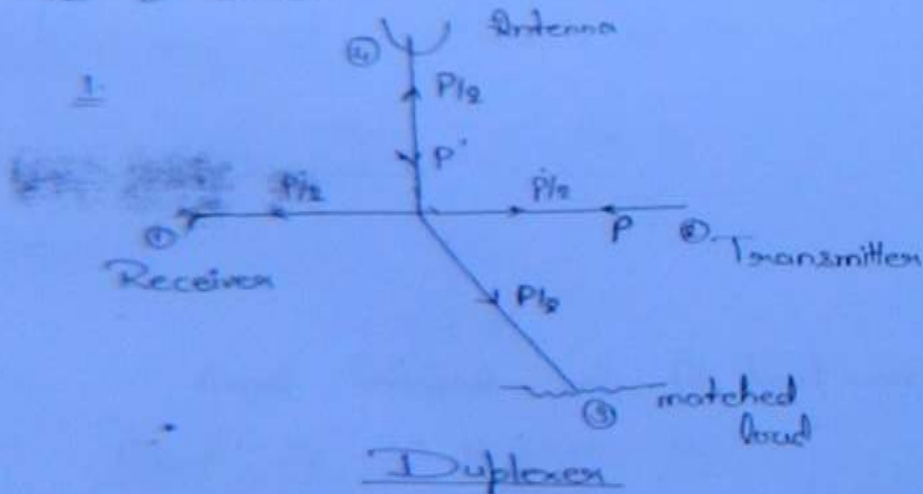
Solu.

$$S = \begin{bmatrix} 0 & \frac{1}{\sqrt{2}} & 0 & \frac{1}{\sqrt{2}} \\ \frac{1}{\sqrt{2}} & 0 & -\frac{1}{\sqrt{2}} & 0 \\ 0 & \frac{1}{\sqrt{2}} & 0 & \frac{1}{\sqrt{2}} \\ \frac{1}{\sqrt{2}} & 0 & \frac{1}{\sqrt{2}} & 0 \end{bmatrix}$$

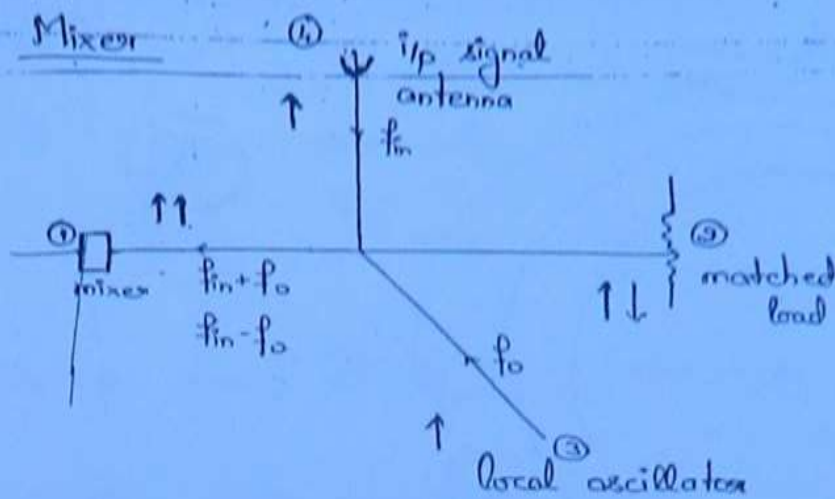
Application

Magic Tee is used as -

- 1. As Duplexer in Radar
- 2. Measurement of unknown impedance.
- 3. As a mixer



Mixer



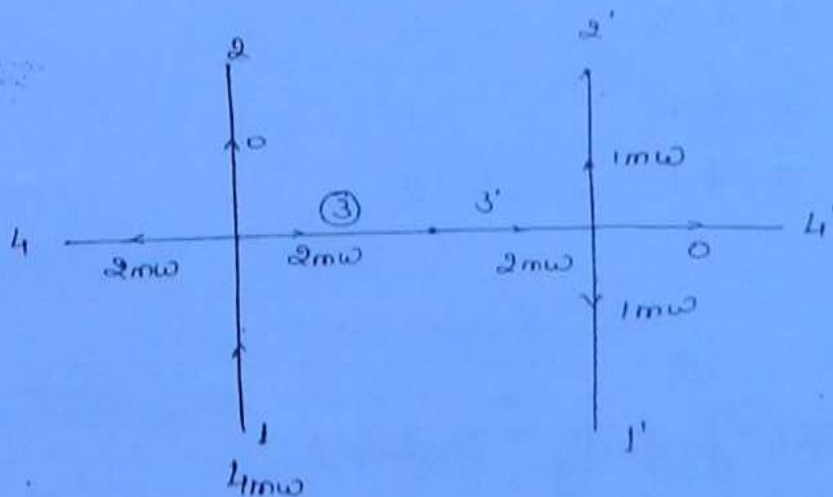
Que Two matched Hybrid Tee are connected through two H-plane waveguides to form a 6 port device. If 4m watt power is fed into port 1, the o/p power (in m watt) in other 5 ports namely 1', 2, 2', 4, 4' will be respectively -

A) 0, 4, 0, 0, 0

B) 1, 0, 1, 2, 0

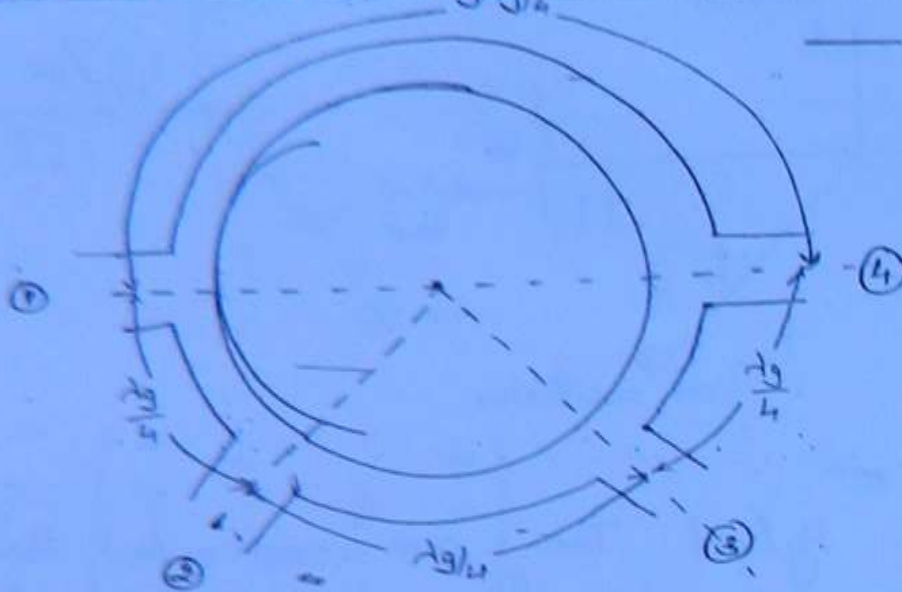
C) 1, 0, 1, 0, 2

D) 0, 2, 1, 1, 0



Rat Race Junction

18



$$\text{Circumference} = \frac{6\lambda_g}{4} = 1.5\lambda_g$$

λ_g = Guided Wavelength

#	i/p to port	o/p from consecutive ports	No. o/p
1		2 & 4	3
2		1 & 3	4
3		2 & 4	1
4		3 & 1	2

$$S_{11} = S_{22} = S_{33} = S_{44} = 0$$

- * All four ports are perfectly matched.
- * 1 & 3 are isolated ports.

$$S_{13} = S_{31} = 0$$

2 & 4 are isolated ports.

$$S_{24} = S_{42} = 0$$




5.

2.9

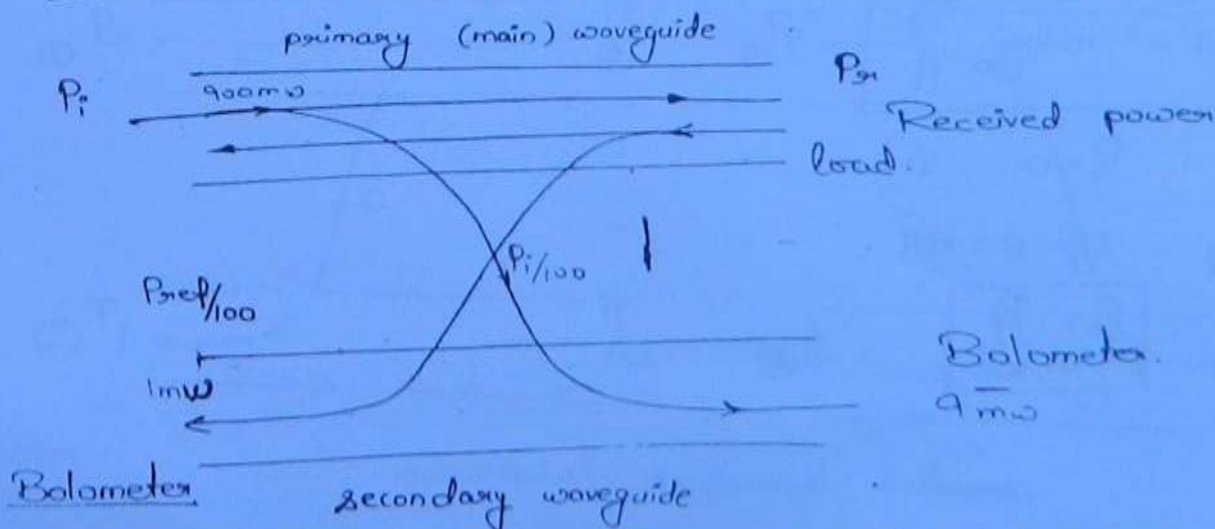
$$[S] = \begin{bmatrix} 0 & S_{12} & 0 & S_{14} \\ S_{21} & 0 & S_{23} & 0 \\ 0 & S_{32} & 0 & S_{34} \\ S_{41} & 0 & S_{43} & 0 \end{bmatrix}_{4 \times 4}$$

(19)

* It is a freq. sensitive device.

Input to port 1	Path Travelled	Path difference	Phase difference	Remarks
divided into two parts	upto port ④			Add
a) 	$3\lambda/4$ $3\lambda/4$	0	0	\therefore o/p from ④
b) 	upto ② $5\lambda/4$ $\lambda/4$	$\lambda/2$	2π	Add. o/p from ②
c) 	upto ③ $\lambda/2$ $\lambda/2$	$\lambda/2$	π	cancel o/p = 0

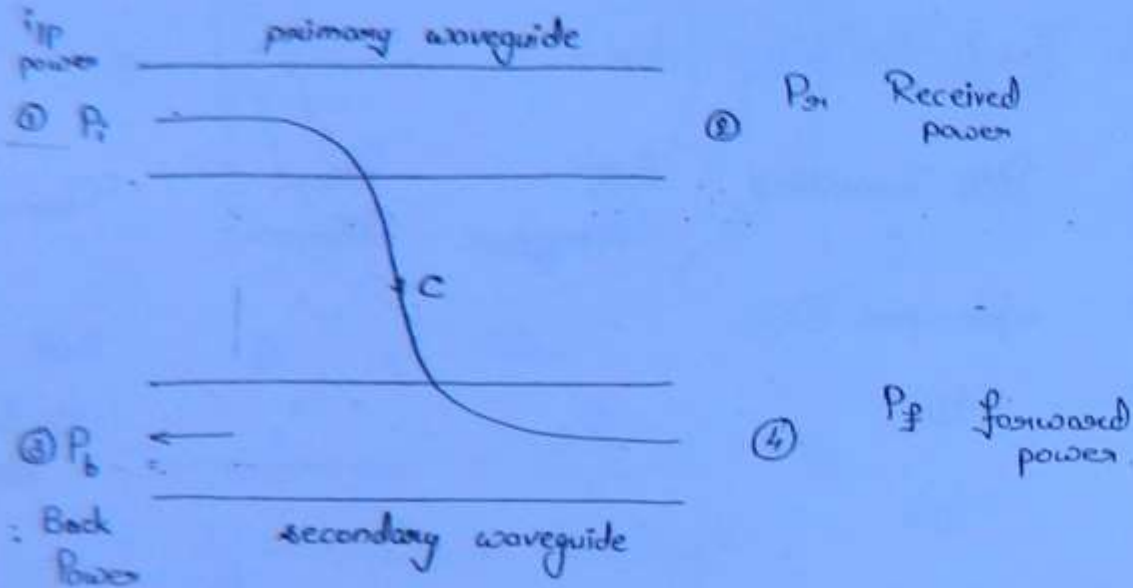
Directional Coupler :-



$$K = \sqrt{\frac{P_{ref}}{P_i}} = \frac{Z_L - Z_0}{Z_L + Z_0}$$

$Z_0 = \text{char. impedance}$

(20)



= Coupling Factor $\rightarrow [C]$

$$C = 10 \log_{10} \frac{P_i}{P_f}$$

normally

$$C = 20 \text{ dB}$$

$$\frac{P_b}{P_i} = \frac{P_f}{100}$$

= Directivity $\rightarrow [D]$

$$D = 10 \log_{10} \frac{P_f}{P_b}$$

ideally

$$P_b = 0 \quad D = \infty$$

normally

$$D = 60 \text{ dB}$$

$$\frac{P_b}{P_i} = \frac{P_f}{10^6}$$

Isolation Factor [I] →

$$I = 10 \log_{10} \frac{P_i}{P_b}$$

(21)

ideally $P_b = 0$ $I = \infty$

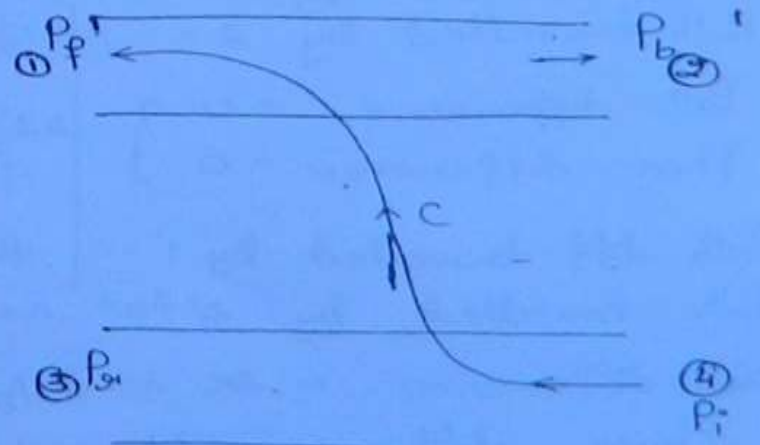
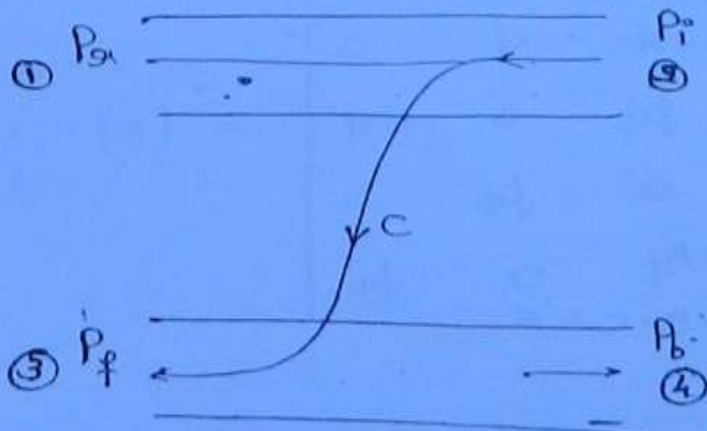
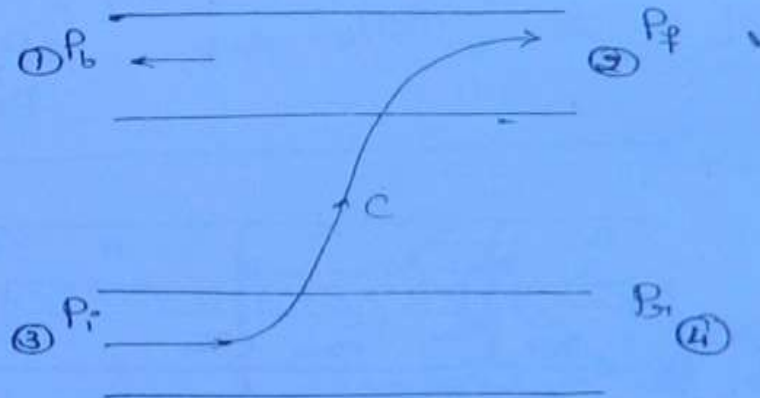
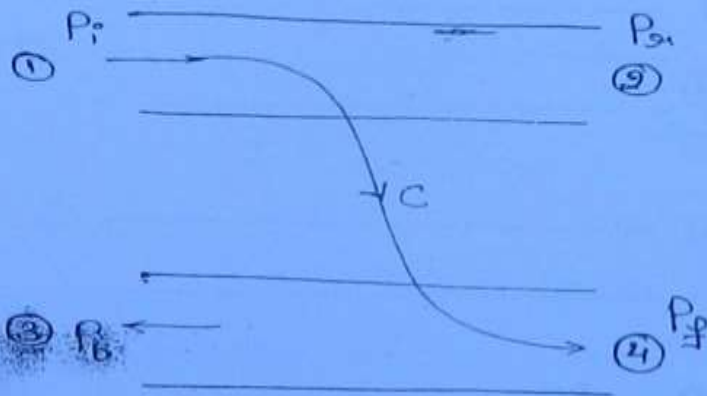
normally $I = 10 \log_{10} \frac{P_i}{P_f} \times \frac{P_f}{P_b}$

$$I = 10 \log_{10} \frac{P_i}{P_f} + 10 \log_{10} \frac{P_f}{P_b}$$

$$I = C + D = 80 \text{ dB}$$

$$P_b = \frac{P_i}{10^8}$$

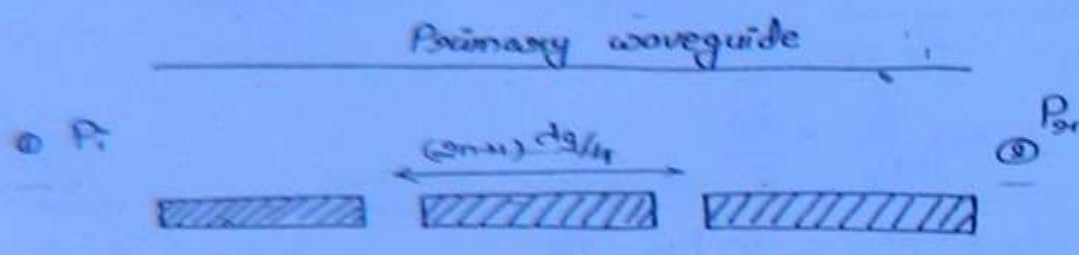
Symmetrical Directional Coupler →



symmetrical reciprocal network.

(22)

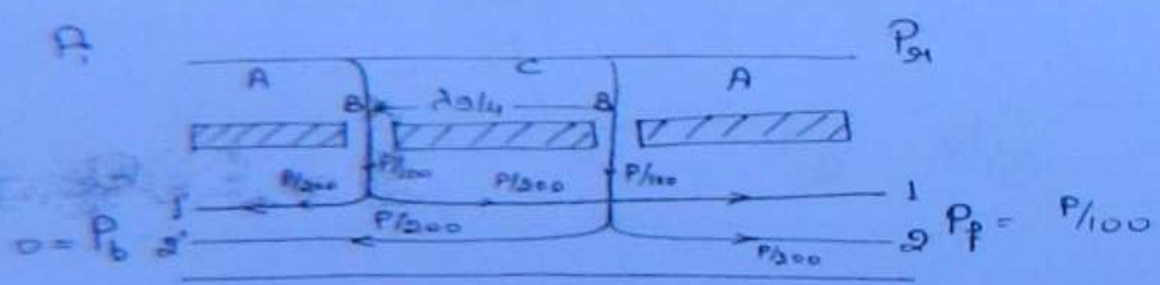
Two hole directional coupler :-



Secondary waveguide

Gap b/w two hole = odd multiple of $\lambda_g/4$
 $= (2n+1) \lambda_g/4$
 $n = 0, 1, 2, 3, 4, \dots$

take $n = 0$
 $= \lambda_g/4$



Path travelled by 1 = $A+B+C+A$
 Path travelled by 2 = $A+C+B+A$

Path difference = 0
 Phase difference = 0 } Add.

Path ~~diff~~ travelled by 1' = $A+B+A$
 Path travelled by 2' = $A+C+B+C+A$

Path difference = $2C = \lambda_g/2$

Phase difference b/w 1' & 2' = π

Sub $\Rightarrow 0$

$$[S] = \begin{bmatrix} S_{11} & S_{12} & S_{13} & S_{14} \\ S_{21} & S_{22} & S_{23} & S_{24} \\ S_{31} & S_{32} & S_{33} & S_{34} \\ S_{41} & S_{42} & S_{43} & S_{44} \end{bmatrix}_{4 \times 4}$$

(23)

* All four ports are perfectly matched

$$\therefore S_{11} = S_{22} = S_{33} = S_{44} = 0$$

* 1 & 3 are isolated ports

$$S_{13} = S_{31} = 0$$

* 2 & 4 are isolated ports

$$S_{24} = S_{42} = 0$$

$$P_g = p^2 V^2$$

$$pV \quad p < 1$$

$$S_{21} = \sqrt{\frac{P_2}{P_1}} = \sqrt{\frac{p^2 V^2}{V^2}} = p = S_{12}$$

$$P_f = q^2 V^2$$

$$qV \quad q < 1$$

$$S_{41} = S_{14} = jq$$

$$\textcircled{1} \quad \textcircled{2} qV$$

$$S_{34} = S_{43} = p$$

$$S_{32} = S_{23} = jq$$

$$\textcircled{3} V \quad \textcircled{4} pV$$

$$\Rightarrow [S] = \begin{bmatrix} 0 & p & 0 & jq \\ p & 0 & jq & 0 \\ 0 & jq & 0 & p \\ jq & 0 & p & 0 \end{bmatrix}_{4 \times 4}$$

Que.

$$[S] = \begin{bmatrix} 0 & p & 0.0001 & j0.01 \\ p & 0.0001 & j0.01 & 0.0001 \\ 0.0001 & j0.01 & 0 & p.0001 \\ j0.01 & 0.0001 & p.0001 & 0 \end{bmatrix}$$

Calc: c, d & I

(24)

$$P_{10} \xrightarrow{v^2} P_1 \text{ (3)} \quad p^2 v^2$$

$$10^8 v^2 \text{ (3)} \xrightarrow{P_B} P_B \text{ (4)} \quad 10^{-4} v^2$$

Sol.

$$C = 10 \log_{10} \frac{P_i}{P_f}$$

$$q = 0.01$$

$$P_f = q^2 v^2$$

$$C = 10 \log_{10} \frac{v^2}{q^2 v^2}$$

$$= 10 \log_{10} \frac{1}{(0.01)^2}$$

$$= 10 \log_{10} 10^4$$

$$C = 40 \text{ dB}$$

$$D = 10 \log_{10} \frac{P_f}{P_b}$$

$$= 10 \log_{10} \frac{10^4 v^2}{10^8 v^2}$$

$$= 10 \log_{10} 10^{-4}$$

$$= -40 \text{ dB}$$

$$I = C + D$$

$$= 40 + (-40)$$

$$= 0 \text{ dB}$$

ch 1

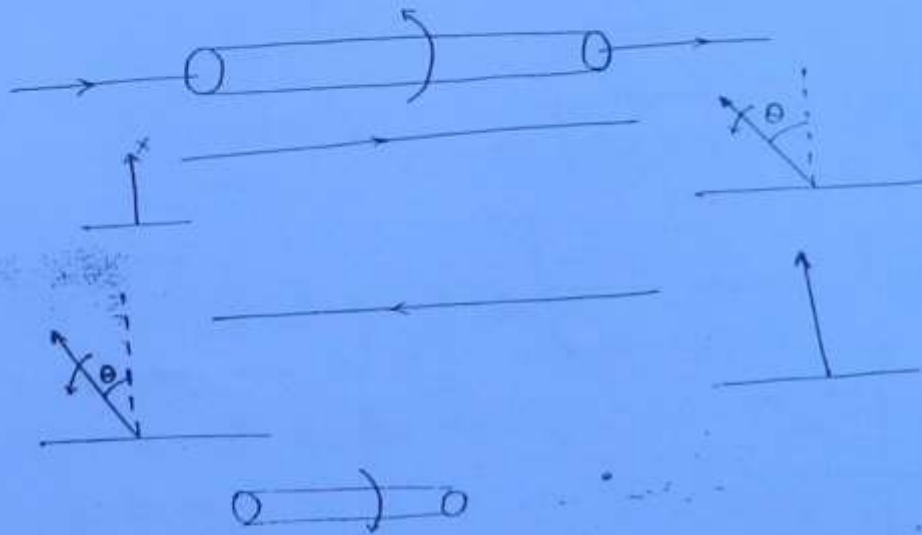
Que.

Pg. 39

Ferrite Devices:

- * Ferrite is a non-metallic material with resistivity 10^4 times greater than that of metal.
- * Dielectric constant $\epsilon_r = 10$ to 15
Relative permeability μ_r are order of 1000 , they are oxide based compound, having general composition of the form $MeO \cdot Fe_2O_3$
 $Me \rightarrow Zn, Mn, Cd, Ni$
- * Ferrite find applications in no. of microwave devices to reduce reflected power, for modulation purpose, in switching device etc. bcz of high resistivity it can be used upto 100 GHz .
- * Ferrite have one imp. property which is useful at microwave freq. i.e. non-reciprocal property.

Ferrite Rod



- # A linearly polarized wave along x-axis is allowed to propagate through ferrite Rod in z-direction then the plane of polarization of this wave rotate with distance, this phenomena is known as Farade

Rotation

Angle of rotation θ is independent of diaⁿ of propagation (non-reciprocal property) it depends only on total length

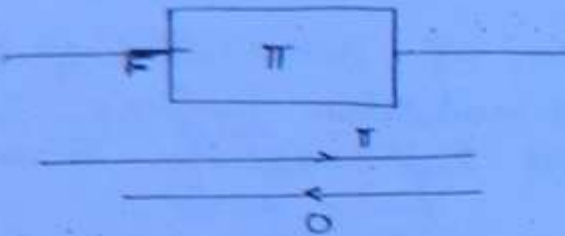
travelled by wave through ferrite rod, so (odd)

Ferrite devices

(26)

1. Gyration
2. Isolator
3. Circulator

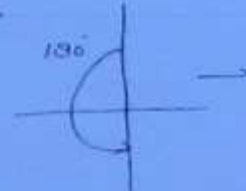
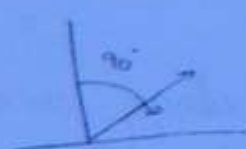
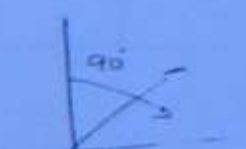
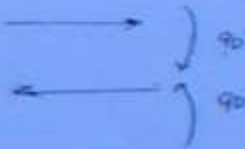
Gyration :-

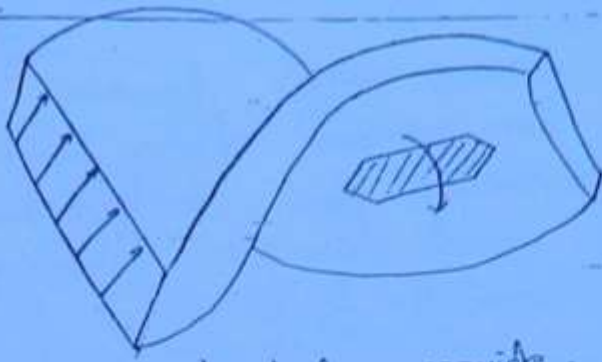


It is a two port device has relative phase difference of 180° for transmission from port ① to port ② and no phase shift for transmission from ② to ①.

Reciprocal device

non-reciprocal device





(27)

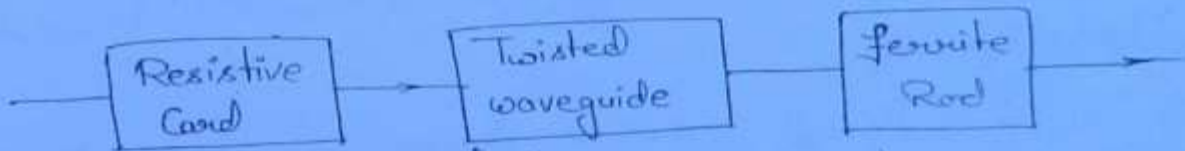
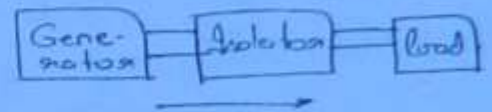
twisted waveguide

Isolator :-



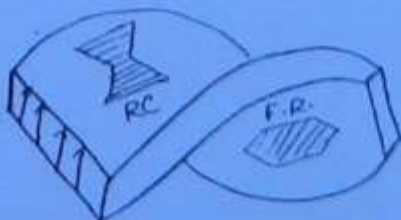
small attenuation

max attenuation



If line of polarisation is \parallel to resistive card then resistive card will absorb signal.

If line of polarisation \perp to RC then RC will pass it.



Mode filter :-

(28)

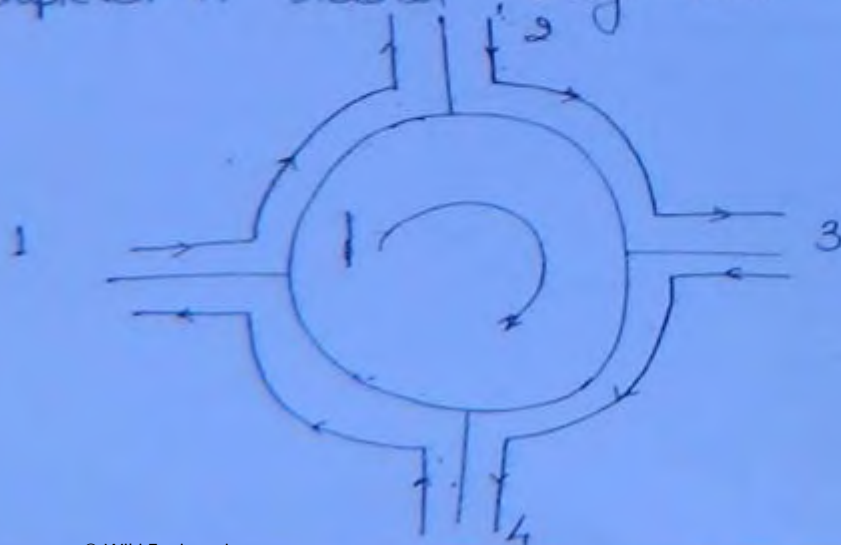
Isolator is a two port device which provide very small amount of attenuation for xmission from port ① to port ② but provide max. attenuation for xmission from ② to ①. This requirement is very much desirable when we want to match source with variable load.

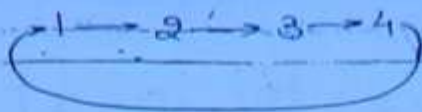
When isolator is inserted b/w generator & load. Generator is coupled to load with zero attenuation & reflection from load are completely absorb by isolator without affecting the generator o/p. Hence generator appears to be matched for all load in presence of isolator so that there is no change in freq. & o/p power due to variation in load.

Note :- Ferrite rods are tapered at both end to reduce the attenuation & also for smooth start rotation of the linearly polarized wave.

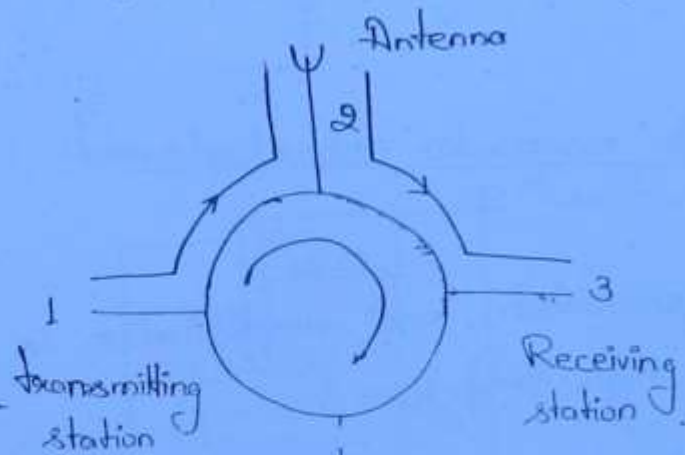
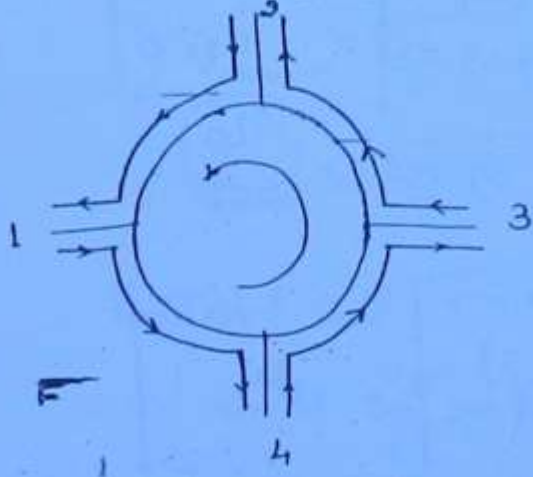
Circulator →

- * It is unidirectional microwave device in which power i/p to any port will be received by its consecutive port in one direction (either in clockwise or counter-clockwise).
- * Circulators are used in parametric amp^s, tunnel diode, duplexers in radar magnetron etc.





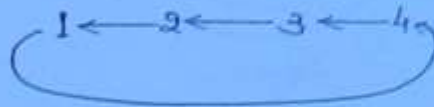
Clock wise.



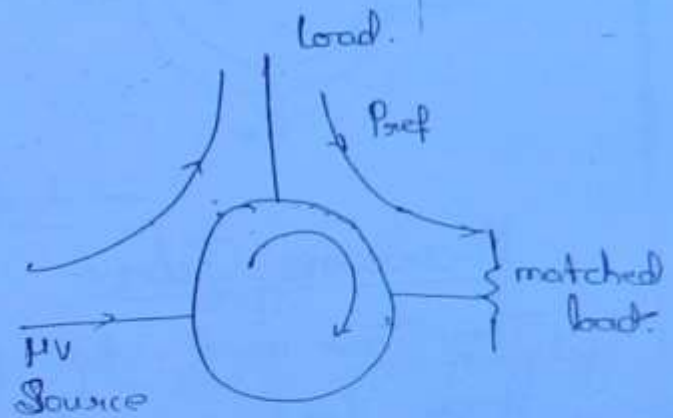
matched load

Duplex in Radar

(29)

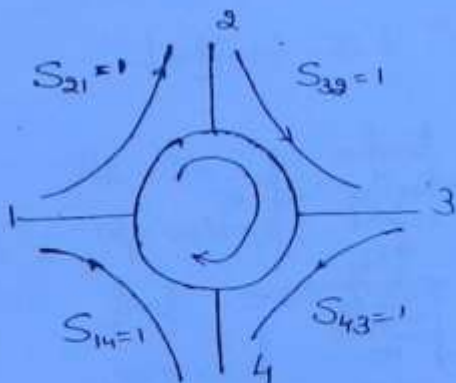


Counter-clock-wise

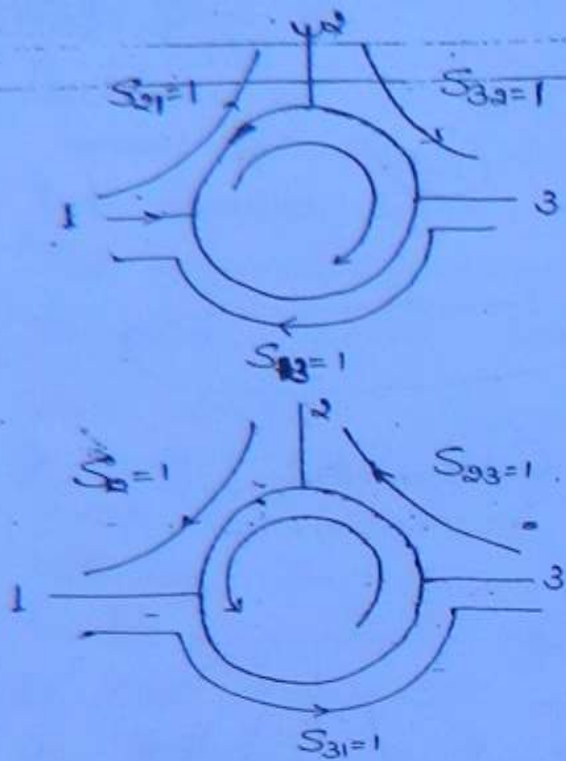


$$k = \sqrt{\frac{P_{ref}}{P_{io}}} = \frac{Z_L - Z_0}{Z_L + Z_0}$$

⇒ We can calc. unknown impedance by using circulator.



$$\Rightarrow [S] = \begin{bmatrix} 0 & 0 & 0 & 1 \\ 1 & 0 & 0 & 0 \\ 0 & 1 & 0 & 0 \\ 0 & 0 & 1 & 0 \end{bmatrix}_{4 \times 4}$$



$$[S] = \begin{bmatrix} 0 & 0 & 1 \\ 1 & 0 & 0 \\ 0 & 1 & 0 \end{bmatrix}$$

(30)

$$[S] = \begin{bmatrix} 0 & 1 & 0 \\ 0 & 0 & 1 \\ 1 & 0 & 0 \end{bmatrix}$$

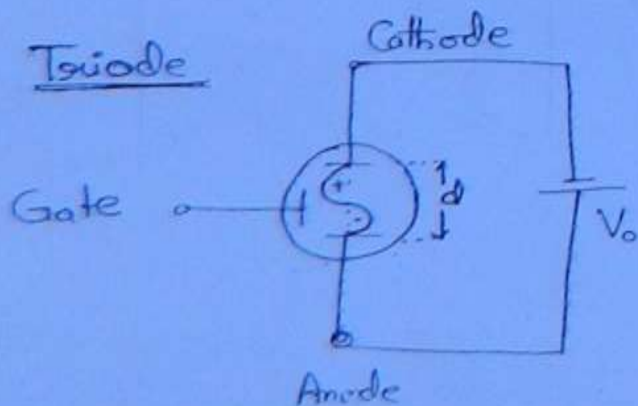
Microwave Tubes :-

They are used for generation and amplification in microwave freq. range (very high freq.).

Limitation of conventional tube →

1. Inter-electrode capacitance effect
2. Lead inductance effect
3. Transient time effect
4. Gain-bandwidth product (GBW)
5. Effect due to RF loss
6. Radiation loss.

Trioode



V_0 = velocity of e^-

$$\frac{1}{2} m v_0^2 = q V_0$$

$$V_0 = \sqrt{\frac{2 q V_0}{m}}$$

$$q = 1.6 \times 10^{-19}$$

$$m = 9.1 \times 10^{-31} \text{ Kg}$$

$$V_0 = 0.59 \times 10^6 \sqrt{V_0} \text{ m/sec}$$

V_0 = DC voltage (volt)

$$V_r \sin \omega t \quad V_1 < V_0$$

$$V_0' = \sqrt{\frac{2q}{m} (V_0 + V_1 \sin \omega t)}$$

(31)

$$V_{0\max}' = \sqrt{\frac{2q}{m} (V_0 + V_1)}$$

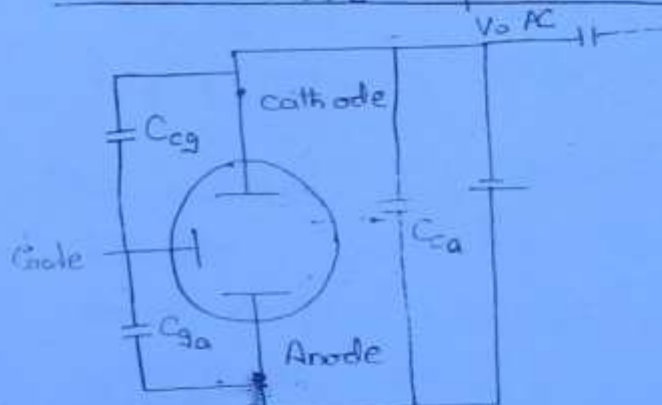
$$V_{0\max}' = \sqrt{\frac{2q}{m} (V_0 - V_1)}$$

transit time $\tau = d/v_0$ time taken by e^- to reach anode to cathode.

T should be comparable to τ

$$T = \frac{1}{f}$$

1. Inter-electrode capacitance effect \rightarrow



$$Z_c = \frac{1}{2\pi f C}$$

$f \rightarrow$ Low

$Z_c =$ Very high

$C \rightarrow$ act as OC

$f \rightarrow$ very high

$Z_c =$ Very low

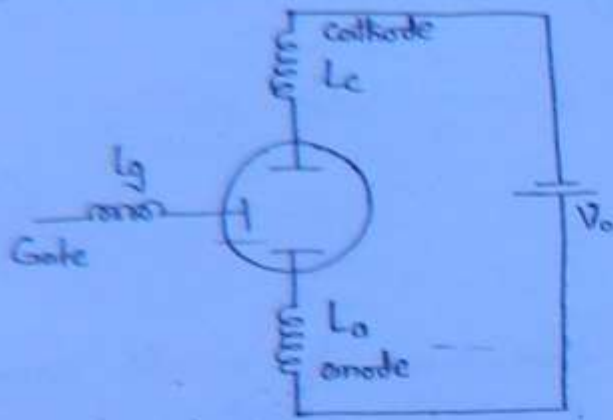
$$C = \frac{\epsilon_0 A}{d}$$

\downarrow effect $C \downarrow Z_c \uparrow A \downarrow$ and/or $d \uparrow$

As Z_c is equal to $\frac{1}{2\pi f C}$ with \uparrow in f fixed. Z_c decreases and at very high frequency due to shunting effect C_{ga} , C_{cg} & C_{ca} become almost zero.

Inter-electrode capacitance effect (IEC) can be minimised by area of electrode and/or by increasing the distance b/w electrode.

2. Lead Inductance effect →



(32)

$$|Z_L| = 2\pi fL$$

$f \rightarrow \text{low}$

$Z_L = \text{Very low}$

$L - \text{act as SC.}$

$f \rightarrow \text{very high}$

$Z_L = \text{Very high.}$

As $|Z_L| = 2\pi fL$ with f in fixed. reactance \uparrow so the voltage appearing across the active electrode is less than voltage appearing across the lead, this effect reduces the gain.

3. Transient time effect →

$$\tau = \frac{d}{V_0}$$

$$d = 0.593 \times 10^6 \sqrt{V_0}$$

$V_0 = \text{dc voltage}$

$$T \approx \tau$$

$f = \text{very high}$ $T = \text{very very low.}$

for useful gain $\tau \downarrow$

$$\tau \downarrow \quad d \downarrow \quad C = \frac{\epsilon_0 A}{d} \quad C \uparrow \quad Z_C \downarrow \quad \text{IEC} \uparrow$$

$\tau \downarrow \quad V_0 \uparrow \quad V_0 \uparrow$ there is limitation of supply.

* Transient time is time taken by e^- to travel from cathode to anode. τ should be comparable to time period of the signal for useful gain.

At very high freq. T is very low i.e. as the freq. \uparrow .

$\tau \uparrow$ w.r.t time period of signal.

To reduce the effect the distance b/w cathode & anode.

19 δ is reduced but this will \uparrow the IEC effect.
So the τ & IEC are conflicting in nature.

4. GBW $\&$ limitations \rightarrow

(33)

1. GBW is a constant.
2. BW \uparrow Gain \downarrow

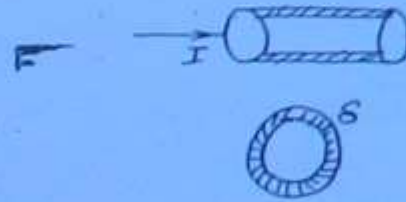
5. Effect due to RF loss \rightarrow

a) Skin effect :-

Skin depth

$$\delta = \frac{1}{\sqrt{\pi f \mu \sigma}}$$

$$\delta \propto \frac{1}{\sqrt{f}}$$



$$R = \rho \frac{l}{A}$$

$$f \uparrow \delta \downarrow A \downarrow R \uparrow I^2 R \text{ loss } \uparrow$$

The current has tendency to confined itself to a smaller crosssection of conductor towards its outer surface, or find \uparrow effective area \downarrow $\&$ resistance \uparrow .

This effect can be reduce by larger size of conduct

b) Dielectric loss :-

$$P_{\text{loss}} \propto f$$

$$f \uparrow \text{ loss } \uparrow$$

c) Radiation loss \rightarrow

$$D = 1 \text{ mm}$$

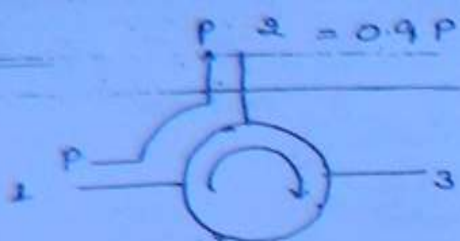
$$f = 30 \text{ kHz}$$

$$\lambda = \frac{3 \times 10^8}{30 \times 10^3} = 10^4 \text{ m} = 10 \text{ km.}$$

$$\lambda \gg D$$

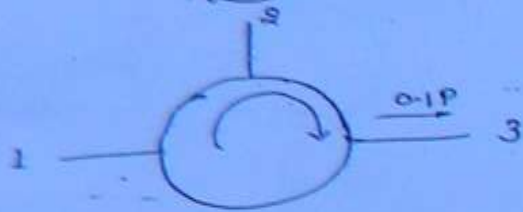


When the dimension of wire approaches the wavelength then it will emit radiation so radiat loss \uparrow with \uparrow in f or



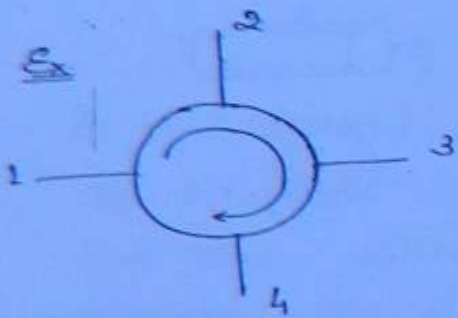
$$A \text{ Insertion loss} = 10 \log \frac{P_1}{P_2}$$

$$\text{Ideal value} = 0 \quad (34)$$



$$B \text{ Isolation loss} = 10 \log \frac{P_1}{P_3}$$

$$\text{Ideal value} = \infty$$



Insertion loss

$$10 \log \frac{P_1}{P_2}$$

$$10 \log \frac{P_3}{P_4}$$

Isolation loss =

$$10 \log \frac{P_2}{P_1}$$

$$10 \log \frac{P_4}{P_3}$$

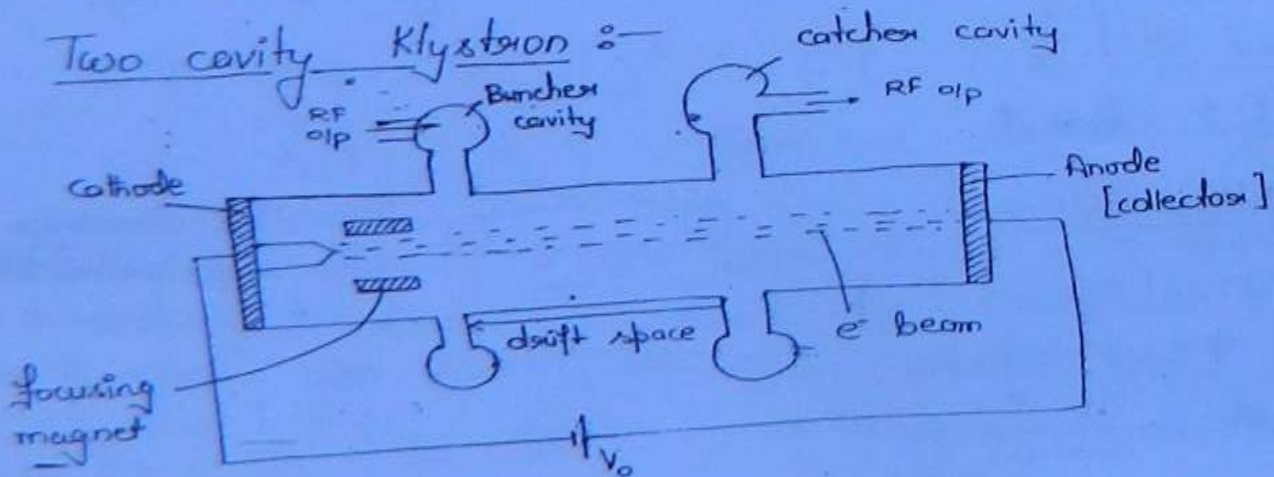
$$10 \log \frac{P_4}{P_2}$$

$$10 \log \frac{P_3}{P_4}$$

Two cavity Klystron :-

Basic principle of operation of microwave tubes → involve transfer of power from a source dc voltage to a source AC voltage by means of a current density modulated e⁻ beam.

Two cavity Klystron :-

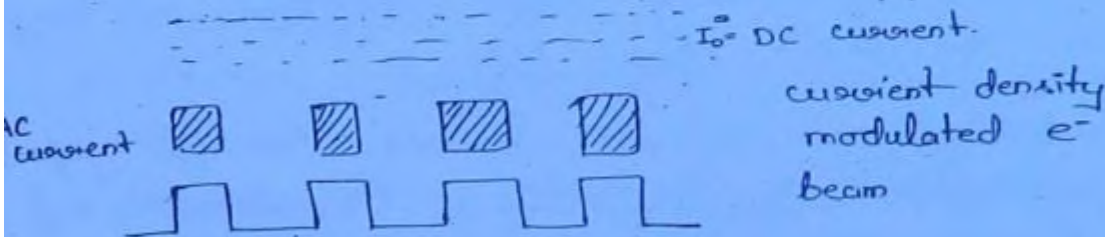
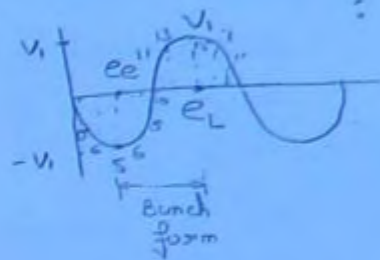
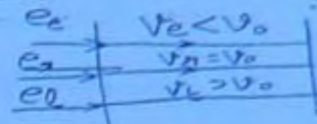


$$\frac{1}{2} m v_0^2 = q V_0$$

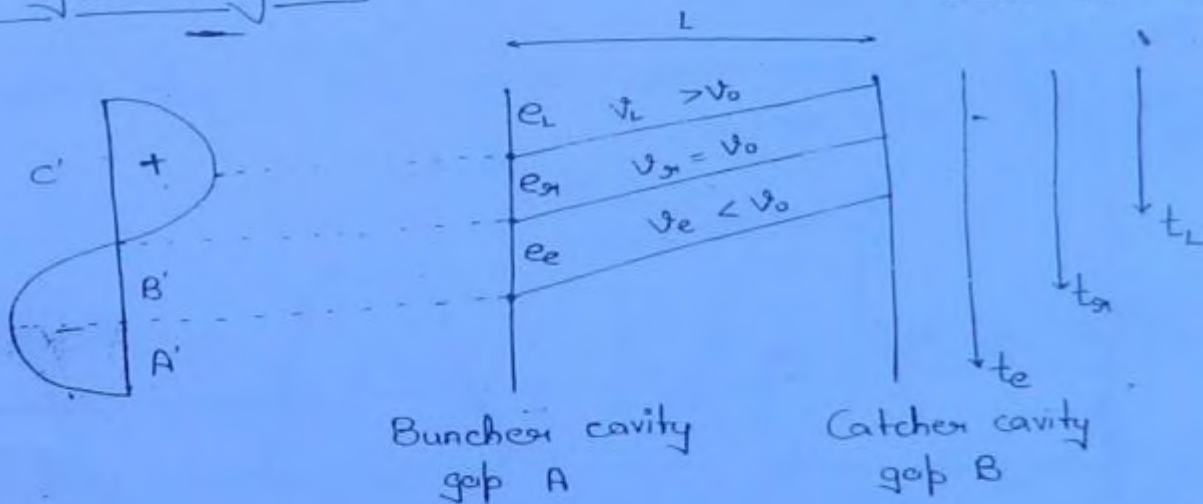
$$V_0 = \sqrt{\frac{2q}{m} V_0} = 0.593 \times 10^6 \sqrt{V_0} \text{ m/sec.}$$

V_0 = Anode voltage
= Beam voltage
= DC Biasing

(35)



Apple gate diagram →



At point B' i/p RF voltage is zero, so the electric field across the gap A is zero. So the ^{which} e^- passes through gap A. at this instant of time will be unaffected. At point B' i/p RF voltage by RF signal this is called reference e^- which travel with unchanged velocity i.e. $V_0 = V_0$

e^- which leave gap A after e_0 is called late e^- (e_L) this is subjected to max. RF +ve voltage hence e^- will travel towards gap B (catcher cavity gap)

velocity $> v_0$ i.e. $v_e > v_0$

(36)

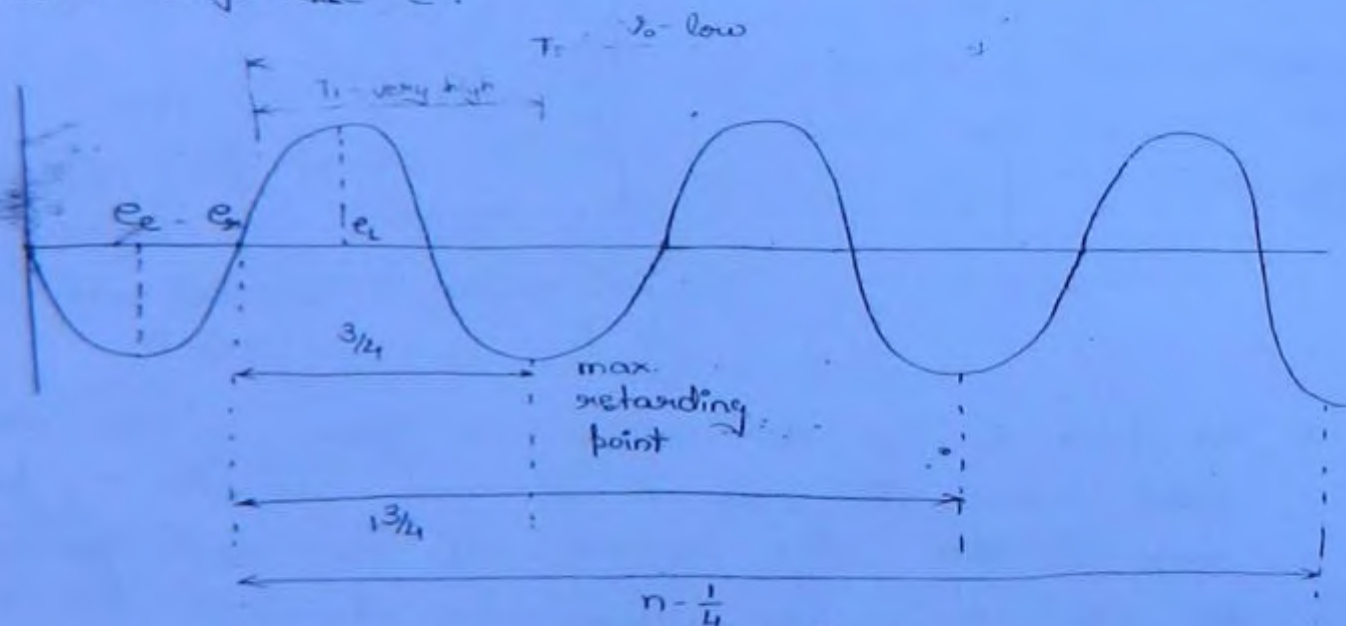
e^- which leave gap A slightly before the reference e^- when subjected to is called early electron. it is subjected to max. RF -ve voltage & hence e^- travel towards gap B with velocity smaller than v_0

$$v_e < v_0$$

as a result of this action (velocity modulation) e^- in bunching limit. gradually bunch together as they travel down the drift space. For

The pulsating stream of e^- passes through gap B & give amplification in o/p cavity. The density of e^- passing through the gap B vary cyclically with time i.e. e^- beam contain an AC current & is current modulated.

Bunching occurs only once per cycle centred around reference e^- .



$$\text{no. of transit cycle} = n - \frac{1}{4}$$

$$n = 1, 2, 3, 4, 5$$

n = no. of complete transit cycle

Phase change = $\left[n - \frac{1}{4}\right] \times 2\pi$

= $2n\pi - \frac{\pi}{2}$

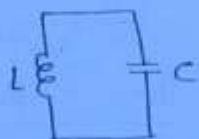
(37)

Quantitative analysis of two cavity klystron →

Quantitative analysis can be describe under following assumptions →

1. e^- beam is assume to have uniform density in cross sectional beam.
2. Space charge effect (~~neutral~~ mutual repulsion b/w charge carriers) is negligible.
3. Magnitude of μ wave signal i/p is assume to be much smaller than DC accelerating voltage that is i.e. $V_1 \ll V_0$

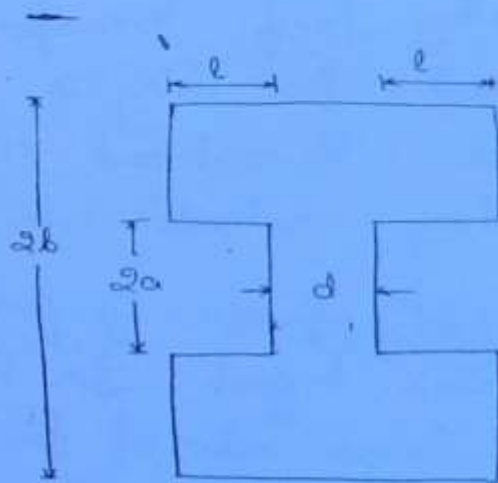
Re-entrant Cavities :-



~~1~~ $\frac{1}{LC}$

$f \rightarrow$ very very high

$L \rightarrow$ & $C \rightarrow$ very very small

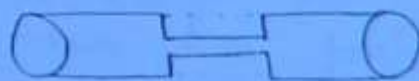


$$Z_{in} = j \frac{1}{2\pi} \sqrt{\frac{\mu}{\epsilon}} \ln(b/a) \tan \beta l \quad \text{--- ①}$$

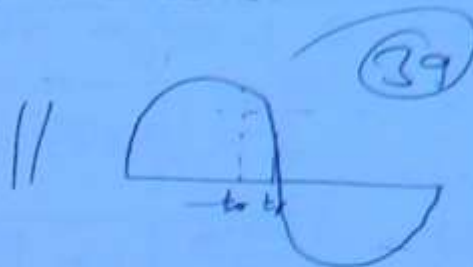
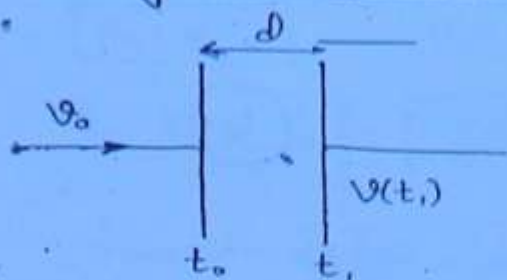
β = phase constant

$$L = \frac{2 Z_{in}}{\omega} = \frac{1}{\pi \omega} \sqrt{\frac{\mu}{\epsilon}} \ln(b/a) \tan \beta l \quad \text{--- ②}$$

$$C_g = \frac{\epsilon \pi a^2}{d} \quad \text{--- ③}$$



Velocity Modulation :



$v(t_1)$ = modulated velocity

$$v(t_1) = \sqrt{\frac{2q}{m} (V_0 + V_1)}$$

$v(t)$ = average value of RF signal in interval $t_1 - t_0$

$$v(t_1) = \sqrt{\frac{2q}{m} [V_0 + \langle v(t) \rangle]} \quad \text{--- ①}$$

gap transit time = $t_1 - t_0$

dc gap transit time = $\tau = d/v_0$ --- ②

$$V_0 = 0.593 \times 10^6 \sqrt{V_0} \quad \text{--- ③}$$

dc gap transit angle

$$\theta_g = \omega \tau = \frac{\omega d}{v_0} \quad \text{--- ④}$$

$$\langle v(t) \rangle = \frac{1}{t_1 - t_0} \int_{t_0}^{t_1} V_1 \sin \omega t \cdot dt$$

$$\langle v(t) \rangle = V_1 \frac{\sin \frac{\omega d}{2v_0}}{\frac{\omega d}{2v_0}} \sin \left[\omega t_0 + \frac{\omega d}{2v_0} \right]$$

$$= V_1 \frac{\sin \theta_g/2}{\theta_g/2} \sin \left[\omega t_0 + \frac{\theta_g}{2} \right]$$

Beam coupling coefficient $R_1 = \frac{\sin \theta_g/2}{\theta_g/2} \quad \text{--- ⑤}$

$$\angle v(t) = \beta_1 V_1 \sin[\omega t_0 + \theta_{g/2}] \quad \text{--- (6)}$$

put (6) in (1)

$$v(t) = \sqrt{\frac{2q}{m} [V_0 + \beta_1 V_1 \sin(\omega t_0 + \theta_{g/2})]}$$

(40)

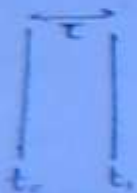
$$v(t) = \sqrt{\frac{2q V_0}{m} \left[1 + \frac{\beta_1 V_1}{V_0} \sin(\omega t_0 + \theta_{g/2}) \right]}$$

Ans $\boxed{v(t) = v_0 \sqrt{1 + \frac{\beta_1 V_1}{V_0} \left[\sin(\omega t_0 + \frac{\theta_g}{2}) \right]}} \Rightarrow \text{velocity modulated eqn.}$

Depth of modulation = $\frac{\beta_1 V_1}{V_0}$

$$[1+x]^{1/2} = [1+x/2]$$

$$v(t) = v_0 \left[1 + \frac{\beta_1 V_1}{2V_0} \sin(\omega t_0 + \frac{\theta_g}{2}) \right]$$



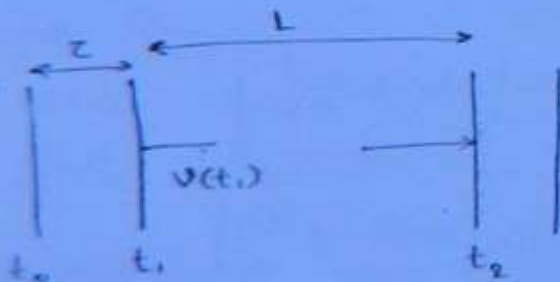
$$t_1 = t_0 + \tau$$

$$t_0 = t_1 - \tau$$

$$\omega t_0 = \omega t_1 - \omega \tau$$

$$\omega t_0 = \omega t_1 - \theta_g$$

$$v(t_1) = v_0 \left[1 + \frac{\beta_1 V_1}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]$$



$$t_2 - t_1 = \text{transit time}$$

$$t_2 - t_1 = \frac{L}{v(t_1)} = \frac{L}{v_0 \left[1 + \frac{\beta_1 V_1}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]}$$

$$T_0 = L/v_0 = \text{dc transit time}$$

Phase change during T_0

$$\theta_0 = \omega T_0$$

θ_0 = dc transit angle

$$t_2 - t_1 = T_0 \left[1 - \frac{\beta_i V_i}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]$$

(4)

transit angle

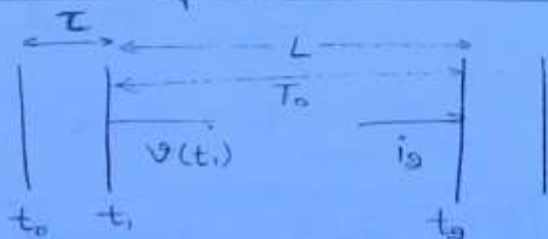
$$\omega(t_2 - t_1) = \omega T_0 \left[1 - \frac{\beta_i V_i}{2V_0} \sin(\omega t_1 - \frac{\theta_g}{2}) \right]$$

$$\omega(t_2 - t_1) = \theta_0 - \frac{\beta_i V_i}{2V_0} \theta_0 \sin(\omega t_1 - \theta_{g/2})$$

Bunching parameter $X = \frac{\beta_i V_i}{2V_0} \theta_0$

$$\omega(t_2 - t_1) = \theta_0 - X \sin(\omega t_1 - \theta_{g/2})$$

calculation of current i_2 at catcher cavity \rightarrow



$$q = I_0 \Delta t$$

$$q = i_2 \Delta t_1$$

$$\Delta t_1 \ll \Delta t$$

$$I_0 \Delta t = i_2 \Delta t_1$$

$$i_2 = \frac{I_0 \Delta t}{\Delta t_1} \gg I_0$$

$$I_2(t_2) = \frac{I_0}{1 - X \cos[\omega t_0 + \theta_{g/2}]}$$

$$t_2 = t_0 + \tau + T_0$$

$$t_0 = t_2 - T_0 - \tau$$

$$\omega t_0 = \omega t_2 - \omega \tau - \omega T_0 \Rightarrow \omega t_0 = \omega t_2 - \theta_g - \theta_0$$

$$i_2(t_2) = \frac{I_0}{1 - X \cos[\omega t_2 - \theta_{g/2} - \theta_0]}$$

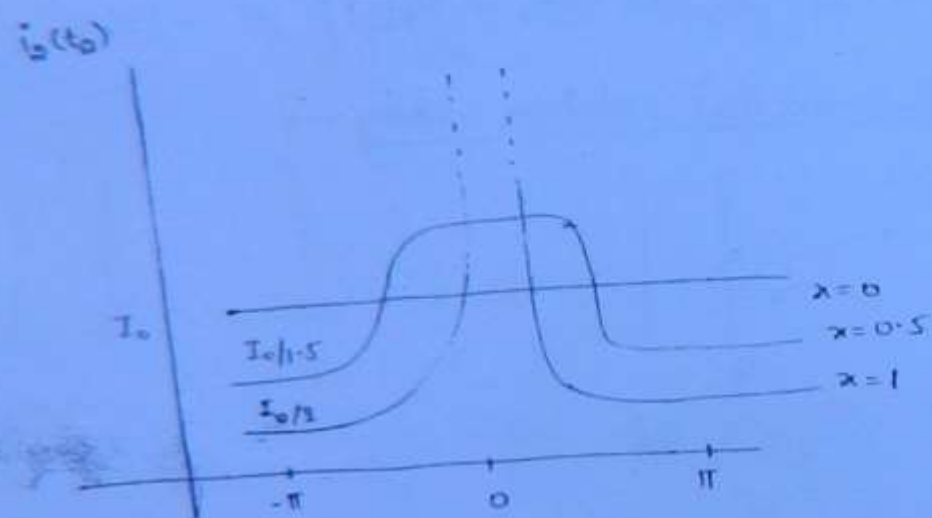
lets say $\phi_0 = 0$ - catcher cavity arrival angle.

(42)

• curve of beam current $i_b(t_a)$ as a fun. of catcher cavity arrival angle in terms of bunching parameters

⇒

Angle			
x	-π	0	+π
0	I_0	I_0	I_0
0.5	$\frac{I_0}{1.5}$	$3I_0$	$\frac{I_0}{1.5}$
1	$\frac{I_0}{3}$	∞	$\frac{I_0}{3}$



Answers →
page 39.

- | | | | |
|------|-------|-------|-------|
| 1. C | 6. C | 11. B | 16. A |
| 2. A | 7. X | 12. A | 17. C |
| 3. A | 8. D | 13. C | 18. |
| 4. C | 9. B | 14. C | 19. |
| 5. D | 10. D | 15. D | 20. |

$$= \frac{9\pi \times l}{\lambda}$$

$$\lambda = \frac{3 \times 10^{10}}{10 \times 10^9} = 3 \text{ cm}$$

Fourier series expansion of $i_2(t_2)$:-

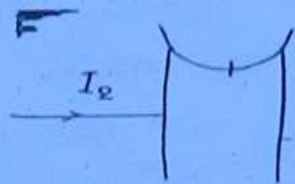
$$i_2 = a_0 + \sum_{n=1}^{\infty} [a_n \cos n\omega t_2 + b_n \sin n\omega t_2]$$

(42)

$$i_2 = I_0 + \sum_{n=1}^{\infty} 2I_0 J_n(x) \cos[n\omega t_2 - \tau - T_0]$$

Magnitude of fundamental component

$$I_f = I_2 = 2I_0 J_1(x)$$



$$i_{\text{induced}} = \beta_0 I_2$$

β_0 = Beam coupling coefficient of o/p cavity

$$\beta_0 = \beta_i = \frac{\sin \theta_g/2}{\theta_g/2}$$

ideally $d=0$ $\theta_g=0$ $\beta_0=1$

$$i_{\text{induced}} = 2I_0 \beta_0 J_1(x)$$

when $x = 1.841$ $J_1(x) = 0.58$

$$x = \frac{\beta_i V_i}{2V_0} \theta_0$$

for max o/p $\Rightarrow x = 1.841$ $\theta_0 = 2n\pi - \pi/2$

$$\beta_i = 1$$

$$\text{Ans: } \left(\frac{V_i}{V_0} \right) = \frac{3.682}{2n\pi - \pi/2}$$

for max o/p

Optimum distance L b/w buncher & catcher

for max power o/p $x = 1.841$ $\theta_0 = \frac{\omega L}{V_0}$

$$x = \frac{\beta_i V_i}{2V_0} \theta_0 = \frac{\beta_i V_i}{2V_0} \times \frac{\omega L}{V_0}$$

$$k_{SH} = \frac{B_1 V_1}{2V_0} = \frac{\omega L_{optimum}}{V_0}$$

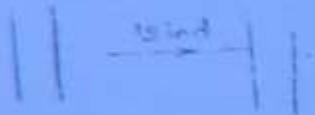
$$L_{optimum} = \frac{3.68 \times V_0 V_1}{B_1 V_1 \omega}$$

(44)

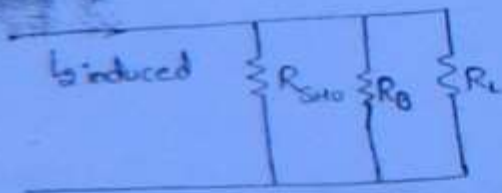
* Qp power and beam loading :-

Max bunching should occur approximately midway b/w catcher grids (catcher gap) the phase of the catcher gap voltage must be maintain in such a way that the bunches, as they pass through the grid encounter a retarding phase so that its KE is transferred into ~~RF field~~ of catcher cavity.

When no. of es emerge from catcher grid they have reduced velocity. and are finally collected by collector (Anode plate)



ckt of catcher cavity

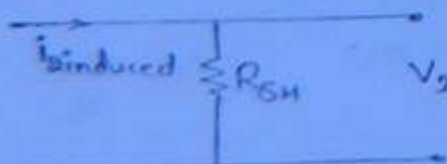


R_{SHO} = Resistance of wall of cavity

R_B = Beam loading resistance.

$$R_{SH} = R_B \parallel R_{SHO} \parallel R_L$$

R_{SH} = ed shunt resistance



At resonance

$$|Z_c| = |Z_L|$$

$$\omega L = \frac{1}{\omega C}$$

38

$$\tan \beta l = \frac{dV}{\omega a^2 \ln b/a} \quad \text{--- (4)}$$

$$v = \frac{1}{\sqrt{\mu \epsilon}} \quad \text{phase velocity in any medium}$$

At a fixed. well below microwave range cavity resonator can be represented by a lumped constt resonant ckt.

When the operating freq. lies to several tens of MHz (microwave range) : both L & C must be reduced to a min value in order to maintain resonance at operating freq. therefore Re-entrant cavities are designed for using in klystron and other microwave devices. Re-entrant cavity is one in which metallic boundary extends into the interior of the cavity.

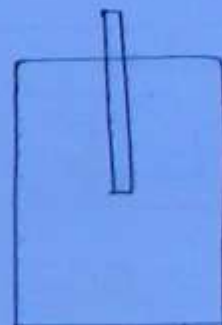
The solⁿ of eqn (4) gives resonant freq. since eqn. contains tangent fun. it has an infinite no. of solⁿ with larger value of freq. \therefore this type of re-entrant cavity can support an infinite no. of resonant freq. and most of oscillations.



Coaxial cavity



Radial cavity



Tunable cavity



Toroidal cavity



Butterfly cavity

induced voltage

$$V_2 = i_{2\text{induced}} \times R_{SH}$$

$$V_2 = 2\beta_0 I_0 J_1(x) R_{SH}$$

Power P_p

$$P_{AC} = \frac{i_{2\text{ind}} \times V_2}{2}$$

$$P_{DC} = V_0 I_0$$

$$\eta = \frac{P_{AC}}{P_{DC}} = \frac{i_{2\text{ind}} \times V_2}{2V_0 I_0}$$

$$\eta = \frac{2\beta_0 I_0 J_1(x) \times 2\beta_0 I_0 J_1(x) R_{SH}}{2V_0 I_0}$$

$$\eta = \frac{2\beta_0^2 J_1^2(x) \times I_0 R_{SH}}{V_0}$$

$$\underline{\eta_{\text{max}} \Rightarrow}$$

for η_{max}

$I_{2\text{induced}}$

$$P_{AC} = \frac{I_{2\text{ind}}^2}{2} \times R_{SH}$$

$$P_{AC} = \frac{I_{2\text{ind}} V_2}{2}$$

$$P_{DC} = V_0 I_0$$

$$\frac{P_{AC}}{P_{DC}} = \frac{\beta_0 I_2 V_2}{2V_0 I_0} = \frac{2\beta_0 J_1(x) I_0 V_2}{2V_0 I_0}$$

$$\frac{P_{AC}}{P_{DC}} = \frac{\beta_0 J_1(x) I_0 V_2}{V_0 I_0}$$

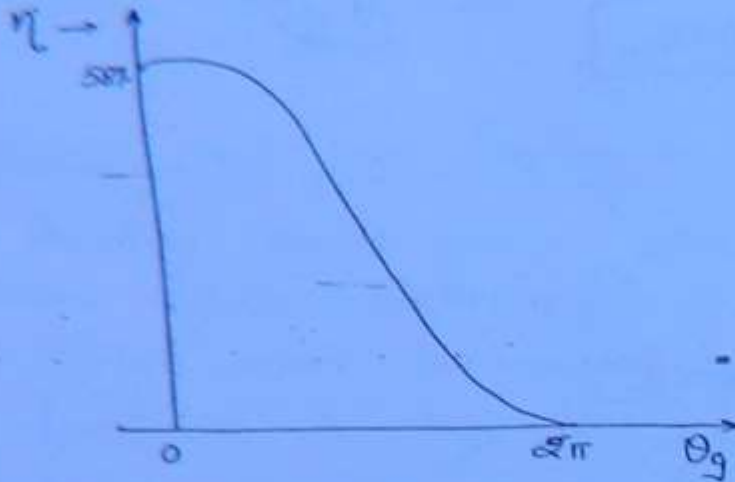
for max efficiency $\beta_0 = 1$ $V_2 = V_0$

$$\eta_{\text{max}} = J_1(x) = 0.58 \quad \text{for } x = 1.841$$

$$\boxed{\eta_{\text{max}} = 58\%}$$

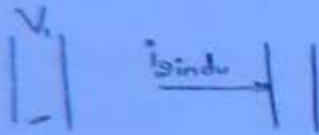
theoretical max efficiency

$$\beta_o = \frac{\sin \theta_o}{\theta_o}$$



Q46

* Mutual conductance →



$$G_m = \frac{i_{\text{induced}}}{V_i} = \frac{2\beta_o I_o J_1(x)}{V_i} = 2\beta_o I_o J_1(x) \times \frac{\beta_i \theta_o}{2V_o x}$$

$$x = \frac{\beta_i V_i}{2V_o} \theta_o$$

$$G_m = \beta_o^2 \frac{I_o}{V_o} \frac{J_1(x)}{x} \theta_o$$

$$V_i = \frac{\beta_i \theta_o}{2x V_o}$$

$$\beta_i = \beta_o$$

For similar cavity

$$G_o = \frac{I_o}{V_o} = \text{dc conductance}$$

$$R_o = \frac{1}{G_o} = \text{dc resistance}$$

$$\boxed{G_m = \beta_o^2 G_o \frac{J_1(x)}{x} \theta_o}$$

Voltage gain

$$A_v = \frac{V_o}{V_i} = \frac{i_{\text{ind}} R_{SH}}{V_i} = G_m R_{SH}$$

Power gain = $\frac{\text{o/p power}}{\text{i/p power}}$

$$A_p = \frac{I_{2ind} V_2 / 2}{V_1^2 / 2 R'_{SH}} = \frac{I_{2ind} V_2 R'_{SH}}{V_1^2}$$

(47)

$$R'_{SH} = R_{SH0} \parallel R_B$$

Beam loading conductance

$$G_B = 1/R_B = \frac{G_0}{2} [\beta_0^2 - \beta_0 \cos \theta_{g/2}]$$

A two cavity klystron as following parameters

$$V_0 = 1000 \text{ volts}$$

$$I_0 = 25 \text{ mA}$$

$$f = 3 \text{ GHz}$$

gap spacing in either cavity $d = 1 \text{ mm}$

spacing b/w two cavity $L = 4 \text{ cm}$

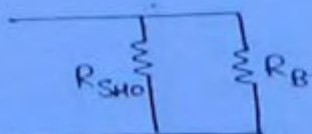
effective shunt impedance excluding the beam loading

$$R_{SH} = 30 \text{ k}\Omega$$

- Find i/p gap voltage to give max voltage at v_2 .
- Find voltage gain neglecting the beam loading in the o/p cavity
- Find the η of ampⁿ neglecting beam loading
- Calc. beam loading conductance. & show that neglecting it was justify in preceding calculation.

Solu. A)

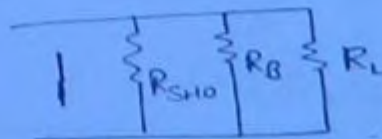
i/p cavity



$$R_{SH} = R_{SH0} \parallel R_B$$

shunt resistance excluding load.

o/p cavity



$$R_{SHL} = R_{SH0} \parallel R_B \parallel R_L$$

shunt resistance including load.

$$\text{For max } V_o$$

$$x = 1.841$$

$$x = \frac{\beta_1 V_1}{2V_o} Q_o$$

$$V_1 = \frac{2V_o x}{\beta_1 Q_o}$$

$$\beta_1 = \frac{\sin \theta_1/2}{\theta_1/2}$$

$$\theta_1 = \omega T_o = \frac{\omega L}{V_o}$$

$$V_o = 0.593 \times 10^6 \sqrt{V_o}$$

$$V_o = 0.593 \times 10^6 \sqrt{1000} \text{ m/sec.}$$

$$\boxed{V_o = 1.88 \times 10^7 \text{ m/sec.}}$$

$$Q_1 = \frac{2\pi \times 3 \times 10^9 \times 10 \times 10^{-3}}{1.88 \times 10^7}$$

$$Q_1 = 1 \text{ rad.}$$

$$\beta_1 = \frac{\sin 1/2}{1/2} = 0.959$$

$$Q_o = \omega T_o = \frac{\omega L}{V_o}$$

$$Q_o = \frac{2\pi \times 3 \times 10^9 \times 4 \times 10^{-2}}{1.88 \times 10^7}$$

$$Q_o = 40 \text{ rad}$$

$$V_1 = \frac{2 \times 1000 \times 1.841}{0.959 \times 40} = 96.5 \text{ volt}$$

$$\boxed{V_1 < V_o}$$

$$B) A_v = V_o/V_1 = \frac{I_{o \text{ ind}} \times R_{SHL}}{V_1}$$

$$I_{o \text{ induced}} = 2I_o \beta_o J_1(x)$$

$$I_{o \text{ induced}} = 2 \times 25 \times 10^{-3} \times 0.959 \times 0.58$$

$$= 27.55 \text{ mA}$$

$$V_0 = I_{a \text{ induced}} R_{SHL}$$

$$A_v = G_m R_{SHL}$$

$$R_{SHL} = R_{SHO} \parallel R_L$$

$$A_v = \frac{V_0}{V_i} = 8.595 \approx 8.6$$

(49)

$$c) \eta = \frac{P_{ac}}{P_{dc}} = \frac{I_{a \text{ induced}} \times R_{SHL}}{\frac{V_0 I_0}{2}} = 45.55\%$$

$$D) G_B = \frac{G_0}{2} [B_0^2 - B_0 \cos \theta_{g/2}]$$

$$= \frac{I_0}{V_0 \times 2} [(0.952)^2 - 0.952 \times \cos 1/2]$$

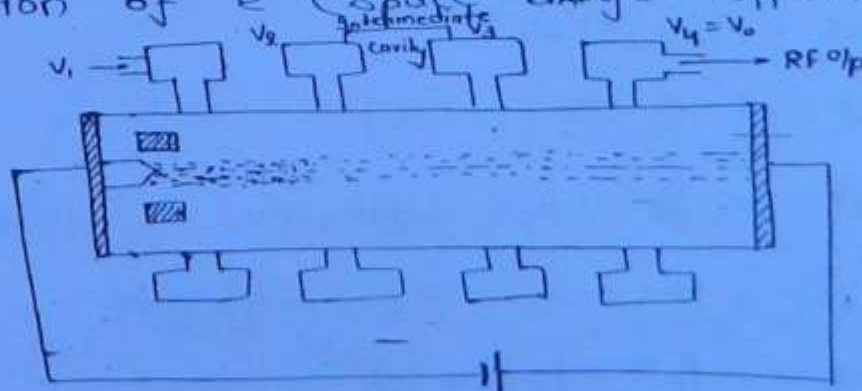
$$G_B = 8.8 \times 10^{-7} \text{ mho}$$

$$R_B = \frac{1}{G_B} = 1.14 \times 10^6 \Omega$$

$$= 1.14 \text{ M}\Omega$$

Multi cavity klystron :-

For higher overall gain generally four cavity klystron are used. In case of two cavity klystron space charge effect is negligible b/c of small density of e^- in the beam for low power amplification however when high power klystron tubes are analysed that e^- density of beam is large & forces of mutual repulsion of e^- (space charge effect) must be considered.



When e^- perturbate (small change in moment of e^-) in e^- beam

The e^- density consist of a dc power + nRF perturbation. cause by e^- bunches. (50)

ρ_0 = dc e^- charge density

ρ = instantaneous ~~re~~ charge density

v_0 = dc e^- velocity

v = instantaneous e^- velocity perturbation

$\phi_0 = \omega/v_0$ = dc phase constant

Plasma freq. $\omega_p = \sqrt{\frac{q \rho_0}{m \epsilon_0}}$

Reduced plasma freq.

$$\omega_q = R \omega_p$$

$$R = \frac{\omega_q}{\omega_p} < 1$$

R = space charge reduction factor varies from ~~0~~ 0-1

e^- plasma freq. is a freq. at which e^- will oscillate in e^- beam. this plasma freq. applies only to a beam of infinite diameter. The practical ~~beam~~ of finite diameter are factorized by reduced plasma freq.

current density $J = \rho v = I/A$

$$J_{\text{total}} = \rho_{\text{total}} \times v_{\text{total}}$$

$$J_{\text{total}} = [-\rho_e + \rho] [v + v_0]$$

$$J_{\text{total}} = -\rho_e v - \rho_e v_0 + \rho v + \rho v_0$$

$$\rho \ll \rho_0 \quad v \ll v_0 \quad \rho v \rightarrow \text{negligible}$$

$$J_{\text{total}} = -\rho_e v - \rho_e v_0 + \rho v_0$$

41. DC current density $J = \rho_0 V_0$

Instantaneous RF convection current density

$$J = \rho V_0 - \rho_0 v$$

$$J_{\text{total}} = -J_0 + J$$

(57)

Que A four cavity klystron has a following parameters -

Beam voltage $V_0 = 14.5 \text{ kV}$

Beam current $I_0 = 1.4 \text{ Amp}$

Operating freq. $f = 10 \text{ GHz}$

dc e^- charge density $\rho_0 = 10^{-6} \text{ C/m}^3$

RF charge density $\rho = 10^{-8} \text{ C/m}^3$

velocity perturbation $v = 10^5 \text{ m/sec}$

Calc. - A) DC e^- velocity

B) DC phase constant

C) plasma freq.

D) reduced plasma freq for $R=0.4$

E) DC beam current density

F) Instantaneous beam current density

Solu

$$\text{A) } v_0 = 0.593 \times 10^6 \sqrt{V_0}$$
$$= 0.714 \times 10^8 \text{ m/sec.}$$

$$\text{B) } \beta_e = \omega / v_0 = \frac{2\pi f}{v_0} = 8.8 \times 10^2 \text{ rad/m.}$$

$$\text{C) } \omega_p = \sqrt{\frac{q}{m} \times \frac{\rho_0}{\epsilon_0}}$$

$$\frac{q}{m} = \frac{1.6 \times 10^{-19}}{9.1 \times 10^{-31}} = 1.759 \times 10^{11}$$

$$\omega_p = \sqrt{\frac{1.759 \times 10^{11} \times 10^{-6}}{8.854 \times 10^{-12}}} = 1.41 \times 10^8 \text{ rad/sec.}$$

$$D) \vec{q} = R \omega p = 0.4 \times 1.41 \times 10^8 \\ = 0.564 \times 10^8 \text{ rad/sec}$$

$$E) J_0 = \rho_0 v_0 = 71.4 \text{ A/m}^2$$

(S2)

$$F) J = p v_0 - p v \\ = 10^{-8} \times 0.714 \times 10^8 - 10^{-6} \times 10^5 \\ J = 0.614 \text{ A/m}^2$$

o/p current & o/p power of two cavity klystron when space charge is considered. →



$|V_1|$ = RMS value of RF signal

$$\text{4mp. } |\dot{i}_0| = \frac{1}{3} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_i |V_1|$$

$$I_2 = |\dot{i}_0|_{\text{induced}} = \beta_o |\dot{i}_0| = \frac{1}{3} \beta_o^2 \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] |V_1|$$

induced voltage

$$V_2 = I_2 \text{ induced} \times R_{SHL}$$

$$V_2 = \frac{1}{3} \beta_o^2 \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] |V_1| R_{SHL}$$

power o/p

$$P_{out} = I_2^2 R_{SHL} \\ = \frac{1}{4} \beta_o^4 \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right]^2 |V_1|^2 R_{SHL}$$

$$\eta = \frac{P_{ac}}{P_{dc}} \times 100\%$$

$$P_{dc} = V_0 I_0$$

$$\text{Power gain } A_p = \frac{P_{out}}{P_{in}} = \frac{P_{out}}{V_1^2 / R_{SHL}}$$

22. Que A two cavity klystron has the following parameters

Beam voltage $V_0 = 20 \text{ kV}$

Beam current $I_0 = 2 \text{ Amp.}$

Operating freq $f = 8 \text{ GHz.}$

Beam coupling coefficient $\beta_i = \beta_o = 1$

$\rho_0 = 10^{-6} \text{ C/m}^2$ dc e^- charge density

Shunt resistance of the cavity $R_{SH} = 10 \text{ k}\Omega$

Total shunt resistance including load $R_{SHL} = 30 \text{ k}\Omega$

$$|V_1| = 10 \text{ V [RMS]}$$

Calc - A) Plasma freq. $\omega_p = 1.41 \times 10^8 \text{ rad/sec.}$

B) Reduced plasma freq. for $R = 0.5$ $\omega_q = R \omega_p = 0.705 \times 10^8 \text{ rad/sec.}$

C) Induced current in o/p cavity -

D) Induced voltage in o/p cavity

E) o/p power delivered to load.

F) Power gain

G) electronic efficiency.

Solu

$$\text{C) } I_{2\text{induced}} = \frac{1}{2} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_o^2 \times |V_1|$$
$$= 0.3565 \text{ Amp.}$$

$$\text{D) } V_{2\text{ind}} = I_{2\text{ind}} \times R_{SHL} = 0.3565 \times 30 \times 10^3$$
$$= 10.71 \text{ kV}$$

$$\text{E) } P_{\text{out}} = I_{2\text{ind}}^2 \times R_{SHL} =$$
$$= 3.82 \text{ kW}$$

F) Power gain

$$P_{in} = |V_1|^2 / R_{SH}$$

(54)

$$A_p = \frac{P_{out}}{P_{in}} = 3.83 \times 10^5$$

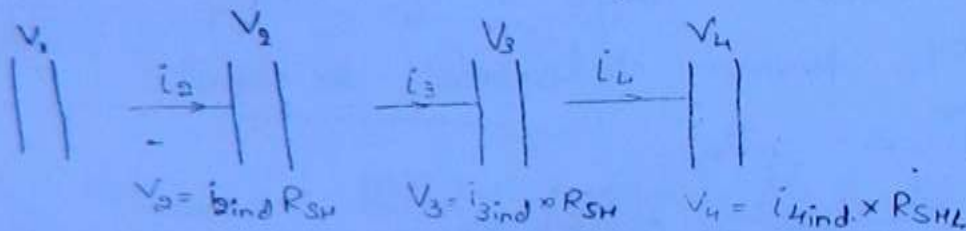
$$(A_p)_{dB} = 10 \log [3.83 \times 10^5] = 55.8 \text{ dB}$$

G) Efficiency (η)

$$\eta = \frac{P_{out}}{P_{dc}} = \frac{3.82 \times 10^3}{I_0 V_0} \times 100\%$$

$$\eta = 9.6\%$$

o/p power of four cavity klystron \rightarrow



$$\dot{i}_2 = \frac{1}{2} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_i |V_1|$$

$$\begin{aligned} \dot{i}_{2ind} &= \beta_o \dot{i}_2 \\ &= \frac{1}{2} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_o^2 |V_1| \end{aligned} \quad (\beta_i = \beta_o)$$

$$\begin{aligned} V_2 &= \dot{i}_{2ind} \times R_{SH} \\ &= \frac{1}{2} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_o^2 |V_1| R_{SH} \end{aligned}$$

$$\dot{i}_3 = \frac{1}{2} \left[\frac{I_0}{V_0} \frac{\omega}{\omega_q} \right] \beta_i |V_2|$$

$$\dot{i}_{3ind} = \beta_o \dot{i}_3$$

$$V_3 = \dot{i}_{3ind} \times R_{SH} = \beta_o \dot{i}_3 R_{SH}$$

$$V_3 = \frac{1}{4} \beta_o^4 \left[\frac{I_o \omega}{V_o \omega_q} \right]^2 |V_1| R_{SH}^2$$

(55)

$$i_4 = \frac{1}{2} \left[\frac{I_o \omega}{V_o \omega_q} \right] \beta_i |V_3|$$

$$i_{4ind} = \beta_o i_4 = \frac{1}{2} \beta_o^2 \left[\frac{I_o \omega}{V_o \omega_q} \right] |V_3|$$

$$i_{4ind} = \frac{1}{8} \beta_o^6 \left[\frac{I_o \omega}{V_o \omega_q} \right]^3 |V_1| R_{SH}^2$$

$$V_4 = i_{4ind} R_{SHL} = \frac{1}{8} \beta_o^6 \left[\frac{I_o \omega}{V_o \omega_q} \right]^3 |V_1| R_{SH}^2 R_{SHL}$$

$$P_{out} = \frac{1}{64} \beta_o^{12} \left[\frac{I_o \omega}{V_o \omega_q} \right]^6 |V_1|^2 R_{SH}^4 R_{SHL} = i_{4ind}^2 R_{SHL}$$

Que For four cavity klystron -

$$V_o = 10 \text{ kV}$$

$$I_o = 0.7 \text{ Amp}$$

$$f = 4 \text{ GHz}$$

$$\beta_i = \beta_o = 1$$

$$\rho_o = 5 \times 10^{-5} \text{ C/m}^3$$

$$V_1 = 2 \text{ V (rms)}$$

$$R_{SH} = 10 \text{ k}\Omega$$

$$R_{SHL} = 5 \text{ k}\Omega$$

Calc.

A) plasma freq. -

B) reduced plasma freq. for $R=0.6$

C) induced current in o/p cavity

D) induced voltage in o/p cavity

E) o/p power delivered to load.

F) Efficiency.

Solu.

$$A) \omega_p = \sqrt{\frac{\rho_o q}{\epsilon_o m}} = 0.997 \times 10^9 \text{ rad/sec}$$

$$B) \omega_q = 0.598 \times 10^9 \text{ rad/sec}$$

$$C) i_{4induced} = \frac{1}{8} \beta_o^6 \left[\frac{I_o \omega}{V_o \omega_q} \right]^3 |V_1| R_{SH}^2 = 0.6365 \text{ Amp}$$

$$D) V_4 = i_{4ind} R_{SHL} = 3.18 \text{ kV}$$

$$E) P_{out} = i_{4ind}^2 R_{SHL} = 2.03 \text{ kWatt}$$

$$F) \eta = \frac{P_{out}}{P_{dc}} = \frac{2.03 \times 10^3}{10 \times 10^3 \times 0.7} \times 100\% = 29\%$$

G) Power gain

$$A_p = \frac{P_{ac}}{P_{dc}} = \frac{2.03 \times 10^3}{10 \times 10^3 \times 0.7}$$

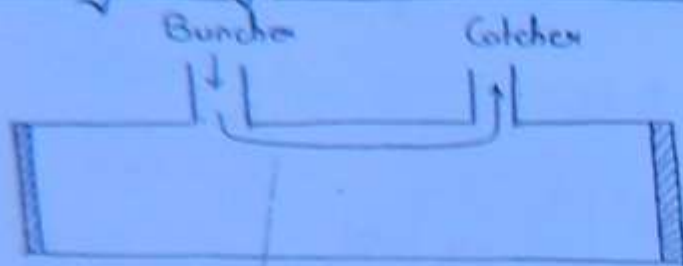
$$P_{in} = |V_1|^2 / R_{SH} = \frac{4}{10 \times 10^3}$$

$$A_p = \frac{2.03 \times 10^3}{4/10^4}$$

$$= 5.06 \times 10^6$$

* Two cavity klystron as an Oscillator

27 Feb. 2012



(56)

$$|AB| = 1$$

$$\phi = 2n\pi$$

$$\theta + \frac{\pi}{2} + \alpha = 2n\pi$$

α = transit angle

$\theta + \frac{\pi}{2}$ = mismatch b/w cavities + feedback path
for matched cavity $\theta = 0$

$$\alpha = 2n\pi - \pi/2$$

$\frac{d\theta}{d\omega}$ = figure of merit of any oscillator

Two co-

klystron as an osc. can be converted into Osc. by feeding back a part of catcher output into the buncher in proper phase so as to satisfy the Barkhausen criteria. The criteria for osc. is -

$$\theta + \alpha + \pi/2 = 2n\pi$$

$\theta + \pi/2$ = total phase shift in resonator & fb cable.

α = transit angle.

If two resonator oscillate in same phase $\theta = 0$.

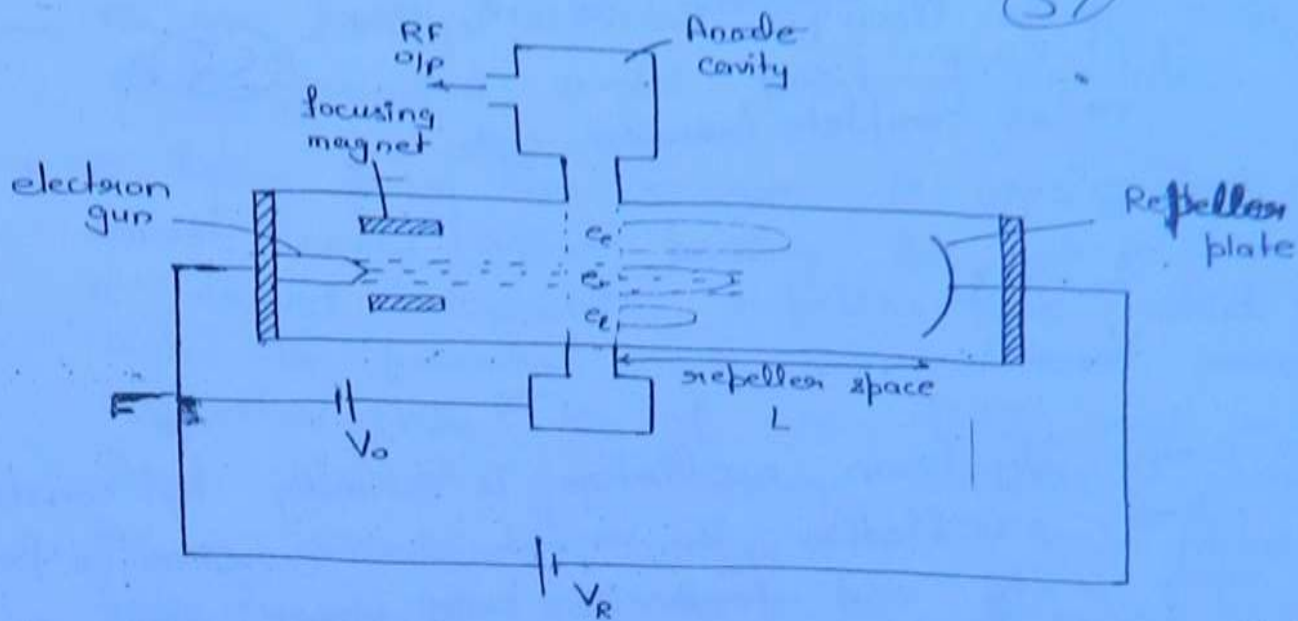
& then transit angle $\alpha = 2n\pi - \pi/2$

If then oscillator to sustain oscillation

$$\alpha = 2n\pi - \pi/2 \text{ is prime imp condition.}$$

Reflex Klystron :-

(57)

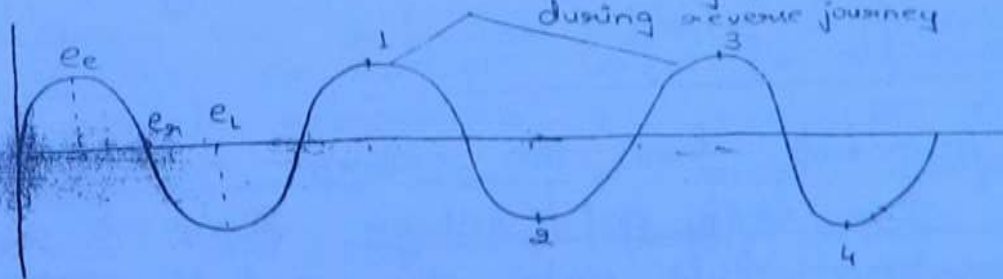
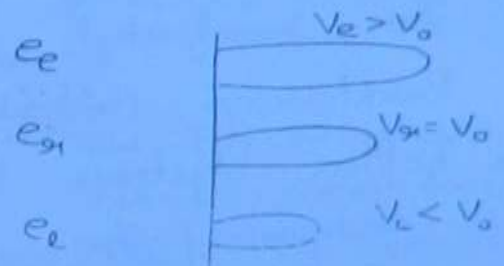


V_R = Repeller voltage

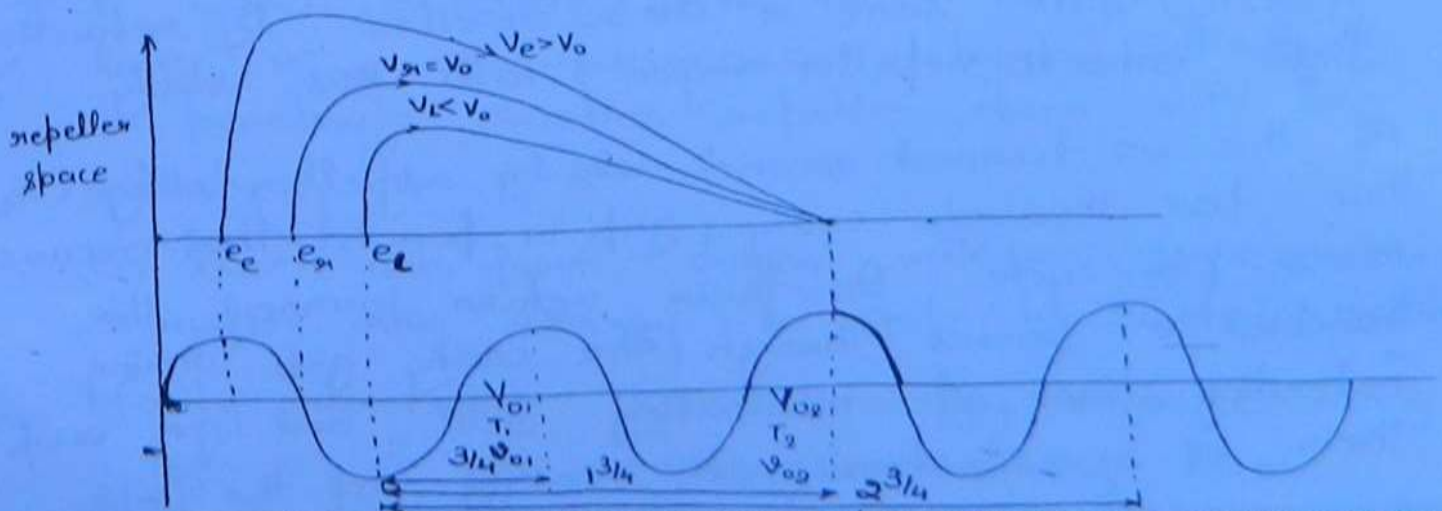
V_0 = dc beam voltage

$$V_0 = \sqrt{\frac{sq}{m}} V_0 = 0.593 \times 10^6 \sqrt{V_0}$$

max. retarding pt. during reverse journey



Apple Gate Diagram →



$N =$ mode of operation, $3/4, 1 3/4$

$n = 1, 2, 3, 4$

no. of complete transit cycle

$$T_0 > T_1$$

$$V_{02} < V_{01}$$

$$V_{02} < V_{01}$$

(58)

- Two cavity klystron oscillator is usually not constructed bcz when oscillation is varied the resonance freq of each cavity and feedback path phase shift must be readjusted for a +ve feedback and to satisfy Barkhausen criteria.
- Reflex klystron is a single cavity klystron that overcome the disadvantage of two cavity klystron osci.

Operating principle of reflex klystron \Rightarrow

- e^- beam injected from the cathode is first velocity modulated by cavity gap voltage. Some e^- accelerated by accelerating field enter the repeller space with greater velocity than those with unchanged velocity while some e^- decelerated by retarding field enter the repeller region with less velocity.
- "All the e^- turned around by repeller voltage (V_R) than pass through cavity gap in bunch. that occurs once per cycle." On their return journey the bunched e^- passes through the cavity gap during retarding phase of alternating field and give up their KE to electromagnetic energy of the field

In the cavity.

29

Then oscillation o/p energy is taken from the cavity as are finally collected by wall of the cavity or other grounded metal part of the tube. (59)

* e^- beam from the e^- gun is accelerated towards anode cavity. after passing the gap in the cavity e^- travel towards repeller plate which is at high -ve potential V_R . The e^- never reach ϕ repeller plate b/c of -ve field. and return back toward gap. under suitable condition the e^- give more energy to the gap then they took from the gap on their forward journey and oscillations are thus sustained.

* e^- which passes through gap when RF voltage is zero is called reference e^- . this e^- move toward repeller plate & get reflected back by -ve voltage on repeller plate & passes through the gap $V_R = V_0$

e^- which experience +ve max. RF voltage is called early e^- . the early e^- move deeper in repeller space and reflected back. since this e^- move with greater velocity i.e. $V_e > V_0$

e^- which experience -ve max. RF voltage is called late e^- . it experience retarded velocity so it penetrate smaller repeller space with low velocity $V_l < V_0$.

So bunch are form during reverse journey which transfer max. energy to gap to sustain oscillation

Cavity resonator spend energy in accelerating the e^- & gain energy in retarding them.

60

$$N = D - \frac{1}{4}$$
$$n = 1, 2, 3, 4$$

1

24



①

②

③

$$\therefore V_i \ll (V_R + V_o)$$

$$\frac{md^2z}{dt^2} = -qE \quad (4)$$

$$t = t_1, \quad v = v(t_1) \quad (5)$$

$$t = t_2, \quad z = d \quad (6)$$

from (4), (5) & (6)

$$T' = t_2 - t_1 = \frac{2mL}{q[V_R + V_0]} v(t_1)$$

(61)

$T' = t_2 - t_1 =$ Round trip transit time

$$t_2 - t_1 = \frac{2mL}{q[V_R + V_0]} V_0 \left[1 + \frac{\beta_i V_i}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]$$

$$\text{Amp.} \quad T_0 = \frac{2mL}{q[V_R + V_0]} V_0$$

$T_0 =$ dc round trip transit time

$$t_2 - t_1 = T_0 \left[1 + \frac{\beta_i V_i}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]$$

Phase change = transit angle

$$\omega(t_2 - t_1) = \omega T_0 \left[1 + \frac{\beta_i V_i}{2V_0} \sin(\omega t_1 - \theta_{g/2}) \right]$$

$\theta'_0 =$ dc transit angle

$$\text{Amp.} \quad \theta'_0 = \omega T_0$$

$$\omega(t_2 - t_1) = \theta'_0 + \frac{\beta_i V_i}{2V_0} \theta'_0 \sin(\omega t_1 - \theta_{g/2})$$

Bunching parameter

$$x' = \frac{\beta_i V_i}{2V_0} \theta'_0$$

$$\omega(t_2 - t_1) = \theta'_0 + x' \sin(\omega t_1 - \theta_{g/2})$$

$$\beta_i = \frac{\sin \theta'_{g/2}}{\theta'_{g/2}}$$

$$\theta'_g = \omega \tau = \frac{\omega d}{V_0}$$

Notes - The bunching parameter of reflex klystron is -ve with respect to bunching parameter of two cavity klystron.

$$q = I_0 \Delta t$$

$$q = I_2 \Delta t$$

(62)

$$i_2(t_2)$$

Fourier series expansion

$$i_2(t_2) = -I_0 - \sum_{n=1}^{\infty} \left[2I_0 J_n(n x') \cos(\omega t_2 - \theta_0' - \theta_{g/2}) \right]$$

Fundamental component

$$|i_2| = |i_g| = 2I_0 J_1(x')$$

$$|i_g| = |i_g| = 2I_0 J_1(x')$$

$$i_{\text{induced}}$$

$$i_{\text{induced}} = \beta_0 |i_g| = 2\beta_0 I_0 J_1(x')$$

$$\text{Induced voltage} = V_g = V_1 = I_{\text{induced}} R_{SH}$$

$$V_1 = 2\beta_0 I_0 J_1(x') R_{SH}$$

$$R_{SH} = R_0 \parallel R_{SH0} \parallel R_L$$

$$P_{ac} = \frac{V_1 i_{\text{ind}}}{2}$$

$$P_{ac} = I_0 V_1 \beta_1 J_1(x')$$

$$\eta = P_{ac} / P_{dc}$$

$$P_{dc} = V_0 I_0$$

$$\eta = \frac{\beta_1 V_1 J_1(x')}{V_0}$$

$$x' = \frac{\beta_i V_i}{2V_0} \theta_0'$$

$$\frac{\beta_i V_i}{V_0} = \frac{2x'}{\theta_0'}$$

(63)

Imp. $\boxed{\eta = \frac{2x' J_1(x')}{\theta_0'}}$

$$x' = 2.405 \quad J_1(x') = 0.52$$

$$[x' J_1(x')]_{\max} = 1.25$$

$$\text{for } n=2 \quad \theta_0' = 2n\pi - \pi/2$$

Imp. $\boxed{\eta = \frac{2x' J_1(x')}{2n\pi - \pi/2}}$

$$\eta_{\max} = \frac{2 \times 1.25}{2 \times 2 \times \pi - \pi/2} \times 100\% = 22.7\%$$

Relation b/w V_R & $V_0 \rightarrow$

Imp. $\boxed{T_0 = \frac{2mL}{q(V_R + V_0)} V_0}$

$$V_0 = \sqrt{\frac{2q}{m}} V_0$$

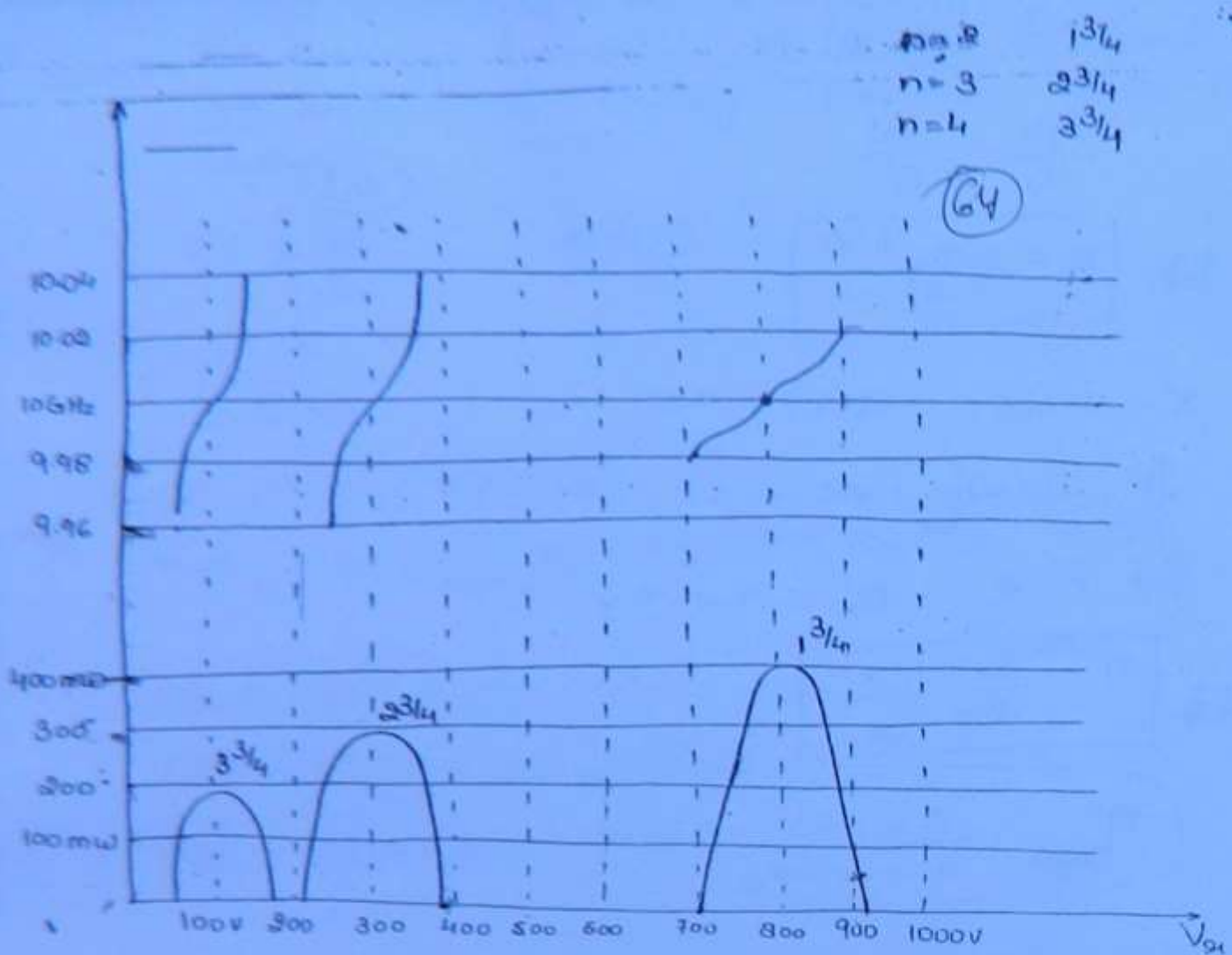
$$\theta_0' = 2n\pi - \pi/2$$

$$x' = \frac{\beta_i V_i}{2V_0} \theta_0'$$

$$\boxed{\frac{V_0}{(V_R + V_0)^2} = \frac{(2n\pi - \pi/2)^2}{8\omega^2 L^2} \cdot \frac{q}{m}}$$

O/p power in terms of repeller voltage \rightarrow

$$P_{ac} = \frac{V_0 I_0}{\omega L} x' J_1(x') [V_R + V_0] \sqrt{\frac{q}{2mV_0}}$$



Que. A Reflex Klystron operates under the following condition

$$V_0 = 600 \text{ V}$$

$$L = 1 \text{ mm}$$

$$R_{sh} = 15 \text{ k}\Omega$$

$$e/m = 1.759 \times 10^{11}$$

$$f_{sr} = 9 \text{ GHz (resonant freq.)}$$

Tube is oscillating at f_{sr} at the peak of $n=2$ mode is $1\frac{3}{4}$ mode assume that the transit time to the gap and beam loading can be neglected.

A) find the repeller voltage V_R .

B) find the direct current necessary to give a p-wave gap voltage of 200 volt

C) what is the electronic efficiency under this condition

Soln A) $\frac{V_o}{(V_R + V_o)^2} = \left(\frac{e}{m}\right) \frac{(2n\pi - \pi/2)^2}{8\omega^2 L^2}$

$$\boxed{V_R = 250 \text{ volt}}$$

(65)

B) $V_{\text{induced}} = 200 \text{ V}$

$$V_{\text{ind}} = I_{\text{ind}} \times R_{\text{SH}}$$

$$= 2\beta_o I_o J_1(x) R_{\text{SH}}$$

$$\begin{array}{c} d=0 \\ \left| \right| \end{array}$$

$$\beta_g = 0$$

$$\beta_i = \beta_o = 1$$

$$R_{\text{SH}} = R_{\text{SH}0} \parallel R_L \parallel R_B$$

$$\boxed{R_B = \infty}$$

$$X = \frac{\beta_i V_i}{2V_o} \theta_o'$$

$$= \frac{1 \times 200}{2 \times 600} (2 \times 2 \times \pi - \pi/2)$$

$$= \frac{14\pi}{24} = 1.838$$

$$\approx 1.84$$

$$X = 1.84 \quad J_1(x) = 0.58$$

$$I_o = \frac{V_{\text{ind}}}{2\beta_o J_1(x) R_{\text{SH}}} = \frac{200}{2 \times 1 \times 0.58 \times 15 \times 10^{-3}} = 11.45 \text{ mA}$$

$$\boxed{I_o = 11.45 \text{ mA}}$$

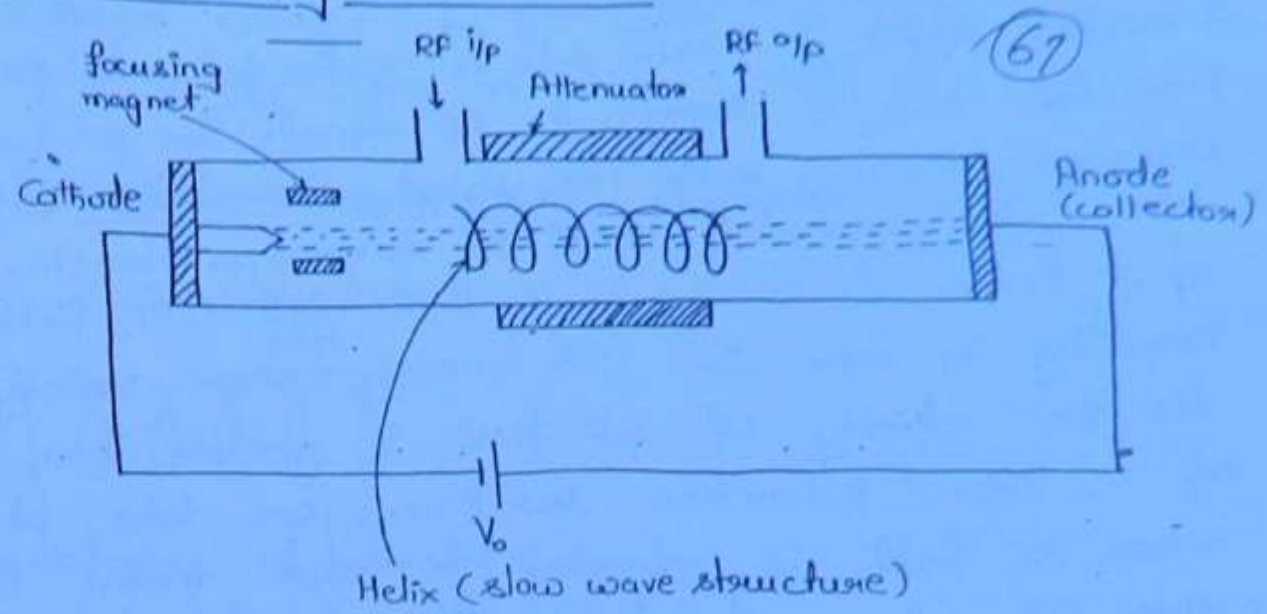
C) $\eta = \frac{2x' J_1(x')}{2n\pi - \pi/2}$

$$\eta = \frac{2 \times 1.84 \times 0.58}{2 \times 2 \times \pi - \pi/2} \text{ per cent} = 19.49\%$$

Reflex Klystron :-

- Reflex klystron is a low power generator of 10-500 m at freq. range of 1-25 GHz, efficiency is about 20-30%. This type is widely used in laboratory for wave measurements and in wave receivers as local oscillator in commercial, military and airborne doppler radar as well as mixer.
- It is used as signal source in wave generators.
- It is used as freq. modulated oscillator in portable wave links as freq. can be varied by change repeller voltage V_R .
- It is used as pump oscillator for parametric amp.

TWT (Travelling Wave Tube)



(67)

$v_e = 0.593 \times 10^6 \sqrt{V_0} \text{ m/sec}$
 for eq. $V_0 = 900 \text{ V}$
 $v_e = 1.8 \times 10^7 \text{ m/sec}$
 $v_{RF} = 3 \times 10^8 \text{ m/sec}$

axial electric field.
 $v_p = \text{phase velocity on}$
 resultant axial velocity
 $v_p = v_e$



Difference b/w Two cavity klystron & TWT

Two cavity klystron

TWT

- # Electron beam is moving from cathode to anode but RF signal is stationary.
- # We are using cavity resonator.
- # ~~It is a~~ Cavity resonator is a resonant device.
 $\therefore \text{GBW} = \text{constt.}$ So to \uparrow BW we have to reduce Gain.
- # This is narrow band ampⁿ.

- # e^- beam & RF signal are travelling in same direction with nearly same velocity.
- # We are using Helix (slow wave structure)
- # Helix is a non-resonant device.
 $\therefore \text{GBW}$ is not constant
 So we can \uparrow BW without compromising Gain.
- # This is broad band ampⁿ.

Operation of TWT (Qualitative Analysis)

(68)

- Interaction space in TWT tube is extended to increase the interaction b/w e^- beam and RF signal. The e^- beam exchange energy with RF signal over full length of tube. The necessary condition to ensure an interaction b/w an e^- beam & RF signal is that both (RF field & e^- beam) travelling in same direction with nearly same velocity.

As the velocity of RF field is greater than velocity of e^- then interaction b/w them can take place when RF field is retarded by some means. Like Helix (slow wave structure). RF field will produce electric field at the centre of helix. RF field travel with velocity of light but resultant axial electric field travel with a retarded velocity due to helix.

When the velocity of e^- beam travelling through the helix approaches the state of resultant electric field that is


$$V_0 = V_p$$

the interaction takes place b/w them. in such a way that on an average e^- beam delivers energy to RF wave.

- # When resultant axial electric field is zero. the velocity of e^- will remain unaffected these are called reference electron.
- # When axial electric field is +ve, e^- will be accelerated these are called late electron. ($V_L > V_0$)
- # When axial electric field is -ve, field will retard the velocity of e^- , these are called early e^- .

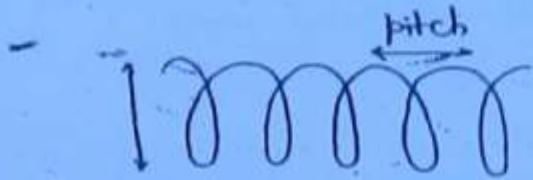
So the velocity of e^- is modulated.

- # With each cycle of axial electric field one bunch of e^- forms (current modulation)

* e's in bunch will counteract retarded field, so it delivered energy to RF wave in helix with successive cycle energy goes on ↑ing.  (69)

Mathematical (Quantitative) Analysis

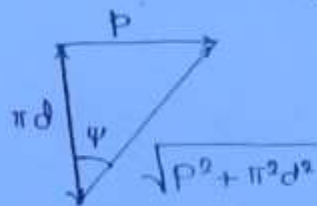
Slow wave structure



circumference of helix = πd
 diameter of helix = d

p = pitch

ψ = helix angle



resultant axial velocity [Phase velocity]

$$V_p = V_c \sin \psi$$

$$V_c = 3 \times 10^8 \text{ m/sec}$$

$$V_c = \frac{1}{\sqrt{\mu_0 \epsilon_0 \mu_r \epsilon_r}}$$

$$V_p = V_c \times \frac{p}{\sqrt{p^2 + \pi^2 d^2}}$$

$$p^2 \ll \pi^2 d^2$$

$$V_p = V_c \times \frac{p}{\pi d}$$

Imp:
$$V_p = V_c \times \frac{\text{Pitch}}{\text{Circumference}}$$

for dielectric medium

$$V_p = \frac{p}{\sqrt{\mu_0 \mu_r \epsilon_0 \epsilon_r (p^2 + \pi^2 d^2)}}$$

$$\mu_r = 1$$

for useful gain
$$V_p = V_0$$

convection current in e- beam

$$i = j \frac{\beta_e I_0}{2 V_0 (j\beta_e - \gamma)^2} E_1 \quad \text{--- ①}$$

(70)

electronic equation

E_1 = axial electric field

$\gamma = \alpha_e + j\beta_e$ = Propagation constant of axial wave

β_e = Phase constant = ω/V_0

$$V_0 = \sqrt{\frac{2q}{m}} V_0$$

$$E_1 = \frac{-\gamma^2 \gamma_0 Z_0 i}{\gamma^2 - \gamma_0^2} \quad \text{--- ② circuit equation}$$

$Z_0 = \sqrt{\frac{L}{C}}$ = characteristic impedance

$$\gamma_0 = j\omega\sqrt{LC}$$

from eqn ① & ②

$$(\gamma^2 - \gamma_0^2) [j\beta_e - \gamma]^2 = \frac{-j\gamma^2 \gamma_0 Z_0 \beta_e I_0}{2 V_0} \quad \text{--- ③}$$

This eqn has four roots.

Approximate soln $V_p = V_0$

$$\gamma_0 = j\beta_e$$

$$(\gamma - j\beta_e)^3 (\gamma + j\beta_e) = 2c^3 \beta_e^2 \gamma^2 \quad \text{--- ④}$$

c = TWT gain parameter

$$c = \left[\frac{I_0 Z_0}{4 V_0} \right]^{1/3} \quad \text{--- ⑤}$$

from eqn ④

Value of four propagation constant

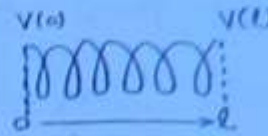
$$\gamma_1 = \beta_e c \frac{\sqrt{3}}{2} + j\beta_e [1 + c/2] \rightarrow \text{forward wave - [Useful]}$$

$$\left. \begin{aligned} Y_2 &= \beta_e c \frac{\sqrt{3}}{3} + j\beta_e [1 + c/2] \\ Y_3 &= j\beta_e [1 - c] \end{aligned} \right\} \rightarrow \text{forward wave (71)}$$

$$Y_4 = -j\beta_e [1 - c^3/4] \rightarrow \text{Backward wave}$$

o/p power gain in decibel

$$A_p = 10 \log \left| \frac{V(l)}{V(0)} \right|^2$$



$$A_p = 9.54 + 47.3 \text{ NC dB}$$

$$N = l/\lambda_e = \text{ckt length in electronic wavelength}$$

$$\beta_e = \frac{2\pi}{\lambda_e}$$

$V(l)$ = o/p voltage at length l

Wave eqn. for TWT

$$V(l) = \frac{V(0)}{3} e^{-\gamma l}$$

$$V(l) = \frac{V(0)}{3} \exp \left[\beta_e c \frac{\sqrt{3}}{3} l \right] \exp \left[-j\beta_e l (1 + c/2) \right]$$

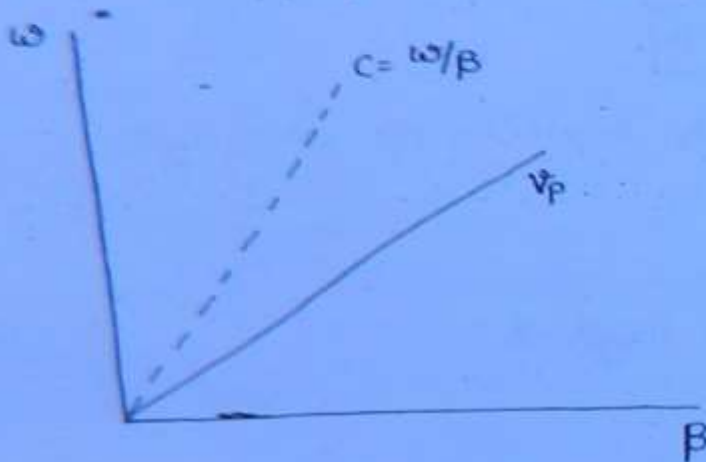
- # TWT is capable of **enormous** bandwidth. Its main application is as a medium or high power ampⁿ. either continuous wave (CW) or pulsed wave.
- # TWT are capable of much higher **duty cycle** than klystron or magnetrons and thus are thus used in application where this features is required.
- # Initial velocity of e^- is slightly greater than that of axial RF field (phase velocity). The extra initial velocity of e^- in beam balance the retardation due to energy being given to RF field.

• If the dielectric constant is large, efficiency of TWT will reduce.

• The parasitic oscillation can be reduced by coating the glass wall of the TWT by "aquodag" which act as attenuator. (72)

• At low freq the gain is limited by helix length.

• Boillouin Diagram



Helix (slow wave structure) ($\omega\beta$) diagram is very useful in designing a helix. Once β is formed v_p can be calculated (computed) from

$\omega_c = \omega_p$ for given dimension of helix.

Que TWT operates under following parameter

Beam voltage $V_0 = 3 \text{ kV}$.

Beam current $I_0 = 30 \text{ mA}$

char. impedance of the helix $Z_0 = 10 \Omega$

ckt. length $N = 50$

freq. $f = 10 \text{ GHz}$

determine - A) Gain parameter C

B) O/p power gain in dB

C) All four propagation constt.

D) Write down the voltage eqn. of TWT.

Solu

$$A) \quad c = \left[\frac{I_0 Z_0}{4 V_0} \right]^{1/3}$$

$$= 2.93 \times 10^{-3}$$

(73)

$$B) \quad A_p = -9.54 \times 47.3 \text{ NC dB}$$

$$A_p = 59.52 \text{ dB} \quad (\text{high gain})$$

$$c) \quad \beta_e = \frac{2\pi}{\lambda_e} = \frac{2\pi}{\lambda_e} f$$

$$\beta_e = \omega / V_0 = 1.93 \times 10^3 \text{ rad/sec}$$

$$[V_0 = 0.593 \times 10^6 \sqrt{V_0} \text{ m/sec.}]$$

$$\gamma_1 =$$

$$= -49.03 + j1952$$

$$\gamma_2 =$$

$$= 49.03 + j1952$$

$$\gamma_3 =$$

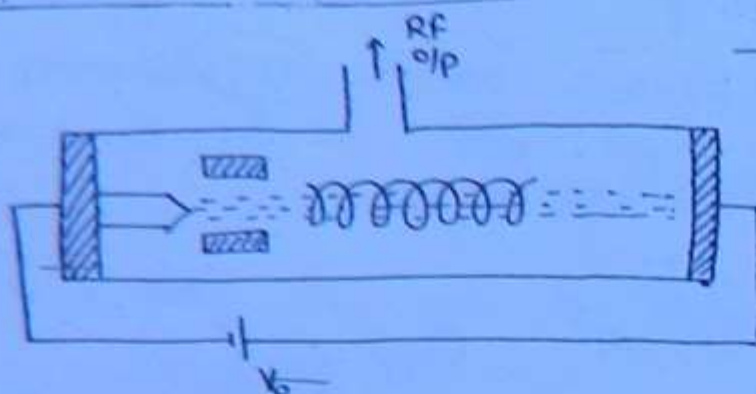
$$= j1872.25$$

$$\gamma_4 =$$

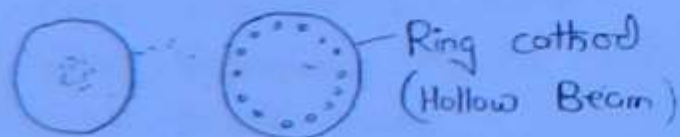
$$= -j1930$$

D)

Backward Wave Oscillator :-



- BWO is a muwave continuous wave (CW). Oscillator with excellent tuning capability and fixed coverage range.
- It operates under the principle of e^- beam RF field interaction. generally using helix (slow wave structure)
- In general appearance BWO looks like a shorter and thicker TWT.
- Unlike the TWT, BWO doesn't have an attenuator along the tube. As a simplification the oscillation may be occurring b/w of reflexion from an imperfectly terminated collector End (Anode end) of the helix. there is a feedback and o/p is collected from Cathode End of ~~the tube~~ towards which reflexion took place.
- ⇒ B/w helix is essentially a non-resonant structure, BW is very high.



- BW is limited by interaction b/w the beam & slow wave structure. to increase this interaction BWO has a ring cathode which sends out a Hollow Beam with max. intensity near to helix.

Que. A helical TWT has a diameter of 2 mm with 50 turns/cm. calculate →

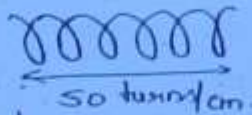
A) Axial phase velocity

B) Anode voltage at which TWT can be operated for useful gain.

Solu. A) $V_p = V_c \times \frac{\text{pitch}}{\text{circumference}}$

$$V_c = 3 \times 10^8 \text{ m/sec}$$

pitch



$$\text{pitch} = \frac{1}{50} \text{ cm}$$

$$d = 2 \text{ mm} = 0.2 \text{ cm}$$

$$V_p = 3 \times 10^8 \times \frac{1}{50} \times \frac{1}{3.14 \times 0.2}$$

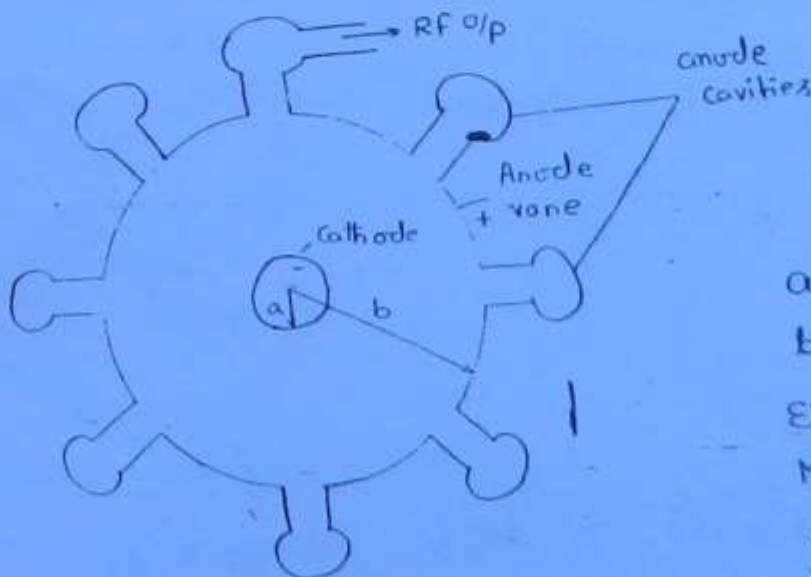
$$V_p = 0.954 \times 10^7 \text{ m/sec}$$

B) $V_p = V_0 = 0.593 \times 10^6 \sqrt{V_0}$

$$V_0 = 259.2 \text{ volt}$$

29 feb 2012

Magnetron :-



a = radius of cathode

b = radius of anode

Electric field is radial dirⁿ

Magnetic field is axial direction

$E \perp B$

cross field device

Effect of magnetic field



Magnetic field

$$B=0$$

Small B

Critical magnetic field $B=B_c$

$$* B > B_c$$

Electron

a

b

c

d

$V_0 = \text{dc voltage}$

$$V_0 = 0.543 \times 10^6 \sqrt{V_0} \text{ m/sec.}$$

$$\frac{mv^2}{R} = BqV$$

$$R = \frac{mv}{Bq}$$

Phase difference b/w adjacent anode cavities \rightarrow

$$\phi = \frac{2n\pi}{N}$$

$N = \text{no. of cavities}$

$$n=1 \quad N=8$$

$$\phi = \frac{2\pi}{8} = \pi/4 = 45^\circ$$

π -mode is dominant mode

$\pi = \text{phase difference b/w adjacent cavities}$

$$\phi = \frac{2n\pi}{N}$$

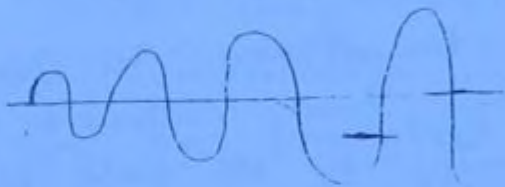
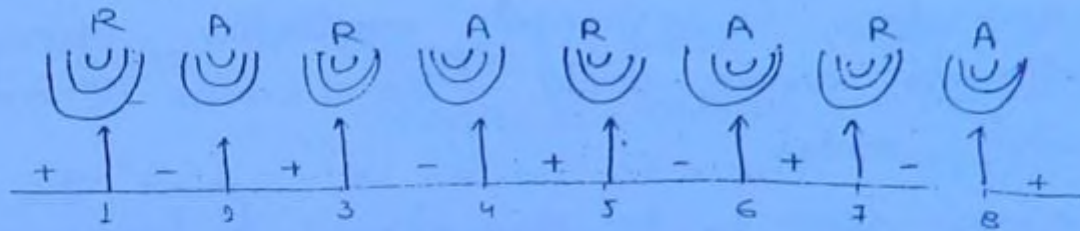
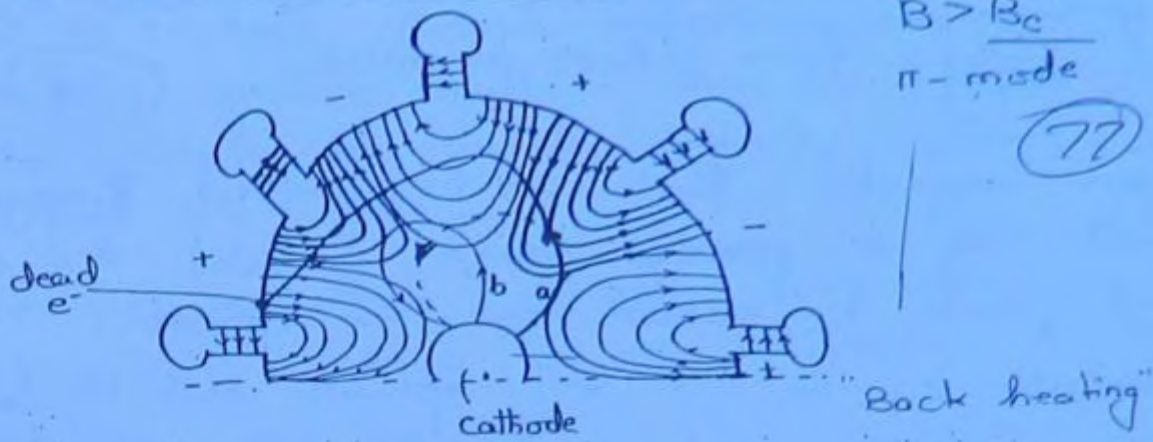
$$\pi = \frac{\phi N}{2n}$$

$$\pi = \frac{2n\pi}{N}$$

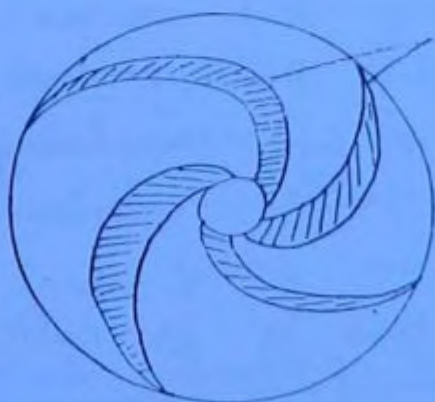
$$N = 2n$$

$$n=1, 2, 3, 4, 5$$

$$N = \text{even no.}$$



$v_e < v_a < v_c$
 one bunch / cycle
 one bunch / two cavity



Spokes

Cavity	spokes
8	4
6	3

Qualitative analysis →

Without any magnetic field e^- travels in straight line from cathode to anode, under electric field in radial direction. (e^- 'a'). When the magnetic field is applied

e^- will travel in circular path of radius 'R'

$$R = \frac{mv}{Bq}$$

from cathode to anode.

(78)

- When magnetic field is too critical & magnetic field de e^- ~~goes~~ ~~goes~~ [touch] the surface of anode & return back to cathode.

for all $B > B_c$ e^- will return back to cathode.

- For magnetron to sustained oscillation phase diff. b/w adjacent anode should be π (since π -mode is dominant mode)

- The e^- 'a' seen to be slow down in presence of oscillation (RF signal) Thus transferring energy to oscillation during its journey from cathode to anode. Such e^- with transfer energy to RF field called favourable e^- . These e^- moves from cathode to anode with some velocity (v_0). due to tangential RF field dirⁿ of e^- changes and velocity of e^- reduces. So KE of e^- is transferred to RF field

Some e^- takes energy from the RF field and return back to cathode with high velocity. Such e^- are called unfavourable e^- . ~~they~~ they cause heating "back heating". Back heating can be compensated by regulating the heater supply.

- The e^- which emit a little later than 'a' is called late e^- .
- to be in correct position they move faster than reference e^- . and try to catchup e^- 'a' and e^- 'c' (early e^-) try to slow down to fall back in step with e^- 'a'.

Thus a cloud of favourable e^- is formed, which is centred around reference e^- , one for each two anode cavities. Thus the spoke so far locate rotate with angular velocity corresponds to two pole per cycle.

phase focusing effect of these favourable e^- impart (give) enough energy to RF oscillation so that oscillations are sustained.

Freq. Pushing \Rightarrow Change in anode voltage result in change in orbital velocity of e^- this will change the rate at which energy is transfer to anode cavity resonator and thus change the freq. of oscillation. this is called freq. pushing. It can be prevented by providing constant supply (V_0).

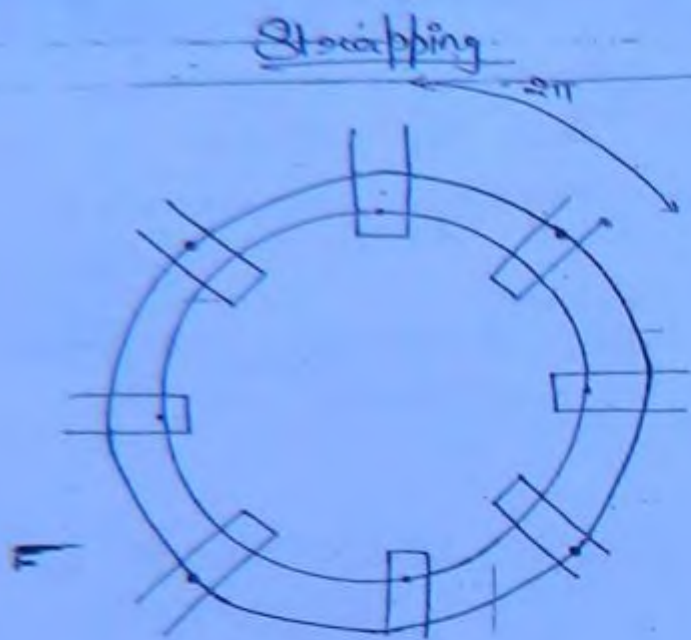
Freq. Pulling \Rightarrow Magnetron is susceptible to freq. variation due to change in load impedance this take place regardless of whether the load variations are purely resistive or reactive variation however magnetron freq. variations are more severe for reactive variations. this freq. variations are called freq. pulling caused by load impedance variation reflected into cavity resonators. freq. pulling can be prevented by using circulator.

Mode Jumping in Magnetron \Rightarrow

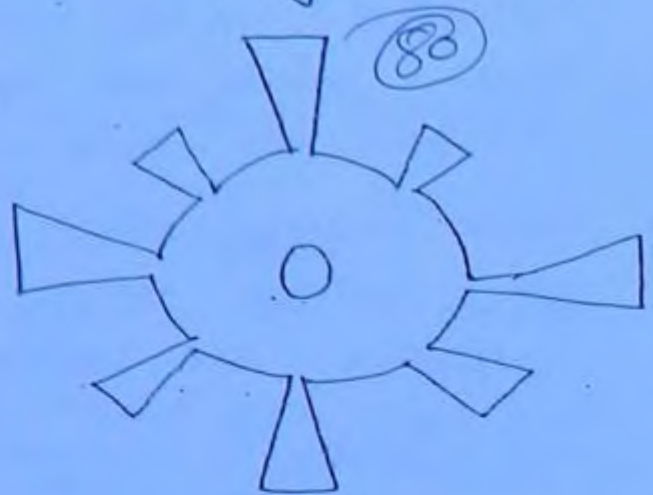
Stray effect

$$Z_c = \frac{1}{2\pi f c}$$

$f \rightarrow$ low $Z_c \rightarrow$ very high
 $f \rightarrow$ high $Z_c \downarrow$



Rising Sun Magnetron



8/2 of magnetron have eight ^{or} more coupled cavity resonators, several diff. modes of operation are possible oscillating freq. ~~corresponding~~ to diff. modes are not same, Some are quite close to one another -

So that ~~there~~ ^{through} mode jumping are 3 cm π mode oscillation which is normal for a particular magnetron could spuriously become a 3.05 cm, $3/4\pi$ mode oscillation.

The DC electric and magnetic field adjusted to be correct for π -mode, would still support spurious mode toward certain extent. since its freq. is not too far distance the result might be oscillations of reduce power at wrong freq.

The magnetron using identical ~~cava~~ cavities in anode block normally employ strapping to prevent mode jumping. Strapping help to achieve dominant mode (π -mode) in magnetron, however strapping cause power loss due to radiation and stray effect.

In rising sun magnetron strapping is not require.

Mathematical Analysis

1. Cyclotron Angular freq. \rightarrow

(81)

Since the magnetic field is normal to motion of e^- that travel in cycloidal path the outward centrifugal force is equal to pulling force.

$$\text{i.e. } \frac{mv^2}{R} = BqV$$

R - radius of cycloidal path

v - velocity of e^-

Angular freq. of e^-

B - magnetic field W/m^2

$$\boxed{\omega_c = \frac{v}{R} = \frac{Bq}{m}} \text{ Imp.}$$

2. "Hull cut off magnetic eqn."

$$B_{oc} = \frac{\left[8V_0 \frac{m}{e} \right]^{1/2}}{b \left[1 - \frac{a^2}{b^2} \right]}$$

m - mass of e^-

e - charge of $e^- = q$

a - radius of cathode

b - radius of anode

Since $b^2 \gg a^2$

$$\boxed{B_{oc} = \frac{1}{b} \left[8V_0 \frac{m}{e} \right]^{1/2}}$$

this means that if applied $\boxed{B_0 > B_{oc}}$ for a given V_0 the e^- will not reach anode.

3. Hull cut off voltage eqn.

$$\boxed{V_{oc} = \frac{e}{8m} B_0^2 b^2 \left[1 - \frac{a^2}{b^2} \right]^2}$$

This means that if ~~$B_0 < B_{oc}$~~ $\boxed{V_0 < V_{oc}}$ for a given B_0 e^- will not reach anode.

Imp points on magnetron

(82)

- * This magnetron are also called "M-type tube" after the french "TPOM" (tubes for propagation of waves in a magnetic field).

* Backward wave cross-field ampⁿ (BWCFA)

Its trade name is amplatron. It is a broad band high power, high gain and high efficiency microwave tube. and it has many applications such as in -

- Air borne radar system
- Space borne comm. system.

Refer workbook

* Backward wave cross-field oscillator (BWCO)

In this device an injection gun replaced its conventional cylindrical cathode of magnetron. Its trade name is cascinatron. and it is also called M-type backward wave oscillator.

- * Magnetron is also called travelling wave magnetron. Since this depends on ~~const~~ interaction of e^- with a travelling electro-magnetic field.

The various char. of magnetron including the optimum combination of anode voltage & magnetic flux are normally plotted on performance chart & Rieke diagram from these best operating conditions are selected.

* Comparison b/w O-type & M-type tube

O-type

- * These are linear beam tube
- * DC magnetic field is \parallel with DC electric field

M-type

- * Crossfield tube
- * DC magnetic field is \perp to DC electric field

* DC magnetic field is used
mainly to focus e-beam.

* DC magnetic field plays a
direct role in RF interaction
process. (83)

Ex. Klystron, TWT, Reflex
Klystron, BWO

Ex. Magnetron, amplifier,
cascination, gyration

Que. X-band pulsed cylindrical magnetron has following
operating parameters.

Anode voltage $V_0 = 26 \text{ kV}$

Beam current $I_0 = 97 \text{ Amp}$

Magnetic flux density $B_0 = 0.336 \text{ wb/m}^2$

radius of cathod cylinder $a = 5 \text{ cm}$

radius of ~~band~~ edge to centre $b = 10 \text{ cm}$
Vane

: find —
A) cyclotron angular freq.

B) cut off voltage for fixed V_0

C) cut off magnetic flux density for fixed V_0

Solu

A) $\omega_c = \frac{q}{m} B_0 = 1.759 \times 10^{11} \times 0.336$

$$\omega_c = 5.91 \times 10^{10} \text{ rad/sec.}$$

B) $V_{oc} = \left[\frac{e}{8m} B_0^2 b^2 \left[1 - \frac{a^2}{b^2} \right]^2 \right]$

$$= \frac{1}{8} \times 1.759 \times 10^{11} \times (0.336)^2 \times [10 \times 10^{-2}]^2 \times \left[1 - \left(\frac{5}{10} \right)^2 \right]^2$$

$$V_{oc} = 139.50 \text{ kV}$$

C) $B_{oc} = \frac{\left[8 V_0 \frac{m}{e} \right]^{1/2}}{b \left[1 - \frac{a^2}{b^2} \right]}$

$$B_{oc} = 14.495 \text{ mwb/m}^2$$

$$B_0 = 0.336 \text{ wb/m}^2 > B_{oc}$$

Note :- In order for oscillations to be produced in the structure anode DC voltage must be adjusted so that avg rotational velocity of e^- correspond to phase velocity of field in slow wave structure.

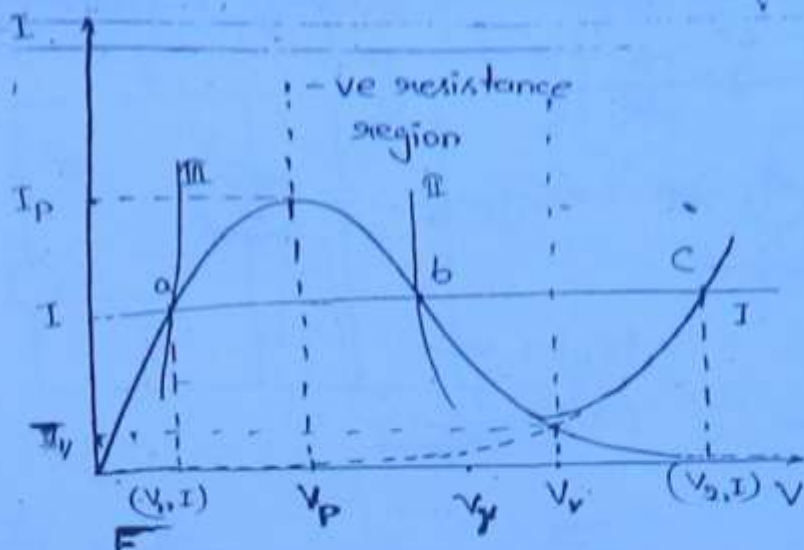
(84)

1 March 2012

SOLID STATE DEVICES

TUNNEL DIODE →

- It is a -ve resistance semiconductor PN junction diode. This -ve resistance is created by tunnel effect of e^- in PN junction. Doping of both p and n-regions of tunnel diode is very high and depletion layer barrier at junction is very thin on order of $100 \text{ \AA} / 10^{-6} \text{ cm}$. Classically it is possible for those particles to pass over the barrier if and only if they have an energy equal to or greater than potential barrier.
- Quantum mechanically however if barrier is less than 20 \AA there is an appreciable probability that particles will tunnel through the potential barrier even though they don't have enough KE to pass over same barrier.
- In addition to barrier thickness there must also be filled energy state on the side from which particles will tunnel and allowed empty state on the other side into which particles penetrate through at same energy level.



(85)

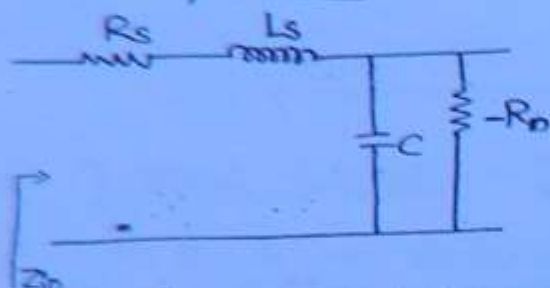
- # The tunnel diode is useful in μ wave oscillator & amp² bcz the diode exhibits a -ve resistance char. in region b/w peak current I_P & valley current I_V .
- # In fig a b c load line intersects the char. curve in three points. a & c are stable points & point b is unstable. If the voltage & current vary about b the final value of I & V would be given by point 'a' or 'c' but not by b.
Since tunnel diode has two stable states for this ~~type~~ ckt. is called bistable. & it can be use as a binary device. in switching ckt.
- # Second load line intersect I_V curve at point b' only, this point is unstable. and shows a dynamic -ve conductance. that enables the tunnel diode to a fun. as a μ wave amp² & oscillator.
the ckt with load line crossing pt 'b' in -ve resistance region is called astable ckt.
- # An other load line (III) crossing point 'a' in +ve resistance region indicates a monostable ckt.

-ve conductance $= -g = \frac{di}{dv} \bigg|_{V_b} = -\frac{1}{R_n}$

R_n = magnitude of -ve resistance

(86)

AC equ. ckt. at high freq.



$$|Z_L| = \omega L_s$$

$$|Z_C| = \frac{1}{\omega C}$$

R_s & L_s denote resistance & inductance of packaging ckt of a tunnel diode

Jun. cap. C is usually measured at valley point.

Typical values -

$$I_p = 10 \text{ mA}, \quad -R_n = -30 \Omega, \quad R_s = 1 \Omega, \quad L_s = 5 \text{ nH}, \quad C = 20 \text{ pF}$$

$$Z_{in} = R_s + j\omega L_s + \frac{-j/\omega C \times -R_n}{-j/\omega C - R_n}$$

$$Z_{in} = R_s - \frac{R_n}{1 + [\omega R_n C]^2} + j \left[\omega L_s - \frac{\omega R_n^2 C}{1 + (\omega R_n C)^2} \right]$$

For resistive cutoff freq.

Obj real part equal to zero -

real part = 0

$$f_c = \frac{\omega_c}{2\pi} = \frac{1}{2\pi R_n C} \left[\frac{R_n}{R_s} - 1 \right]$$

Obj For self resonance freq.

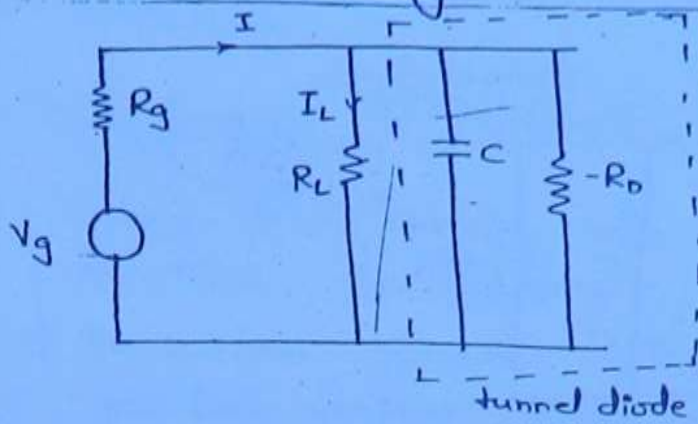
img. part = 0

$$f_{sr} = \frac{\omega_{sr}}{2\pi} = \frac{1}{2\pi R_n C} \left[\frac{R_n^2 C}{L_s} - 1 \right]$$

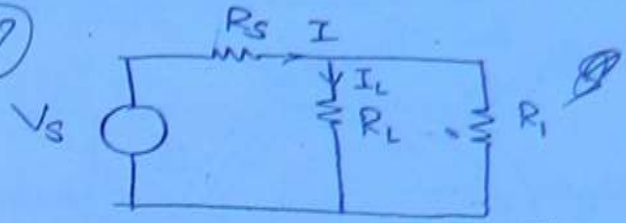
Tunnel diode can be connected either in parallel or in series with a resistive load as an ampⁿ →

1. Parallel loading

Parallel loading :-



(87)



$$\frac{I_L}{I} = \frac{R_i}{R_i + R_L} < 1$$

$$A = \frac{I_L}{I} = -\frac{R_n}{-R_n + R_L} = \frac{R_n}{R_n - R_L} > 1$$

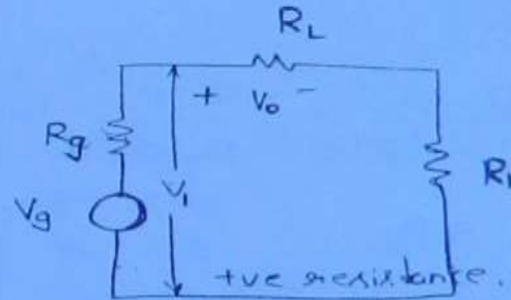
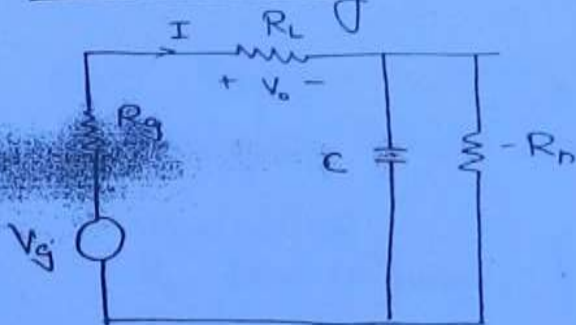
$$|R_n| = |R_L|$$

amp^x

$$A = \infty$$

ckt. act as an oscillator.

Series loading :-



$$A = \frac{V_0}{V_i} = \frac{R_L}{R_i + R_L} < 1 \quad \therefore \text{Attenuation.}$$

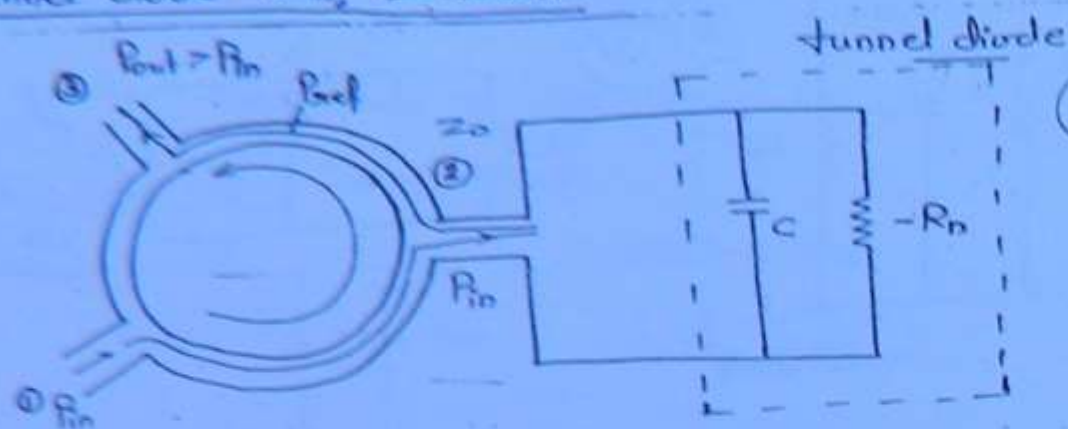
$$\text{-ve resistance} \quad A = \frac{V_0}{V_i} = \frac{R_L}{R_L - R_n} > 1$$

\therefore amplification.

$$|R_L| = |R_n| \quad A = \infty$$

ckt. act as an oscillator.

Tunnel diode with circulator →



Reflection coefficient

$$K = \frac{Z_L - Z_0}{Z_L + Z_0}$$

$$Z_L = -R$$

$$Z_0 = R$$

normally

$$K = \sqrt{\frac{P_{ref}}{P_{in}}} < 1$$

$$P_{ref} < P_{in}$$

$$K = \frac{-R - R_0}{-R + R_0} = \frac{R + R_0}{R - R_0} > 1$$

$$P_{ref} > P_{in}$$

$$\text{if } |R| = |R_0| \quad K = \infty$$

i.e. there is finite reflected power without incident power ckt. act as an oscillation.

- A tunnel diode can be connected to a microwave circulator to make a -ve resistance amp. If the circulator is perfect & has a +ve real char. impedance. i.e. $Z_0 = R_0$, and amp. with infinite gain can be built by selecting a -ve resistance tunnel diode whose i/p impedance has a real part equal to $-R_0$ & img. part is equal to zero then reflection coefficient, $K = \infty$ i.e. finite

reflected w/p without any i/p ckt act as an oscillator

Transferred e^- devices [TED]:-

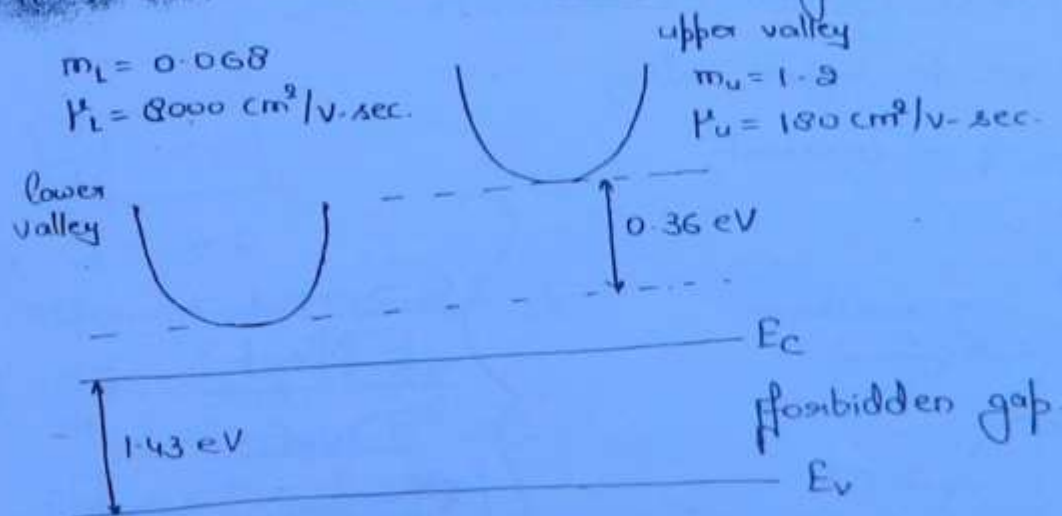
(89)

Theory & technology of transistors can't be applied to TED's for following reasons -

1. Transistors operate with either junc. or gate but TED's are bulk devices having no junc. or gates.
2. The majority of Tr are fabricated from elemental S.C. such as Si & Ge. whereas TED's are fabricated from compound S.C. such as GaAs [Gallium Arsenide], InP [Indium phosphide], CdTe [Cadmium telluride]
3. Tr. operated with 'warm' e^- whose energy is not much greater than thermal energy (0.026 eV) at room temp) of e^- in S.C. whereas TED's operate with 'Hot' e^- whose energy is very much greater than thermal energy.

RWH Theory (Ridley Watkins Hilsum theory)

It is also known as two valley theory



n-type GaAs

$n = N_D = \text{conc } e^- \text{ in conduction band}$

$J = nE$ all es are in lower valley

Case I conc. of e^- in lower valley $= n$

$$\sigma = n\mu_L q = \text{constant}$$

$$J = \sigma E$$

$$E \uparrow J \uparrow$$

Case II $E \uparrow$ some e^- get sufficient energy & jump upper valley.

let $n_1 =$ conc e^- in lower valley

$n_2 =$ " " upper valley

$$n = n_1 + n_2$$

$$\sigma' = [n_1 \mu_L + n_2 \mu_U] q$$

$$E \uparrow \sigma' \downarrow \quad J = \sigma' E \downarrow$$

+ve resistance region

Ex $n = 100$ $\mu_L = 100$ $\mu_U = 50$

$$\sigma = n\mu_L^1 = 10000 \text{ constant}$$

$$\sigma' = 80 \times 100 + 20 \times 50 = 9000$$

$$\sigma' = 50 \times 100 + 50 \times 50 = 7500$$

$$\sigma' = 20 \times 100 + 80 \times 50 = 6000$$

$$\left. \begin{array}{l} \downarrow \\ E \uparrow \end{array} \right\}$$

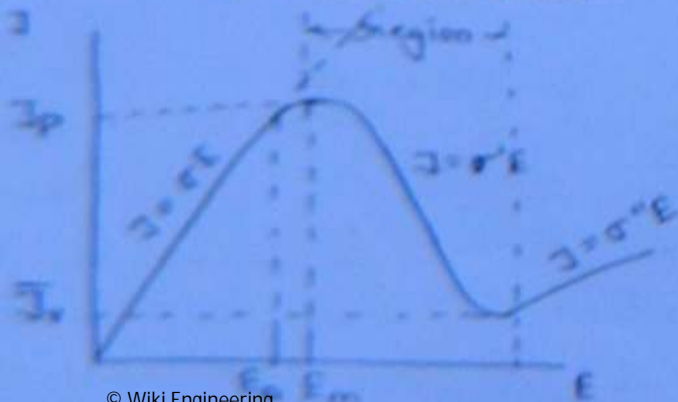
$$\sigma' = 100 \times 50 = 5000 \text{ constant}$$

Case III all e^- in upper valley

$$\sigma'' = n\mu_U q = \text{constant}$$

$$J = \sigma'' E$$

$$E \uparrow J \uparrow \text{ -ve resistance region}$$



GUNN
Effect
Device
(GUNN Diode)

1. Gunn effect diode is based on periodic fluctuation of current passing through n-type GaAs when applied voltage exceeds the threshold value. (91)

AR 2. It consists of two valleys, lower valley & upper valley. e^- in lower valley has smaller effective mass and higher mobility, while e^- in upper valley has higher effective mass and lower mobility (since the upper valley has higher density of states than lower valley).

⇒ At low electric field & low temp. e^- occupied lower valley and carry ohmic current density i.e. $J = \sigma E$.
 As the applied field E increases, e^- gains energy and move upward in upper valley so mobility of e^- decreases and effective mass increases as a result of which current density decreases with increase in electric field and differential conductivity is -ve.

3. As applied field further increases all the e^- from lower valley transfer to upper valley and carrying ohmic current density i.e. $J = \sigma'' E$ & $\sigma'' < \sigma$.

for -ve differential conductivity

$$E \uparrow \quad J \downarrow$$

$$\boxed{\frac{dJ}{dE} < 0}$$

$$J = \sigma E$$

differentiate w.r.t E

$$\frac{dJ}{dE} = \sigma + E \frac{d\sigma}{dE}$$

$$\frac{dJ}{dE} = \sigma \left[1 + \frac{E}{\sigma} \frac{d\sigma}{dE} \right]$$

$$\frac{dJ}{dE} < 0$$

$$\sigma \left[1 + \frac{E}{\sigma} \frac{d\sigma}{dE} \right] < 0$$

$$\boxed{1 + \frac{E}{\sigma} \frac{d\sigma}{dE} < 0}$$

(92)

Domain Formation:-

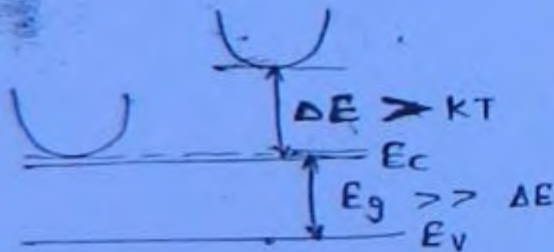
Imp. condⁿ for transferred e⁻ device

1. There should be two valley in conduction band.

- lower valley
- Upper valley

Effective mass of e⁻ in lower valley should be less than that in upper valley. and the mobility of e⁻ in lower valley should be greater than that in upper valley.

2. Separation energy b/w bottom of lower valley & bottom of upper valley must be several times larger than thermal energy (0.026 eV at room temp) this means that —



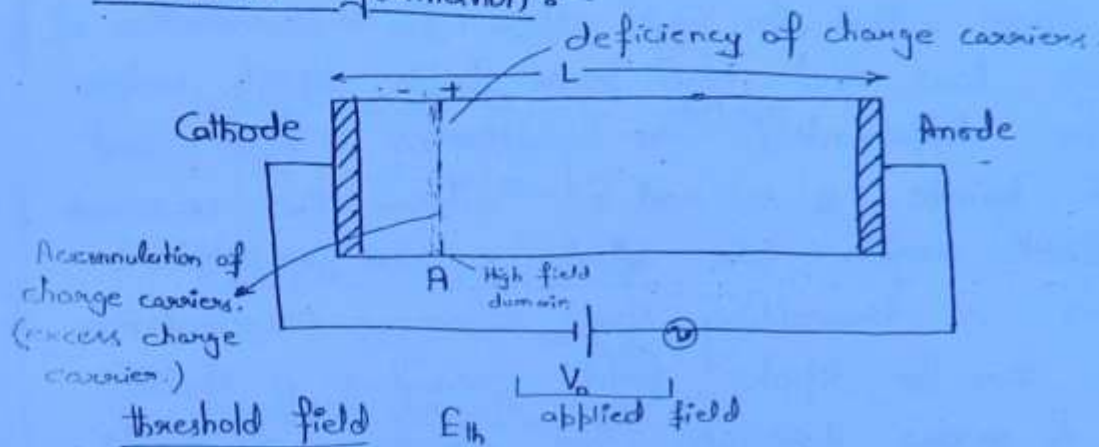
3. The separation energy b/w valleys must be smaller than gap energy b/w conduction band & valence band i.e. $\Delta E < E_g$ otherwise S.C. will breakdown & become highly conductive before e⁻ begins to transfer to upper valley b/c hole-e⁻ pair formation is created.

Note: Si & Ge don't meet all these criteria therefore, they can't use as TED.

GaAs, InP, CdTe satisfied these criteria.

Note:- InAs [Indium arsenide], GaP [gallium phosphide] & InSb [Indium Antimonide] doesn't satisfied these criteria.

Domain formation:-



$$E = V_a/L < E_{th}$$

charge distribution is uniform.

electric field is uniform.

Applied field $E > E_{th}$.

charge distribution become non uniform.

Electric field become non uniform.

" When applied voltage is above threshold value, high field domain is formed near the cathode that reduces the electric field in rest of material (since the charge density & electric field within the sample become non-uniform & creating domain)

" For constt voltage V an increase in electric field within the specimen 'A' must be compensated by decrease in electric field in rest of the diode. then high field domain drifts with carrier stream, across the electrode & disappear at anode contacts.

- Specifically it is assumed that at point 'A' there exist an axis (or accumulation of -ve charge that would be caused by a random noise fluctuations or possibly by a permanent non-uniformity in doping in N-type GaAs diode. Then an electric field is created by accumulated charge carriers. Field to left of point 'A' is lower than that to right. b/c of accumulation of charge both low and high peak fields reach values outside the differential -ve resistance region and settled at points 'a' and 'c'. where the current in two field regions are equal. as a result of this process a travelling space charge accumulation is formed; then the dipole field reaches a stable condition & moves through the specimen towards anode.
- When high field domain disappears at anode a new dipole field starts forming at cathode & process is repeated.

- Note 3-1 A domain will start to form whenever the electric field in a region of the sample increases above threshold electric field and will drift with carrier stream through the device.
- ⇒ When electric field increases e^- drift velocity decreases & GaAs diode exhibits -ve resistance
 - 2. If additional voltage is applied to a device containing a domain the domain will increase in size and absorb more voltage than that was added.
 - 3. A domain will not disappear before reaching the anode unless the voltage is drop appreciably below threshold value (that is upto sustaining field E_s)

The fundamental freq. of operation: $f = \frac{v_d}{L}$

L - length of specimen

v_d - drift velocity of e^-

(95)

Mode of operation \Rightarrow

The conc. length product ($n_0 L$) along with the freq. determine the mode of operation.

1. Transit time domain mode

$$[fL = 10^7 \text{ cm/sec.}]$$

2. Delayed domain mode

$$[10^6 < fL < 10^7 \text{ cm/sec.}]$$

3. Quenched domain mode

$$[fL > 2 \times 10^7 \text{ cm/sec.}]$$

4. LSA mode (limited space charge accumulation mode)

$$[fL > 2 \times 10^7 \text{ cm/sec.}]$$

Transit Time \rightarrow

Time taken by the ~~diopole~~ to travel from cathode to anode.

OR

It is the time b/w formation of domain & absorption of the domain.

E_{th} range \rightarrow 2800 V/cm to 3000 V/cm

$$T = \tau$$

$$f_L = 10^7 \text{ cm/sec.}$$

(96)

DC
Biasing

E_{th}

E_s

$$T > \tau$$

$$10^6 < f_L < 10^7 \text{ cm/sec.}$$

E_{th}

E_s

$$f_L = 10^7 \text{ cm/sec.}$$

E_{th}

E_s

$$T < \tau$$

$$f_L > 2 \times 10^7 \text{ cm/sec.}$$

E_{th}

E_s

1. Transit time domain mode (Gunn mode / travelling domain mode) ⁴⁸

→ Time period of oscillation = Transit time

High field domain is stable.

Efficiency = 10%. (η)

This mode is of low power & low efficiency.

(97)

2. Delayed domain mode (Inhibited mode)

Transit time is chosen that when domain is collected applied field E is less than threshold field E_{th} \therefore a new domain can't form until the field rises again above threshold.

Efficiency = 20%. (η)

3. Quenched domain mode

In this mode biased field (applied field) dropped below sustaining field E_s during -ve half cycle so domain collapse before reaching the anode.

Efficiency = 13%. (η)

The operating field in this mode is higher than transit time mode or delayed domain mode.

4. LSA mode

In this mode, domain are not allowed to form. Field and amplitude of RF signal are so chosen that domain doesn't have sufficient time to form while the field is above threshold.

In this mode domain are kept in -ve conductance stage during max part of voltage cycle. Thus this mode give high power o/p & high efficiency.

Efficiency = 23%. (η)

Advantage of Gunn Diode

1. Gunn diode has lesser noise.

Disadvantage of Gunn Diode

• Gunn diode is very temp. sensitive. $[0.53 \text{ MHz}/^\circ\text{C}]$

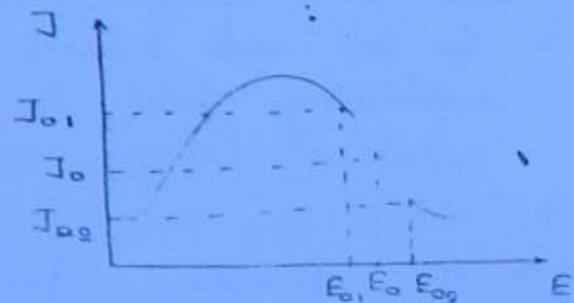
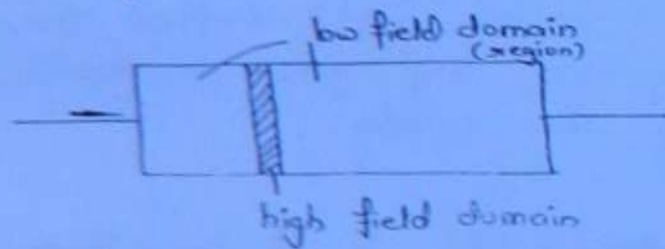
Differential -ve Resistance \Rightarrow

(98)

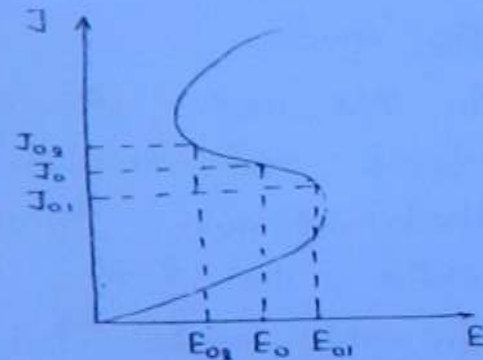
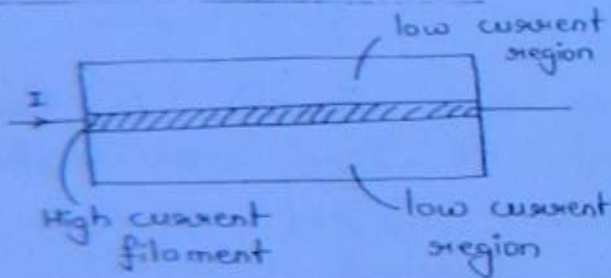
• The fundamental concept of RWA theory is differential -ve resistance developed in bulk solid state compound. There are two modes of -ve resistance device i.e. voltage controlled & current controlled mode.

• In voltage controlled mode current density can be multi valued whereas in current controlled mode voltage can be multi valued.

Voltage controlled mode



Current controlled mode



Que Typical n-type GaAs Gunn diode has the following parameters:- $E_{th} = 2000 \text{ V/cm}$

Applied ~~with~~ field $E = 3200 \text{ V/cm}$

device length $L = 10 \mu\text{m}$

doping conc. $n_0 = 2 \times 10^{14} \text{ cm}^{-3}$

$f = 10 \text{ GHz}$

A) Compute e^- drift velocity.

B) Calc current density

c) estimate -ve e^- mobility.

Solu: A) $J = \frac{V_d}{L}$

$V_d = J L$

$= 10 \times 10^9 \times 10 \times 10^{-6} = 10^5 \text{ m/sec.}$

$V_d = 10^7 \text{ cm/sec}$

If this product is 10^7 cm/sec. , then the given ckt is in transit time mode.

B) $J = \sigma E$

$J = nq\mu E$

$J = nqV_d$

$J = 2 \times 10^{14} \times 1.6 \times 10^{-19} \times 10^7$

$J = 320 \text{ A/cm}^2$

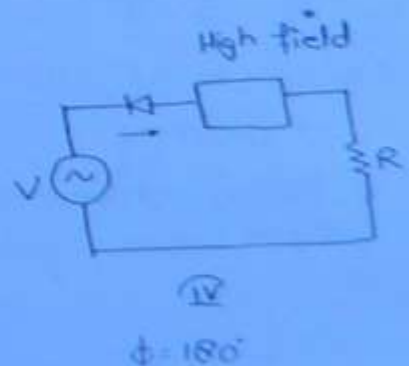
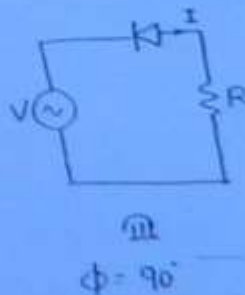
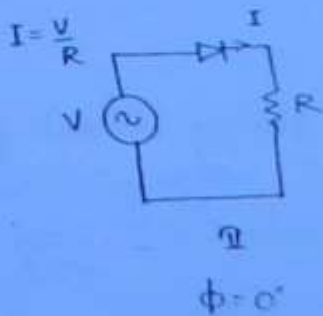
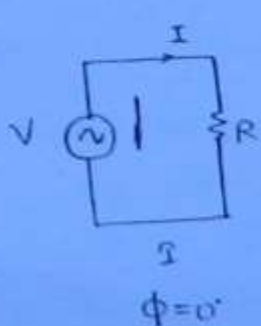
c) Since applied field $> E_{th}$ hence domain will form & e^- will jump from lower valley to upper valley hence, in -ve resistance region -

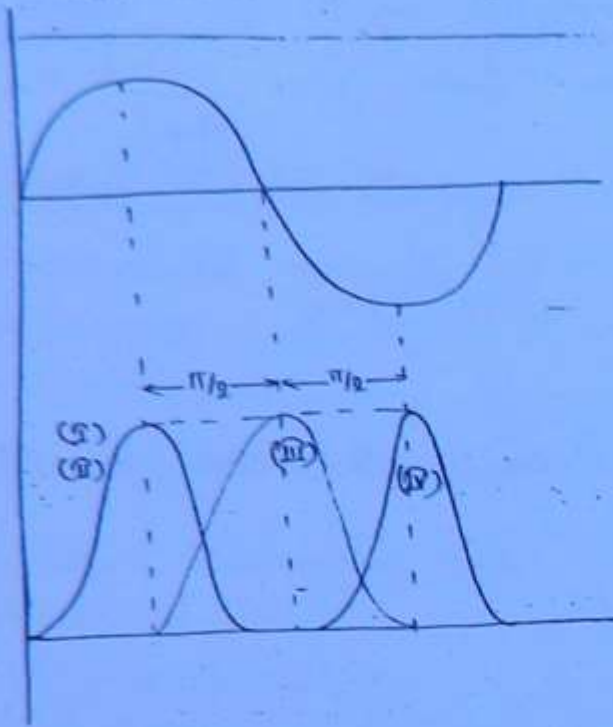
$V_d = -\mu_n E$

$-\mu_n = \frac{V_d}{E} = \frac{10^7}{3200}$

$\mu_n = \frac{-V_d}{E} = -3100 \text{ cm}^2/\text{V-sec.}$

Avalanche transit time device \Rightarrow





(100)

$$J = \sigma E$$

$$= nq\mu E$$

$$J = nq\mu E$$

- # Avalanche transit time diode osci. based on effect of voltage breakdown across a RB p-n-jn. to produce a supply of holes & e^- . Avalanche diode osci. uses carrier impact ionisation & drift in high field region of a SC-jn to produce a -ve resistance at microwave freq.

IMPATT

TRAPATT

- # Impact ionisation avalanche transit time operation

- # Trapped plasma avalanche triggered transit time operation

$$\eta = 5-10\%$$

$$\eta = 50-60\%$$

η = DC to AC conversion efficiency

Noisy device

Noisy device

Barrier injected transit time device

$\eta = 1.8\%$

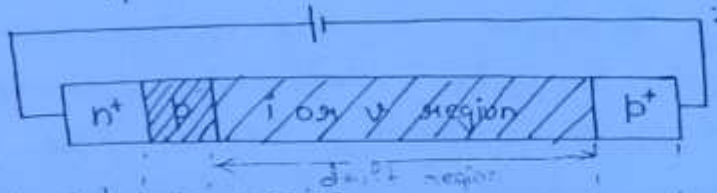
(10)

* (20 marks) [2007]
IMPATT Diode :-

→ READ Diode

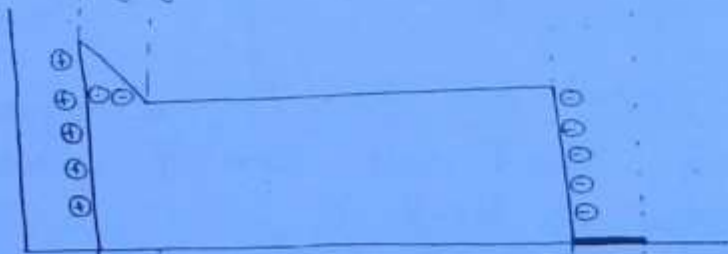
The basic operating principle of Impatt diode can be understood by reference to first proposed avalanche diode i.e. READ diode.

A mode of original READ diode will a doping profile & a DC electric field distribution that exists when a large RB applied across the diode is shown in the fig.



i - intrinsic region
n⁺, p⁺ - highly doped

field distribution



doping profile (cm⁻³)



The READ diode is an n⁺-p-i-p⁺ structure where the superscript + sign denotes very high doping & i or v refers intrinsic material.

1. The device consists of two regions -

1. thin p-region at which avalanche multiplication occurs - this region is also called high field region or avalanche region

3. i or v region through which generated holes must drift in moving to the p⁺ contact. - This region is also called intrinsic region or drift region. (102)

* Similar device can be built in p⁺-n-i-n⁺ structure in which es generated from avalanche multiplication drift through the i region.

Avalanche Multiplication ⇒

- * When the RB voltage is well above punch through voltage (Reach through voltage) the space charge region always extend from n⁺ p Jn - through p & i region to i-p⁺ Jn.
- * The max. field which occurs at n⁺p Jn. is very high (several 100 kV/cm) therefore carrier moving near the high field n⁺p Jn. gets sufficient energy to knock valence e⁻ into conduction band. thus producing ~~hole~~ hole pair. the e⁻ move into n⁺ region & hole drift through space charge region to p⁺ region with constant velocity v_d of above 10^7 cm/sec for Si.
- * The field throughout the space charge region is above about 5 kV/cm. Then transit time of a hole across the drift region of length 'L'.

$$\tau = \frac{L}{v_d} \Rightarrow \text{Transit time}$$

* Avalanche multiplication factor

$$M = \frac{1}{1 - (V/V_b)^n}$$

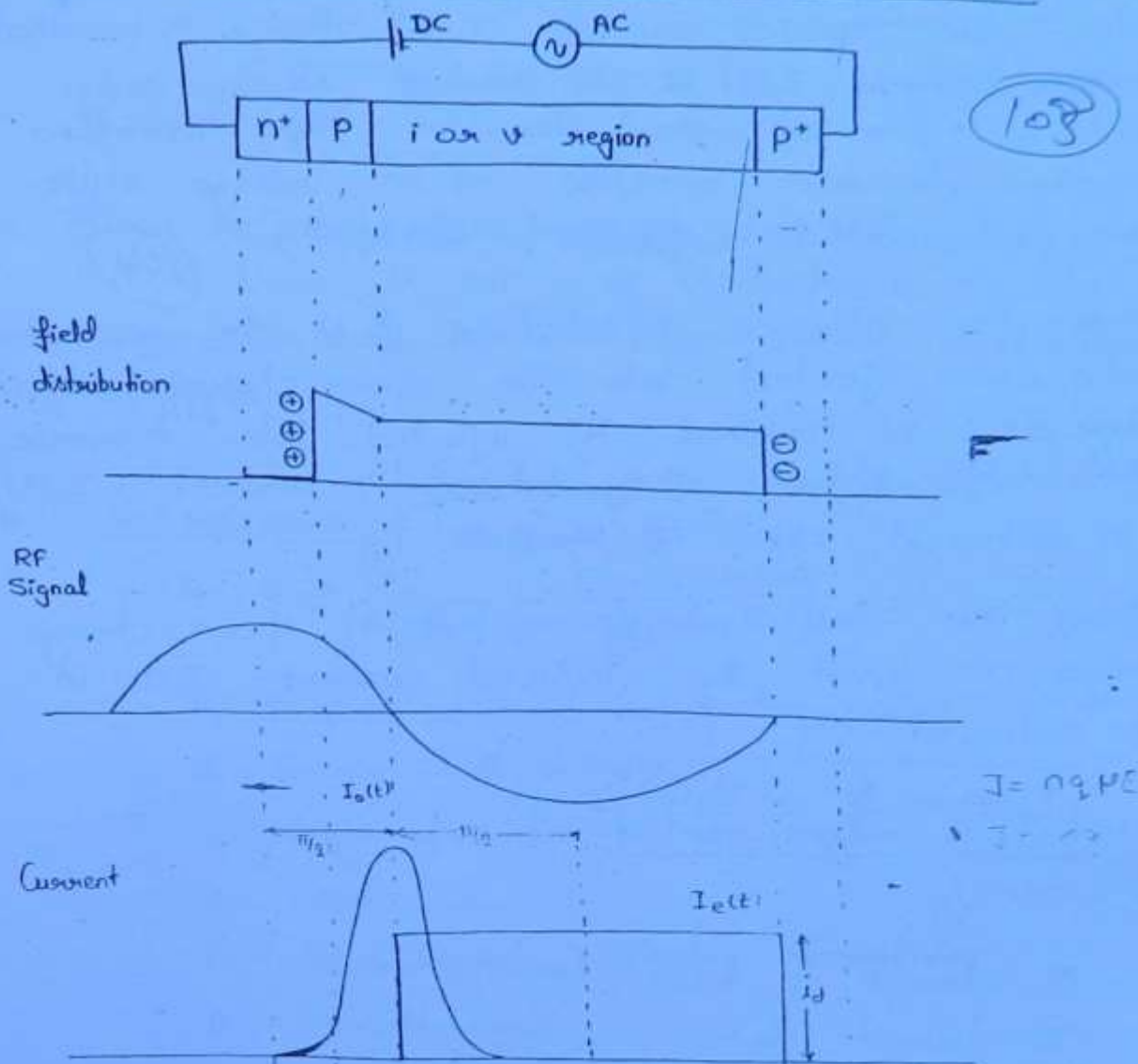
V → applied voltage

V_b → breakdown voltage (avalanche breakdown voltage)

n → 3-6 for Si

n is numerical no. depending on doping of p⁺n / n⁺p Jn

Carrier current $I_0(t)$ & External current $I_e(t) \rightarrow$ 103



The READ diode oscillator consists of n^+p structure diode biased in Reverse direction & mounted in a passive cavity. The impedance of cavity is mainly inductive & is matched to mainly capacitive impedance of diode to form a resonant ckt. an AC voltage can be maintain at a given freq. in the ckt. and total field across diode is sum of DC & AC field ~~is~~ this total field cause breakdown at n^+p In during +ve half of AC voltage cycle if the field is above breakdown voltage. Then carrier current (hole current $I_0(t)$) is generated at n^+p In. by avalanche multiplication grows exponentially with time while the field is above critical value.

- During -ve half when the field is below critical value the carrier current $I_0(t)$ decays exponentially. Carrier current $I_0(t)$ is the current at -ve only and is a pulse of short duration. Hence therefore $I_0(t)$ reaches its max in middle of ac voltage cycle. i.e. phase diff b/w ~~carrier~~ $I_0(t)$ & I_b . (04)

- Under the influence of electric field the generated holes are injected into the space charge region towards -ve terminal. As injected hole traverse the drift space they induced a current $I_e(t)$ in external ckt as shown in fig.

- Since the drift velocity of holes in space charge region is const the induced current $I_e(t)$ in the external ckt is -

$$I_e(t) = \frac{Q}{\tau} = \frac{V_d Q}{L}$$

$$\tau = \frac{L}{V_d}$$

Q - charge of holes (moving holes)

τ - transit time

V_d - hole drift velocity

L - length of drift region

- The induced current $I_e(t)$ is equal to avg current in space charge region when pulse of hole current $I_0(t)$ is suddenly generated at n-p region, a const current $I_e(t)$ starts flowing in external ckt & continues to flow during time τ in which holes are moving across the space charge region. Thus an avg. external current $I_e(t)$ b/w of moving holes is delayed by $\tau/2$ or 90° relative to $I_0(t)$. External current $I_e(t)$ is delayed by 180° relative to ac voltage & resonant freq of cavity is given by -

$$\omega = \frac{1}{2\tau}$$

$$\omega = 2\pi f = \pi/\tau$$

$$\tau = L/v_d$$

$$\frac{d}{f} = \frac{V_d}{\omega L} = \frac{1}{\omega \tau}$$

(105)

- * Since the applied AC voltage and external circuit are out of phase by 180° -ve conductance occurs and READ diode can be used for passive oscillation & amplification.

- * -ve resistance [from small sig analysis of READ diode.] 3 March 2012

$$R = R_s + \frac{\omega L^2}{V_d E_s A} \frac{1}{1 - \omega^2/\omega_a^2} \frac{1 - \cos \theta}{\theta}$$

R_s = Passive resistance of inactive region

V_d = Carrier drift velocity

L = length of depletion charge region

A = Diode cross section

E_s = Semiconductor intrinsic permittivity

θ = transit angle

$$\theta = \omega \tau = \frac{\omega L}{V_d}$$

ω_a = avalanche resonant freq

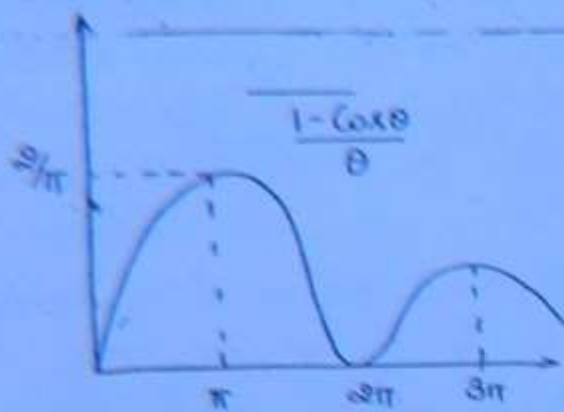
$$\omega_a = \left[\frac{2\alpha' V_d I_0}{E_s A} \right]^{1/2}$$

α' = derivative of ionisation coefficient w.r.t electric field

α' = no. of ionisation/cm produced by a single carrier

~~Small sig~~

Small sig analysis of read diode results in given expression for real part of impedance.



(106)

By varying transit angle

- Que An IMPATT diode has the following parameters
- | | |
|------------------------|--------------------------------------|
| carrier drift velocity | $V_d = 2 \times 10^7 \text{ cm/sec}$ |
| drift region length | $L = 6 \text{ Nm}$ |
| max operating voltage | $V_{\text{max}} = 100 \text{ V}$ |
| max operating current | $I_{\text{max}} = 200 \text{ mA}$ |
| Efficiency | $\eta = 15\%$ |
| Breakdown voltage | $V_{\text{bd}} = 90 \text{ V}$ |
- A) Compute max. continuous wave o/p power in watt
 B) Resonant freq in GHz.

Solu.

$$\eta = \frac{P_{\text{out}}}{P_{\text{dc}}}$$

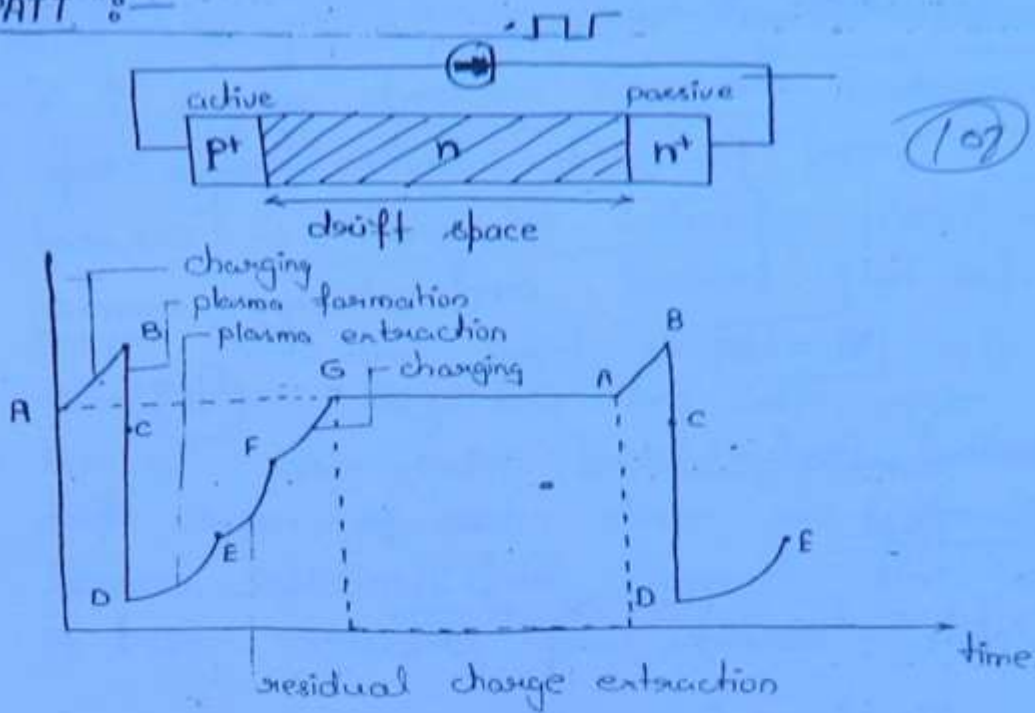
$$P_{\text{out}} = \eta P_{\text{dc}} = 0.15 \times V_{\text{max}} \times I_{\text{max}}$$

$$= 0.15 \times 100 \times 200 \times 10^{-3}$$

$$P_{\text{out}} = 3 \text{ W}$$

$$f = \frac{V_d}{2L} = \frac{2 \times 10^5}{2 \times 6 \times 10^{-6}} = 16.67 \text{ GHz}$$

It is very noisy due to avalanche multiplication process.



At point A current is turned on and the electric field is uniform throughout the sample but less than avalanche breakdown voltage. Since the only charge carriers are ~~present~~ due to thermal generation. The diode charge like a linear capacitor & AB portion of the curve shows the electric field above breakdown voltage.

When sufficient no. of charge carriers are generated electric field is depressed throughout the depletion layer causing voltage to \downarrow from B to C. During this time interval

dense plasma of e^- & holes in depletion $\&$ layer. therefore field is further depressed & voltage drop from C to D.

A long time is required to remove the plasma. At point E plasma is removed but residual charge of e^- remaining on one end of depletion layer.

& residual charge of hole on the other end.

As the residual charge is removed voltage \uparrow from E to F. From F to G diode charge up again like a fixed capacitor. At point G current goes to zero for half period and voltage remain constant that is $V_G = V_A$ (108).

Mathematical Analysis :-

Electric field

$$E(x, t) = E_m - \frac{qNa}{\epsilon_s} x + \frac{It}{\epsilon_s}$$

if $E(x, t) = E_m$

$$\frac{qNa}{\epsilon_s} x = \frac{It}{\epsilon_s} \Rightarrow t = \frac{qNa}{I} x$$

diff w.r.t 't'

Ans $\left[V_z = \frac{dx}{dt} = \frac{I}{qNa} \right]$

Avalanche zone velocity.

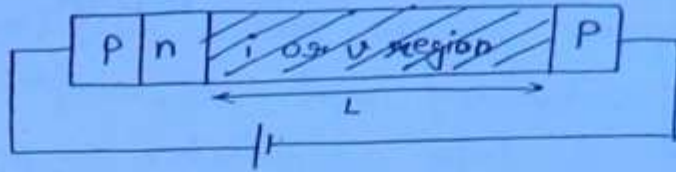
Avalanche zone quickly sweep across most of diode leaving diode ~~field~~ filled by a highly conducting plasma of holes & es. Whose space charge depressed the voltage to low value.

Plz of dependence of drift velocity on the field (since $v_d = \mu E$) e^- & holes will drift at velocity determined by low field & transit time of carrier become much larger.

Delay of carrier in transit (time b/w injection & collection) is utilized to obtain a current phase shift favourable for oscillation.

* It is very noisy due to avalanche multiplication process.

BARITT :- (Barrier Injected transit time device) 5.



* BARITT diodes are latest addition to family of active μ wave diode. they have long drift region similar to those of IMPATT diodes. however carriers traversing the drift region of BARITT diode are generated by minority carrier injection. from forward bias junction is instead of being extracted from plasma of an avalanche region

~~for~~

* Different structure of BARITT diode -

1. P-n-p
2. p-n-v-p
3. p-n-metal
4. metal-n-metal

* For p-n-v-p BARITT diode FB p_n J_n emit holes into v-region. These holes drift with saturation velocity ($v_s = v_d$) through the v-region and are collected at P contact.

* The diode exhibits a -ve resistance b/w π & 3π .

* Optimum transit angle is $1.6 \cdot \pi$

* These are much less noisy than IMPATT & TRAPATT diode as no avalanche multiplication involved.

Major disadvantages are relatively narrow BW and power ϕ limited to few mWatt.

BARITT are primarily used for amplification rather than for oscillation b/c of their lower efficiency.

mathematical analysis

critical voltage at which punch through occurs.

$$V_c = \frac{qNL^2}{2\epsilon_s}$$

Breakdown voltage

$$V_{bd} = 2V_c = \frac{qNL^2}{\epsilon_s}$$

breakdown electric field

$$E_{bd} = \frac{V_{bd}}{L} = \frac{qNL}{\epsilon_s}$$

(110)

Que. Typical Si BARITT diode has the following specification

relative dielectric constt. $\epsilon_{r1} = 12.5$

donor conc.

$$N_D = 3.2 \times 10^{22} / m^3$$

length

$$L = 8 \text{ mm}$$

find critical voltage, breakdown voltage & breakdown electric field

Sol.

$$V_c = \frac{qNL^2}{2\epsilon_s}$$

$$= \frac{1.6 \times 10^{-19} \times 3.2 \times 10^{22} \times (8 \times 10^{-6})^2}{2 \times 12.5 \times 12.5 \times 8.85 \times 10^{-12}}$$

$$V_c = 1.48 \text{ kV}$$

$$V_{bd} = 2V_c = 2.96 \text{ kV}$$

$$E_{bd} = \frac{V_{bd}}{L} = \frac{2.96}{8 \times 10^{-6}}$$

$$= 3.7 \times 10^8 \text{ V/m}$$

PARAMETRIC AMPLIFIER :-

35.

It is one that uses a non-linear reactance (capacitance or inductance) or a time varying reactance. Word parametric is derived from the term parametric excitation. Since capacitance or inductance which is a reactive parameter can be used to produce capacitive or inductive excitation.

Parametric excitation can be subdivided into-

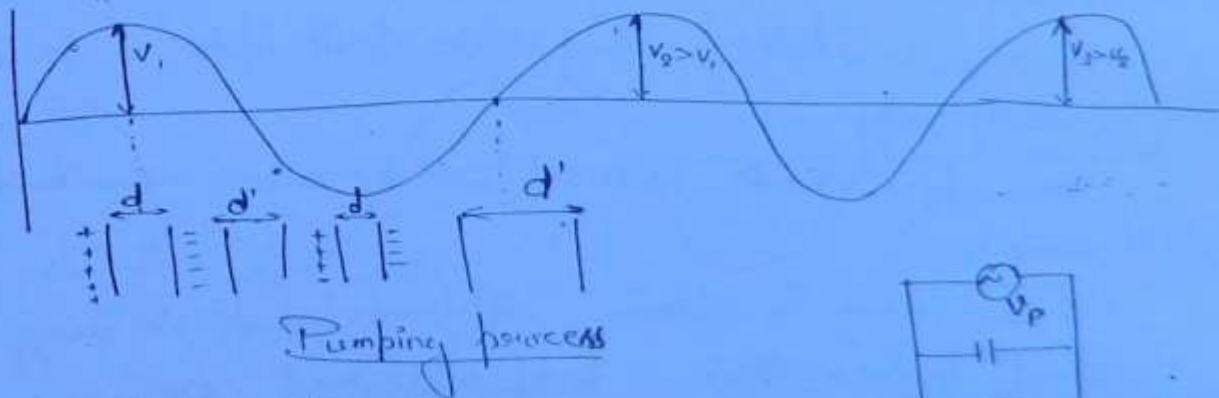
(1/1)

Parametric amplification & oscillations.

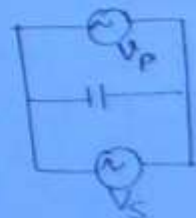
Unlike the microwave tubes, transistors & lasers, parametric diode is of a ~~set~~ reactive

One of the distinguishing feature of the a parametric ampⁿ is that it utilizes an A.C. whether than a dc power supply as microwave tubes do. In this respect it is similar to quantum ampⁿ laser & maser, in which an AC power supply is used.

At present solid state rectifier varactor diode is most widely used parametric ampⁿ.



pump freq. $f_p = 2f_s$



Parametric device basically depends on possibility of ~~ing~~ energy of the signal at one freq.

By supplying energy at some other freq. (112)

To obtain ~~not~~ amplification, cap. plates are pulled apart when the charge & voltage are at max. b/c a electric field b/w the plates, it requires an expenditure of energy to pull the

plate $C = \frac{\epsilon_0 A}{d}$, energy = $\frac{1}{2} CV^2$
 $V = Q/C$

$$E = \frac{1}{2} \frac{Q^2}{C}$$

at zero voltage plate of cap. brought back to their original with each signal

\therefore electrical energy on cap. goes on to ring with successive cycle if the plates are separated each time by same extent amplitude of voltage would twice upto infinity - however as amplitude \uparrow it requires more & more force to separate the plate. \therefore at ultimately force required would also be infinity. With only finite force available amplitude built upto a finite value only.

Varactor diode is most widely used in active amp^s.

Amplification is obtain if reactance is vary at some freq. higher than freq. of signal being amplifying.
($f_p > f_s$)

Parametric Amplifier :-

35

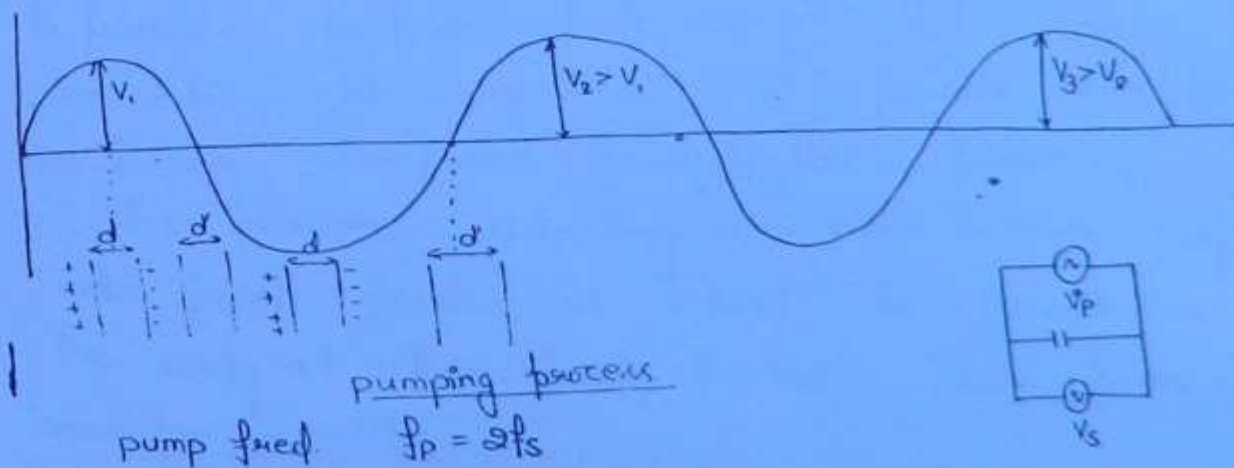
It is one that uses a non-linear reactance (capacitance or inductance) or a time varying reactance. Word - parametric is derived from the term parametric excitation. Since capacitance or inductance which is a reactive parameter can be used to produce capacitive or inductive excitation. (1/2)

Parametric excitation can be subdivided into -
Parametric amplification & oscillations.

Unlike the μ wave tubes, transistors & lasers, parametric diode is a reactive nature & thus generates a very small amount of Johnson noise (thermal noise).

One of the distinguishing feature of the parametric ampⁿ is that it utilizes an AC whether than a DC power supply as μ wave tubes do. In this respect it is similar to quantum ampⁿ laser & maser in which an AC power supply is used.

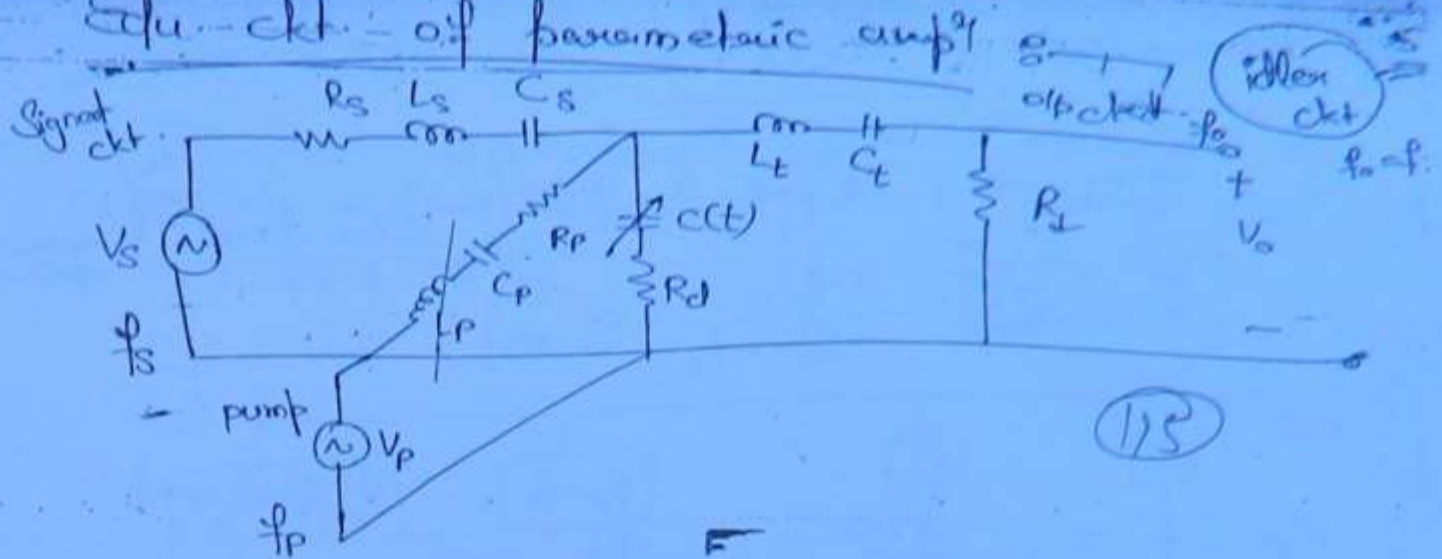
At present solid state varactor diode is most widely used parametric ampⁿ.



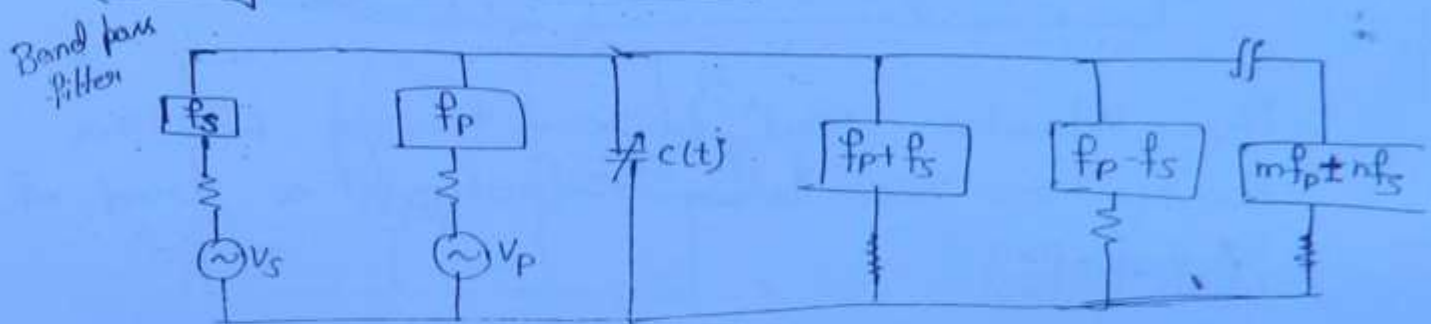
Parametric device basically depends on possibility of increasing the energy of the signal at one freq.

114

Sch. ckt. of parametric amp^r



Manley & Rowe relation

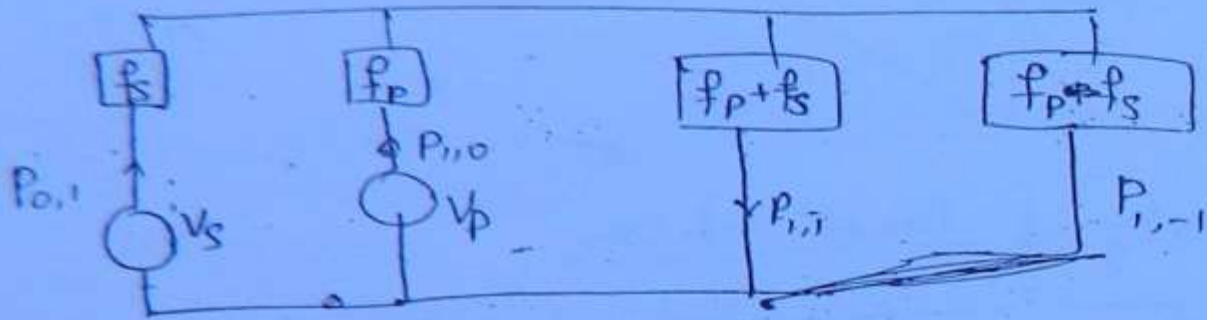


Manley and Rowe designed a set of general energy relation regarding power flow into & out of them non-linear reactance. These relations are useful in predicting ~~whether~~ whether power gain is possible in parametric amp^r, let each resonating ckt are ideal. \therefore power loss by non-linear reactance is negligible. \therefore P.E power entering a non-linear cap. at pump freq. is equal to power leaving the cap. at other freq, through non-linear interaction.

Manley & Rowe establish a power relation b/w f_p power at f_{mod} & f_s & f_p & f_o power at other frequencies. i.e. $m f_p \pm n f_s$

where m & n are integers from 0 to ∞ .

$$\left. \begin{aligned} \sum_{m=0}^{\infty} \sum_{n=0}^{\infty} \frac{m P_{m,n}}{m f_p + n f_s} &= 0 \quad \text{--- (1)} \\ \sum_{m=0}^{\infty} \sum_{n=0}^{\infty} \frac{n P_{m,n}}{m f_p + n f_s} &= 0 \quad \text{--- (2)} \end{aligned} \right\} \text{Standard forms} \quad \text{--- (116)}$$



$P_{m,n}$ indicates real power flowing into or leaving the non-linear capacitor at a freq. of $(m f_p + n f_s)$

Sign convention for $P_{m,n}$

1. Power flowing into non-linear capacitor or power coming from two voltage generators (V_s, V_p) is +ve.
2. Power leaving the non-linear cap. or power flowing into load resistance is -ve. For example, let power o/p is at freq. $(f_p + f_s)$ only. then signal exists at three freq. i.e. f_p, f_s & $(f_p + f_s)$. then from eqn (1).

$$\frac{P_{p,0}}{f_p} + \frac{P_{p,1}}{f_p + f_s} = 0 \quad \text{--- (3)}$$

Similarly from eqn (2)

$$\frac{P_{p,1}}{f_p} + \frac{P_{p,-1}}{f_p - f_s} = 0 \quad \text{--- (4)}$$

Power Gain

57

It is defined as ratio of power delivered by cap. at a fixed. $(f_p + f_s)$ to that absorb by cap. at fixed. f_s .

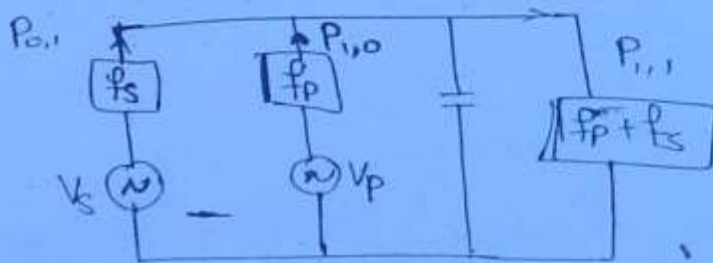
(117)

$$P_{o,1} = +ve$$

$$P_{i,1} = -ve$$

from eqn. (4)

$$\text{power gain} = \frac{P_{i,1}}{P_{o,1}} = \frac{f_p + f_s}{f_s}$$



$$f_o = \text{O/p freq.} = f_p + f_s$$

$$f_o > f_p > f_s$$

ckt is called as up converter.

Also called as modulator.

If the sig. freq. is the sum of pump freq. f_p O/p freq. then from eqn. (4)

$$f_s = f_p + f_o$$

$$\text{Gain} = \frac{f_s}{f_p + f_s} < 1$$

~~It is actually less~~ "actually it is less"

$$f_o = f_s - f_p$$

$f_o < f_s$ \therefore It is called down converter. Demodulator.

Q. 3

If $f_p = f_o + f_s$ then power supplied at f_p

(P_{i,o})

(118)

is ~~positive~~ ^{+ve} & both P_{i,o} & P_{o,i} are -ve
in other words cap. delivers the power to
signal generator at f_s . instead of absorbing
it. Power gain may be infinite which is an
unstable condⁿ. and ckt. may be oscillating
at both f_s & f_o . this type of device is called
-ve resistance parametric ampl.

Parametric up converter →

It has following properties -

1. $f_o = f_s + f_p$

$f_o > f_p > f_s$

(119)

2. there is no power flow in parametric device at freq. other than signal, pump & up freq.

a) Power gain = $\frac{f_o}{f_s} \times \frac{x}{[1 + \sqrt{1+x}]^2}$

$\frac{x}{[1 + \sqrt{1+x}]^2} = \text{Gain degradation factor}$

$x = \frac{f_s}{f_o} [YQ]^2$

$Q = \frac{1}{2\pi f_s C R_d}$

 R_d = series resistance of p-n Jⁿ diode YQ = figure of merit for non-linear capacitanceideally - $R_d = 0$ $YQ = \infty$ degradation factor = 1

$$\text{Gain} = \frac{f_o}{f_s} = \frac{f_p + f_s}{f_s}$$

practically

$YQ = 10 \quad \frac{f_o}{f_s} = 15$

max gain = 7.3 dB

b) Noise figure

$$F = 1 + \frac{2T_d}{T_o} \left[\frac{1}{YQ} + \frac{1}{(YQ)^2} \right]$$

 T_d - diode temp. T_o - ambient temp.

$$F = 0.90 \text{ dB}$$

$$\text{if } Y_0 = 10$$

which is far less than 3 to 4 dB of TW. (120)

c) Band width

$$BW = 2Y \sqrt{\frac{f_0}{f_s}}$$

* Solved numerical from Liao

$$\text{eg } \frac{f_0}{f_s} = 10 \quad Y = 0.2$$

$$BW = 1.264 \quad \text{Wide Band parametric amp}^{\text{st}}$$

Parametric down converter \rightarrow

$$f_s = f_p + f_0$$

$$f_0 < f_s$$

$$f_p < f_s$$

there is loss

$$\text{Gain} = \frac{f_s}{f_0} \times \frac{x}{[1 + \sqrt{1+x}]^2}$$

* Idler Ckt \Rightarrow o/p ckt. which does not require external excitation is called idler ckt. $[f_0 = f_i]$

The i/p power must feed resonance in Idler ckt. &
& o/p power must move out from the signal ckt.

-ve Resistance parametric ampst

$$f_p = f_0 + f_s$$

$$f_0 = f_i = f_p - f_s$$

f_i - idler freq.

If significant power flows only at f_s , f_p & f_i , degenerative

condⁿ with the possibility of oscillation at both the 59 signal & idler freq will occur.

When the mode operate below oscillation threshold, the device behaves as a -ve resistance parametric amp^r.

$$f_p = f_s + f_i$$

$$2f_s = f_s + f_i$$

$$f_i = f_s$$

(12)

a) Power Gain

$$G = \frac{4f_i}{f_s} \cdot \frac{R_g R_i}{R_{T_s} R_{T_i}} \cdot \frac{a}{[1-a]^2}$$

R_g = o/p resistance of signal generation

R_i = o/p resistance of idler generation

R_{T_s} = Total series resistance at f_s

R_{T_i} = total series resistance at f_i

$$a = \frac{R}{R_{T_s}}$$

$$R = \frac{Y^2}{\omega_s \omega_i C^2 R_{T_i}} = -ve \text{ resistance}$$

b) Bandwidth

$$BW = \frac{Y}{2} \sqrt{\frac{f_i}{f_s (\text{gain})}}$$

Ex

$$\text{gain} = 20 \text{ dB}$$

$$f_i = 4f_s$$

$$Y = 0.3$$

$$BW = 0.03 \% \text{ of centre freq.}$$

Narrow Band Parametric amp^r.

c) Noise fig $F = \text{same as PUC}$

$$F = \left[1 + \frac{2T_0}{T_0} \left[\frac{1}{\gamma\omega} + \frac{1}{(\gamma\omega)^2} \right] \right]$$

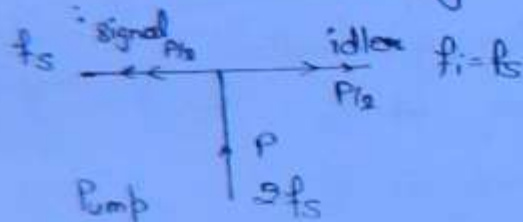
Degenerate Parametric Ampⁿ →

Degenerate parametric ampⁿ or oscillator is defined as a -ve resistance ampⁿ with signal freq. f_s is equal to idler freq. f_i .

$$\text{i.e. } f_s = f_i$$

$$f_p = f_s + f_i = 2f_s$$

- If $f_p \neq 2f_s$ then this is called non-degenerative parametric ampⁿ.
- With $f_s = f_i$ & $f_p = 2f_s$ power transfer from pump to idler is equal to power transfer from pump to signal so at this condⁿ gain is 3dB.



Noise Figure

$$F_{SSB} = 2 + \frac{2 T_d R_d}{T_o R_g}$$

Single Sideband

R_g - resistance for generator.

$$F_{DSB} = 1 + \frac{T_d R_d}{T_o R_g}$$

Double Sideband

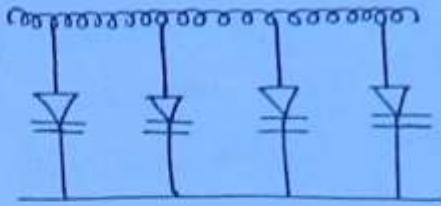
$$F_{OSB} = F_{SSB} - 3\text{dB}$$

Ex

1 Broad Band Parametric Ampⁿ →

Parametric ampⁿ has narrow BW. To provide bandwidth as large as 50% of centre freq. we use travelling wave tube structure for parametric ampⁿ. The typical TWT

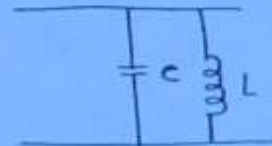
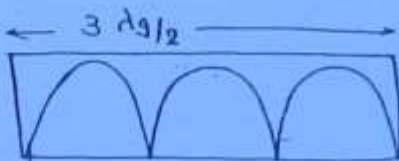
parametric amp^{or} employ a multi stage & LPF with suitable shunt varactor diode.



(123)

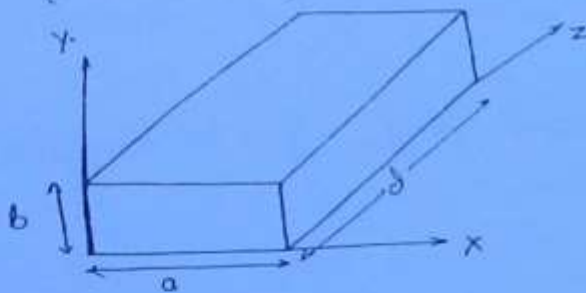
By employing circulator fixed stability, noise figure & o/p power can be improved.

CAVITY RESONATOR :-



$$f_0 = \frac{1}{2\pi\sqrt{LC}}$$

rectangular waves guide →



resonant freq. (f_0)

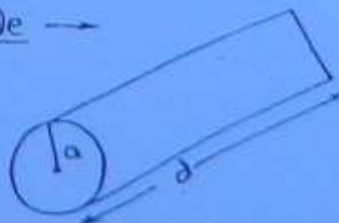
$$f_0 = \frac{c}{2} \left[\left(\frac{m}{a} \right)^2 + \left(\frac{n}{b} \right)^2 + \left(\frac{p}{d} \right)^2 \right]^{1/2}$$

TE_{mnp} or TM_{mnp}

$$c = \frac{1}{\sqrt{\mu\epsilon}}$$

$$\Rightarrow c = \frac{1}{\sqrt{\mu_0\epsilon_0}}$$

circular waveguide →



i) TM_{mnp} - mode

$$f_0 = \frac{1}{2\pi\sqrt{\mu\epsilon}} \left[\left(\frac{P_{nm}}{a} \right)^2 + \left(\frac{P_{\Pi}}{d} \right)^2 \right]^{1/2}$$

$$f_0 = \frac{c}{2\pi} \left[\left(\frac{P_{nm}}{a} \right)^2 + \left(\frac{P_{\pi}}{d} \right)^2 \right]^{1/2}$$

(124)

- $n = 0, 1, 2, 3, \dots$ = No. of full cycle variation in ϕ direction.
 $m = 1, 2, 3, 4, \dots$ = No. of full cycle variation in radial dir.
 $p = 1, 2, 3, 4, \dots$ = No. of half cycle variation in axial dir.

ii) TE_{mnp}-mode

$$f_0 = \frac{c}{2\pi} \left[\left(\frac{P_{nm}}{a} \right)^2 + \left(\frac{P_{\pi}}{d} \right)^2 \right]^{1/2}$$

dominant-mode

rectangular cavity resonator

TE₁₀₁ TM₁₁₁ :

circular cavity resonator

TM₁₁₀ for $2a > d$

TE₁₁₁ for $d \geq 2a$

Que Calc the lowest resonant freq of a rectangular cavity resonator of dimension -

$a = 2 \text{ cm}$

$d = 3 \text{ cm}$

$b = 1 \text{ cm}$

Soln

$$f_0 = \frac{c}{2} \left[\left(\frac{m}{a} \right)^2 + \left(\frac{n}{b} \right)^2 + \left(\frac{p}{d} \right)^2 \right]^{1/2}$$

$$= \frac{3 \times 10^{10}}{2} \left[\left(\frac{1}{2} \right)^2 + \left(\frac{0}{1} \right)^2 + \left(\frac{1}{3} \right)^2 \right]^{1/2}$$

$$= \frac{3 \times 10^{10}}{2} \left[\frac{1}{4} + \frac{1}{9} \right]^{1/2}$$

$$= \frac{3 \times 10^{10}}{2} \times$$

$$f_0 = 9 \text{ GHz}$$

Quality factor of cavity resonator →

$$Q_o = 2\pi \frac{\text{max. energy stored / cycle}}{\text{energy dissipated / cycle}}$$

(125)

$$Q_o = \frac{\text{volume of cavity that stores energy}}{\text{volume of metal that determines energy dissipated}}$$

$$Q_o = \frac{\text{volume of cavity}}{\text{Skin depth } (\delta) \times \text{surface area of cavity}}$$

$$\delta = \text{Skin depth} = \frac{1}{\sqrt{\pi f \mu \sigma}}$$

$$Q_o = \frac{\text{cross sectional area of cavity}}{\delta \times \text{periphery of cavity}}$$

Q_o = Quality factor of unloaded cavity

Q_L = Quality factor of loaded cavity

Q_{ex} = Quality factor due to external ohmic losses

$$\frac{1}{Q_L} = \frac{1}{Q_o} + \frac{1}{Q_{ex}}$$

$$Q_{ex} = \frac{Q_o}{K}$$

K - coupling factor
or
coupling coefficient

Critically coupled cavity resonator

$$K = 1 \quad Q_{ex} = Q_o$$

$$\frac{1}{Q_L} = \frac{1}{Q_o} + \frac{1}{Q_o}$$

$$Q_L = \frac{Q_o}{2} = \frac{Q_{ex}}{2}$$

under coupled cavity resonator

Cavity terminals are at voltage min.

K - coupling factor < 1

$$K = \frac{1}{\rho} \quad \boxed{\rho = \text{VSWR} \geq 1}$$

(126)

$$Q_{\text{ext}} = \frac{Q_0}{\frac{1}{\rho}} = Q_0 \rho$$

$$\frac{1}{Q} = \frac{1}{Q_0} + \frac{1}{Q_{\text{ext}}} = \frac{1}{Q_0} + \frac{1}{\rho Q_0}$$

Imp $\boxed{Q_L = \frac{\rho}{1+\rho} Q_0}$

over coupled cavity resonator

cavity terminals are at voltage max.

$$K \geq 1$$

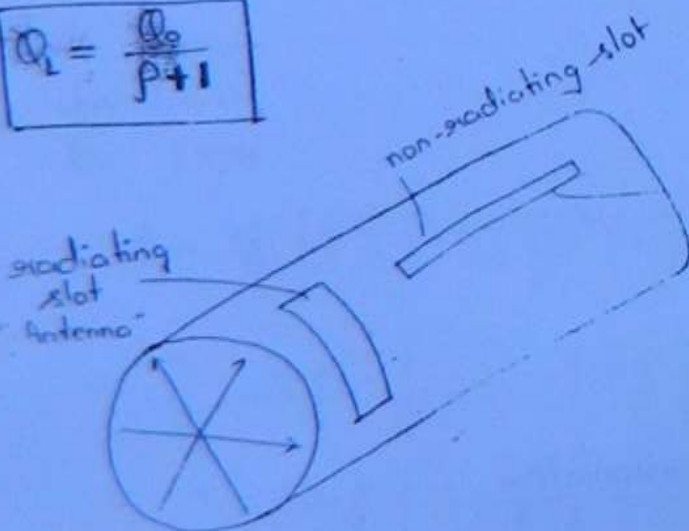
$$K = \rho$$

$$\rho = \text{VSWR}$$

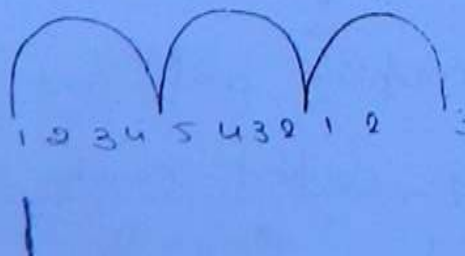
$$Q_{\text{ext}} = \frac{Q_0}{K} = Q_0 / \rho$$

$$\frac{1}{Q_L} = \frac{1}{Q_0} + \frac{1}{Q_{\text{ext}}} = \frac{1}{Q_0} + \frac{\rho}{Q_0}$$

$$\boxed{Q_L = \frac{Q_0}{\rho+1}}$$

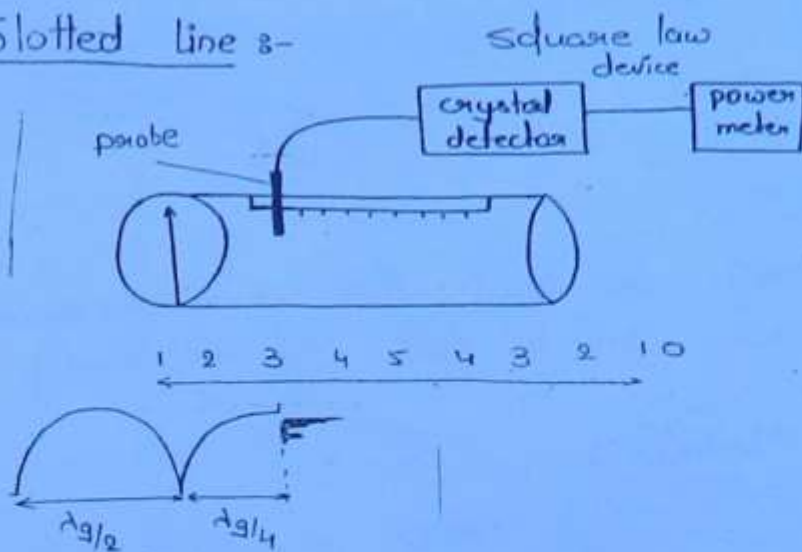


- measurement



* Microwave Measurement →

Slotted line :-



(127)

$$\frac{P_{max}}{P_{min}} = \frac{V_{max}^2}{V_{min}^2}$$

$$VSWR = \frac{V_{max}}{V_{min}} = \sqrt{\frac{P_{max}}{P_{min}}}$$

It is used to measure SWR (standing wave ratio) for dominant mode travelling inside the waveguide. Slot doesn't radiate any power. A small probe in ckt. through the slot sense relative field strength of standing wave pattern inside the waveguide. The probe is connected to a crystal detector so that o/p of detector is proportional to square of i/p voltage at that position of probe. As the position of probe is move along the waveguide slot it gives the o/p voltage proportional to standing wave pattern inside the waveguide. The ratio of max. o/p to min. o/p gives VSWR.

Slotted line will have same char. impedance as the main line.

Its length is slightly greater than half the wavelength of lowest freq. operation.

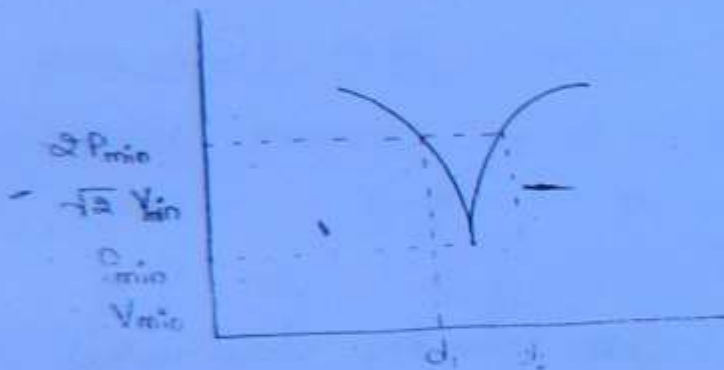
VSWR Meter :-

(a) for VSWR < 10

VSWR meter can't be used for measurement of VSWR greater than 10 due to loss of accuracy.

(b) Double Minimum Method :-

for VSWR > 10 (high VSWR)



$$VSWR = \frac{d_g}{\pi [d_2 - d_1]}$$

$$d_g = \frac{\lambda_0}{\sqrt{1 - (\lambda_0/\lambda_c)^2}}$$

Que. Calc. SWR of a transmission system operating at 10 GHz. assume TE_{10} wave transmission inside a waveguide of dimension $a = 4 \text{ cm}$, $b = 2.5 \text{ cm}$, next distance measured b/w twice min. power point is 1 mm on a slotted line.

Solu. $d_2 - d_1 = 1 \text{ mm} = 0.1 \text{ cm}$.

$$\lambda_0 = \frac{c}{f} = \frac{3 \times 10^{10}}{10 \times 10^9} = 3 \text{ cm}$$

$$\text{For } TE_{10} \quad \lambda_c = 2a = 8 \text{ cm}$$

$$d_g = \frac{3}{\sqrt{1 - (3/8)^2}} = 3.236$$

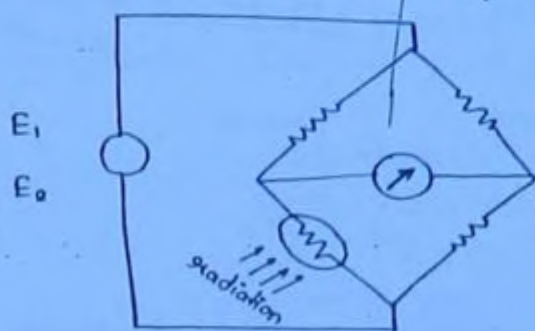
$$VSWR = \frac{3.236}{\pi \times 0.1 \text{ cm}} = 10.30$$

Measurement of Power :-

1. Low power measurement

[0.01 mW - 10 mW]

[Bolometer Technique]



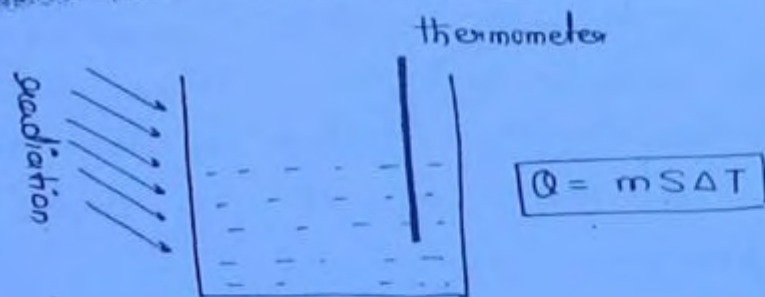
(129)

Bolometer is a simple temp. sensitive device whose resistance is fun. of temp. it consist of Bolometer (+ve temp. coefficient of resistivity) or thermister (-ve temp. coefficient).

Bolometer is a square law device when μ wave fall on bolometer its resistance vary which unbalance the bridge to reach ~~to reach~~ ^{balance} balance bridge supply is vary. So μ wave power is proportional to $(E_1 - E_2)$.

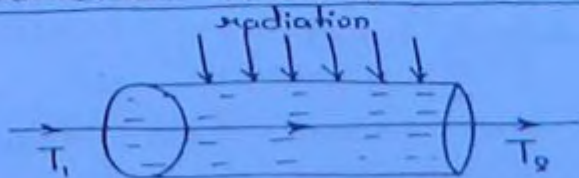
2. For medium power [10 mW to 10 watt]

[Calorimetric Technique]



3. High power [10 watt to 50 kWatt]

[Calorimetric Wattmeter Technique] (Flow meter)



$$P = \frac{RKP(T_2 - T_1)}{4.18}$$

R - rate of flow cm^3/sec .

K - specific heat cal/gm .

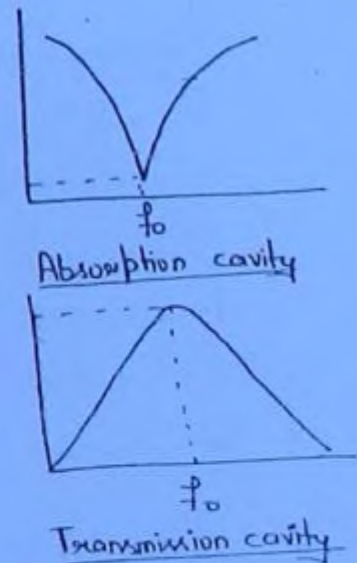
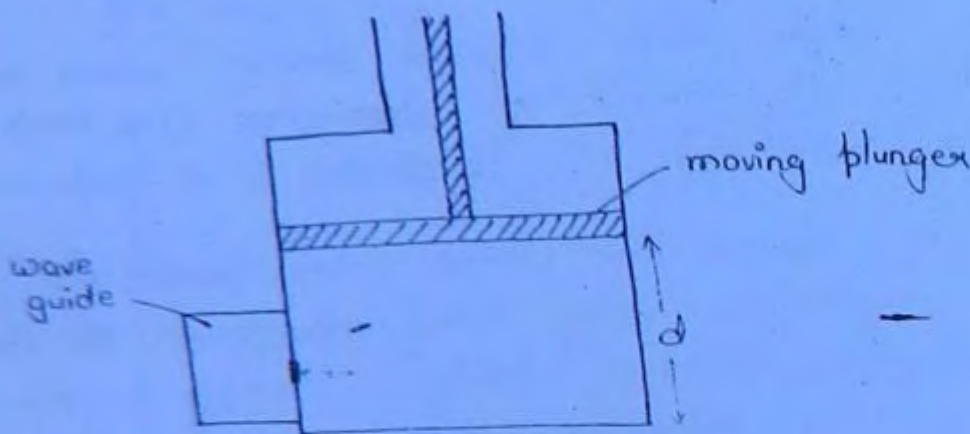
p - specific gravity gm/cm^3

P - power measured in watt

130

Measurement of freq. :-

Cavity Wave Meter \Rightarrow



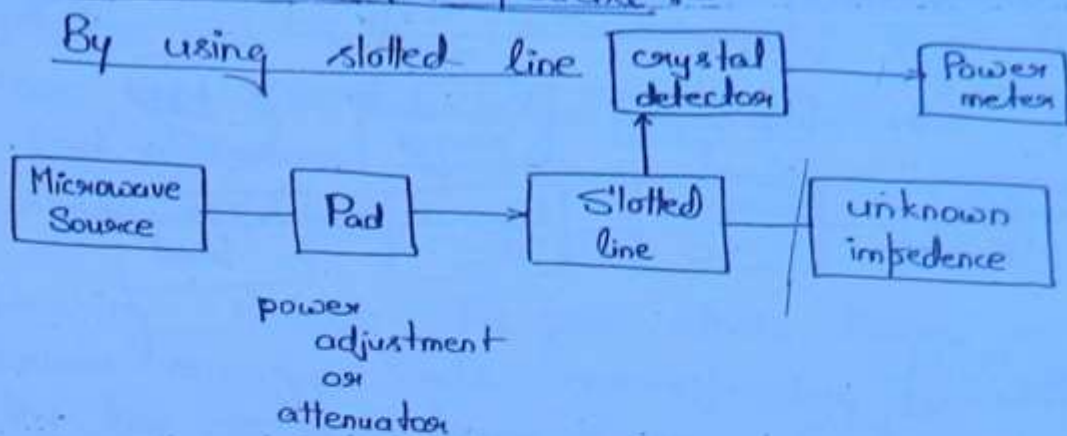
$$f_0 = \frac{c}{\lambda} \sqrt{\left(\frac{m}{a}\right)^2 + \left(\frac{n}{b}\right)^2 + \left(\frac{p}{d}\right)^2}$$

Dominant mode TM_{010} is normally used in wave meter. have a higher quality factor. The quality factor of 1000 to 5000 result in accuracy as much as 1% to 0.005%.

These are of two types -

1. Transmission cavity \rightarrow which pass only those signal freqs. for which they are ~~tuned~~ tuned.
2. Absorption cavity \rightarrow it attenuates those signal freqs. for which they are ~~tuned~~ tuned.

Measurement of Impedance :-



$$VSWR = \sqrt{\frac{P_{max}}{P_{min}}} = \frac{V_{max}}{V_{min}}$$

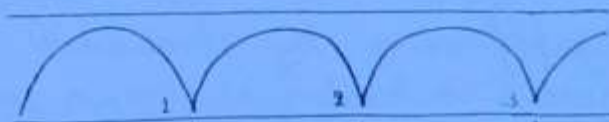
$$\text{Reflection coefficient} = K = \frac{VSWR - 1}{VSWR + 1}$$

$$K = \frac{Z_L - Z_0}{Z_L + Z_0}$$

$$Z_L = \text{Magnitude}$$

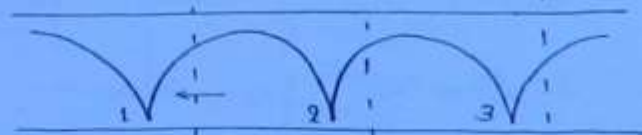
1st Set

With unknown impedance



2nd Set

With Short ckt



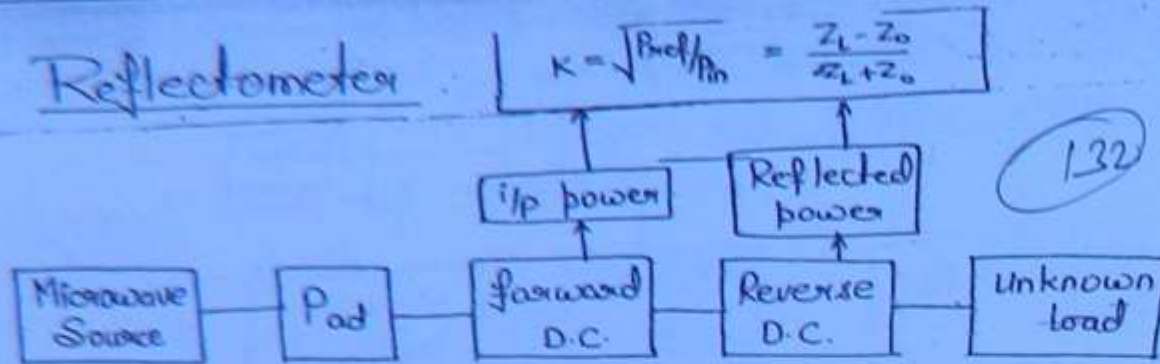
Inductive



Capacitive

2 Standing wave pattern is obtain for unknown load. So unknown load is replaced by short ckt. If minimal shift ~~tow~~ towards left - impedance is Inductive, If minimal shift towards left unknown impedance is capacitive.

Reflectometer



$$VSWR = \frac{1 + |K|}{1 - |K|}$$

Reflectometer's accuracy is high for low VSWR.

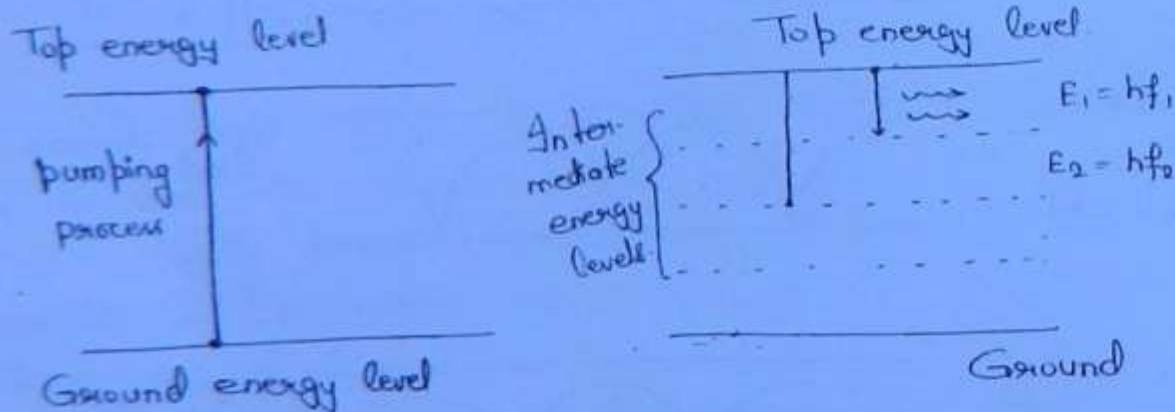
Measurement of Dielectric Constant :-

"VON HIPPEL METHOD"

LASER & MASER

MASER → Microwave amplification by stimulated emission of Radiation

LASER → Light amplification by stimulated emission of Radiation.



$$E = h\nu = hf$$

h = plank's constant

$$h = 6.624 \times 10^{-34} \text{ erg} \cdot \text{sec.}$$

$$h = 6.624 \times 10^{-34} \text{ J/sec.}$$

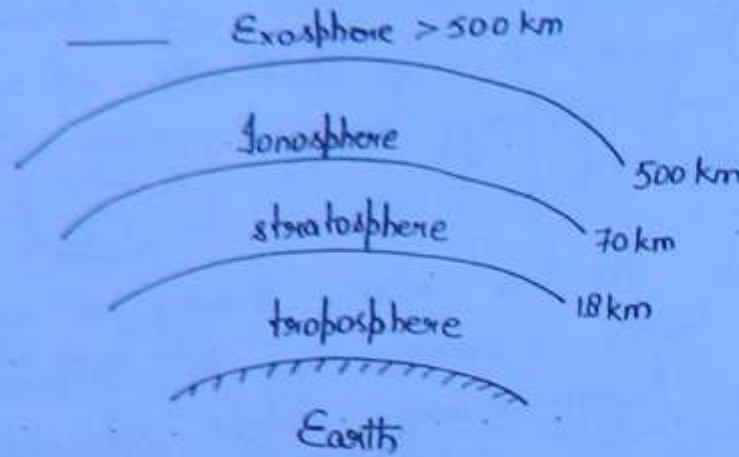
- 65
- These devices are highly directional coherent power devices with extremely low noise fig. hence these are used for generation & amplification of radiation & find applications in military, medicine, communication, space exploration etc.

(133)

Working Principle As per atomic theory e^- exists at various energy levels corresponding to different orbits. ~~they~~ they occupy lower energy levels at extremely low temp. by providing additional energy e^- can be raised or stimulated from this energy level. according to quantum theory the necessary energy for raised level of e^- is given by $E = h\nu$.

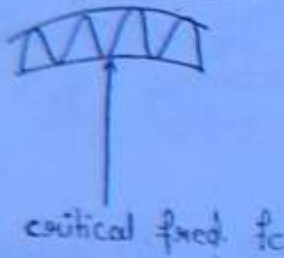
- Pumping is done at a freq. corresponding to energy difference b/w ground and top energy levels. ~~the~~
 - Re-emission of energy is stimulated at desired freq. and signal at this freq. is thus amplified.
 - Practically no noise is added to amplified signal as there is no resistance involved & no e^- stream. to produce ~~shot~~ noise. shot noise.
 - Cooling a maser as the effect of reducing the noise level i.e. noise figure is improved.
 - By using travelling wave ~~sub~~ ~~sub~~ structure instead of cavity, BW can be increased.
- material used:-
- | | |
|----------|----------|
| Ammonia | } fixed. |
| Hydrogen | |
| Cesium | |
- Ruby - Crystalline form of Al Aluminium Silica $[Al_2O_3]$
It is Amenable

μ wave communication system :-



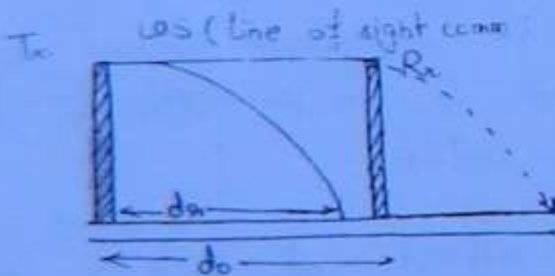
134

Ionospheric propagation (MUF)



$f_{\text{muf}} = \text{max usable freq.}$

$$f_{\text{muf}} = \frac{f_c}{\cos \phi} = f_c \sec \phi$$



$d_R = \text{Radio horizon}$

$d_O = \text{Optical horizon}$

correction factor $K = \frac{d_O}{d_R}$

$$K=1 \quad d_R = d_O$$

$$K>1 \quad d_R < d_O$$

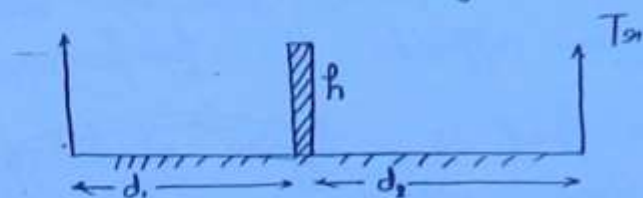
$$K<1 \quad d_R > d_O$$



As the μ wave radio horizon bend due to change in refractive index of atmosphere, radio horizon could be less than or greater than optical horizon.

- ii When seen from the tower effective height of an obstacle is more than its physical height due to earth curvature Bulge & fraction fresnel diffraction.

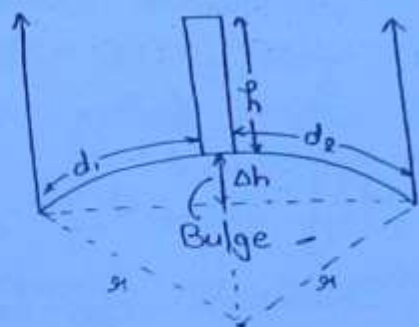
a) Earth curvature Bulge



(135)

d_1 = distance of obstacle from transmitting end km.

d_2 = distance of obstacle from receiving end km.

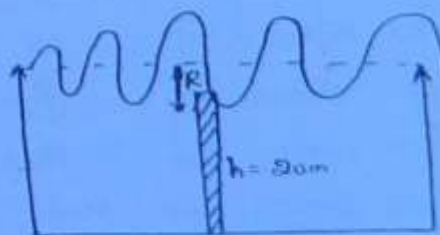
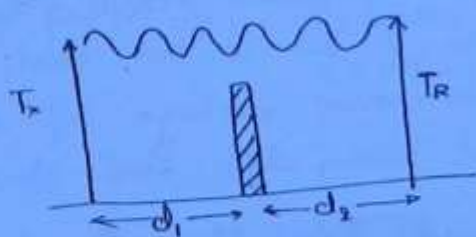


$$\Delta h = 0.078 d_1 d_2 \text{ mt}$$

Effective height of obstacle = $h + \Delta h$

b) Fresnel diffraction

It is expanding property of electromagnetic wave result in reflection and phase transition. As wave pass through obstacle.



$$R = 17.3 \left[\frac{d_1 d_2}{f(d_1 + d_2)} \right]^{1/2}$$

R - radius of 1st fresnel zone (mt)

f - freq. of operation (GHz)

R → 1st fresnel zone clearance

* At freq. > 10 GHz, the absorption due to ~~range~~ rain, fog & snow may effect the signal. (136)

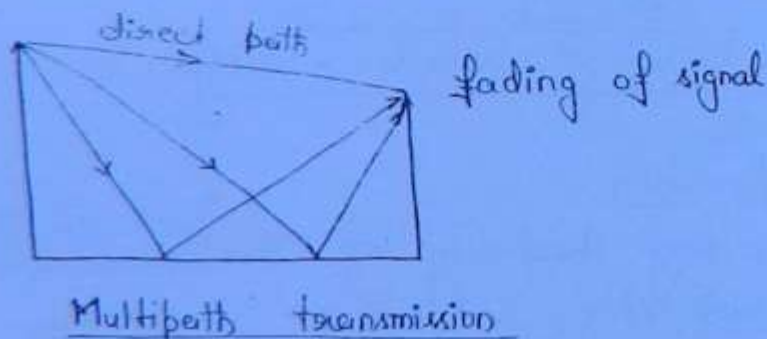
* At freq. > 20 GHz, absorption due to water vapour & atmospheric oxygen affects the performance.

* Advantage of higher freq. is higher directivity of antenna, less 1st fresnel zone clearance, reduced transmitter power & large base band BW.

* Disadvantage is increased propagation loss, fading and receiver noise figure.

* The LOS system suffers from fading. fading due to atmospheric band can be reduced by antenna having greater altitude (or) increasing height of antenna)

& fading due to multipath transmission can be reduced by freq., space or polarization diversity.

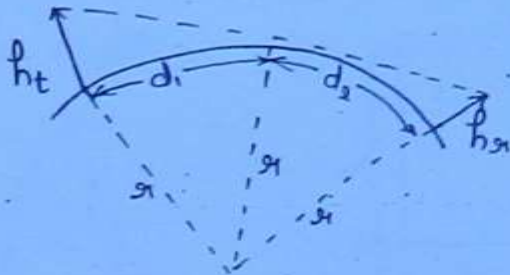


In ship to ~~ship~~ ship or ship to shore comm. we use freq. diversity for comm. [This is not most preferred method for comm b/c in this comm more advantage of spectrum E-or in this comm we send a signal using diff freq spectrum]

In all LOS comm. sys the ground below the direct path is 1st fresnel zone & is smooth reflecting the phase diff. b/w direct & indirect wave at receiving antenna will be 180° .

Repeaters are characterised by two antenna for two direction. repeaters are placed at 50 km apart due to curvature of earth.

LOS Communication Range :-



$$d = d_1 + d_2 = 3.57 [\sqrt{h_t} + \sqrt{h_r}] \text{ km}$$

d = LOS range (kms)

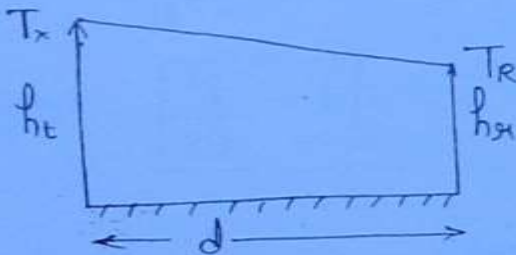
h_t = height of transmitting ant. mt.

h_r = height of receiving antenna.

For standard atmospheric refraction, effective radius of the earth is $4/3$ times of the actual radius of the earth \therefore actual line of sight comm. range is -

$$d = d_1 + d_2 = 4.12 [\sqrt{h_t} + \sqrt{h_r}] \text{ kms.}$$

Field strength at receiving antenna :-



$$E_R = \frac{88 \sqrt{P} h_t h_r}{d^2 \lambda}$$

P = effective radiated power in watt.

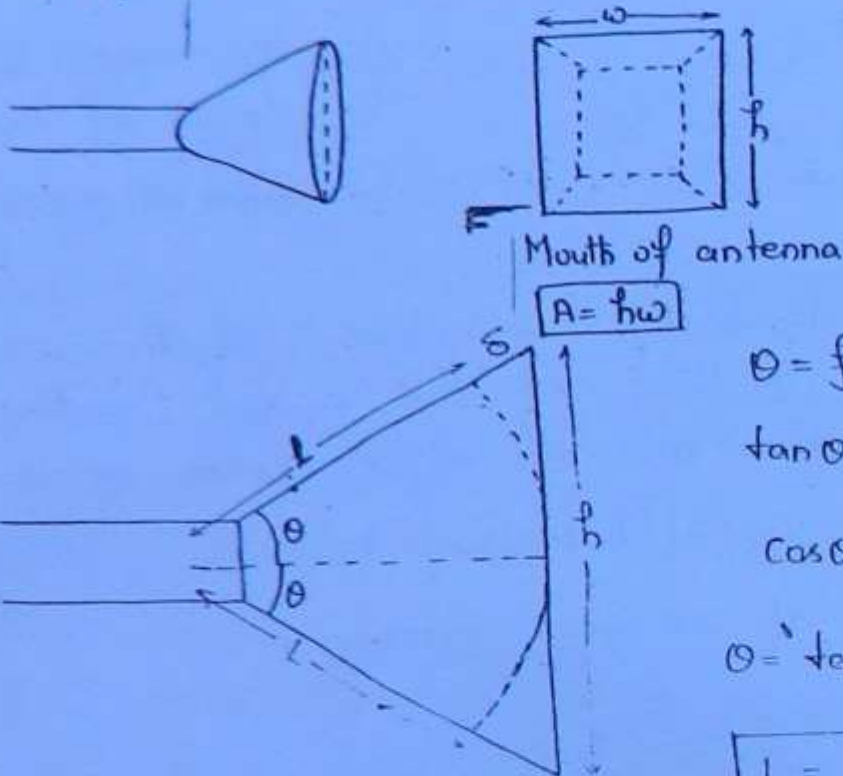
$$\left\{ \begin{array}{l} P = 10 \text{ W} \\ f = 1 \text{ GHz} \\ f = 10 \text{ GHz} \end{array} \right\}$$

Microwave Antenna :-

138

1. HORN Antenna :-

This is an open ended waveguided in which the open end is flared so that it looks like a horn.



θ = flared angle

$$\tan \theta = \frac{h/2}{L} = \frac{h}{2L}$$

$$\cos \theta = \frac{L}{L+S}$$

$$\theta = \tan^{-1} \frac{h}{2L} = \cos^{-1} \frac{L}{L+S}$$

$$L = \frac{h^2}{8S}$$

Design consideration

Beam width of horn antenna :-

$$\theta_E = \frac{56 \lambda^\circ}{h}$$

$$\theta_H = \frac{67 \lambda^\circ}{w}$$

θ_E & θ_H are half power beam widths in E & H direction

Directivity :-

$$D = \frac{7.5 A}{\lambda^2}$$

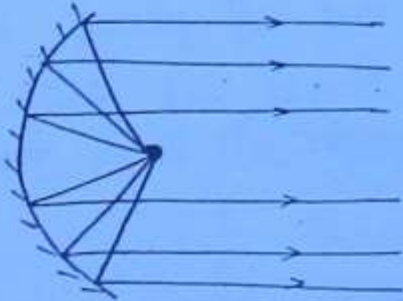
$A = hw$ = area of horn mouth [Aperture Area]

Power Gain :-

$$G_p = \frac{4.5 A}{\lambda^2}$$

Note:- Horn antennas are extensively used at microwave freq. where moderate power gains are sufficient. For large power gain horn dimension, become prohibitively large so that parabolic reflectors would be preferred. (139)

2. Parabolic Reflectors [Paraboloids or microwave dish antenna] \Rightarrow It utilizes geometrical optic principle.



Power Gain

$$G_p = \frac{4\pi A_0}{\lambda^2} = \frac{4\pi KA}{\lambda^2}$$

A_0 = Aperture Area

A = Actual area of mouth

K = a constant that depends on type of antenna feed

[For dipole feed $K=0.65$]

$$G_p = \frac{4\pi K}{\lambda^2} \left[\frac{\pi D^2}{4} \right]$$

D = Diameter.

$$\Rightarrow G_p \approx 6 \left[\frac{D}{\lambda} \right]^2 \frac{4\pi}{\lambda^2}$$

[if D & freq. are given \Rightarrow Obj]

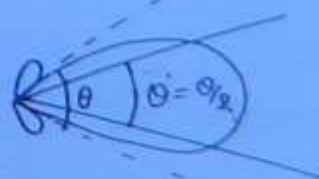
D/λ = Aperture Ratio

Beam Width b/w 1st nulls [BWFN]

$$\theta = \frac{140\lambda^\circ}{D}$$

Beam width b/w half power points [BWHP]

$$BWHP = \theta' = \frac{70\lambda^\circ}{D} = \theta/2$$



3 Lens Antenna \Rightarrow

(140)

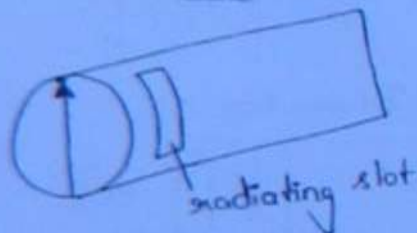


t - thickness at center
 $t = n\lambda$
 $n \gg 1$

It can be used in high freq. end of μ wave infect the freq. range of lens antenna starts at 1GHz. But its greatest used beyond 3GHz. at lower freq. lens antenna become bulky & heavy.

In order to have noticeable effect on the velocity of wave thickness of center of lens must be appreciable no. of wavelength i.e. $[t = n\lambda]$

4 Slot Antenna \Rightarrow



If the slots are cut in a waveguide radiation take place. Single slot radiators are mostly used in Air craft body. Where they are made of part of Air craft body such as tail fin.

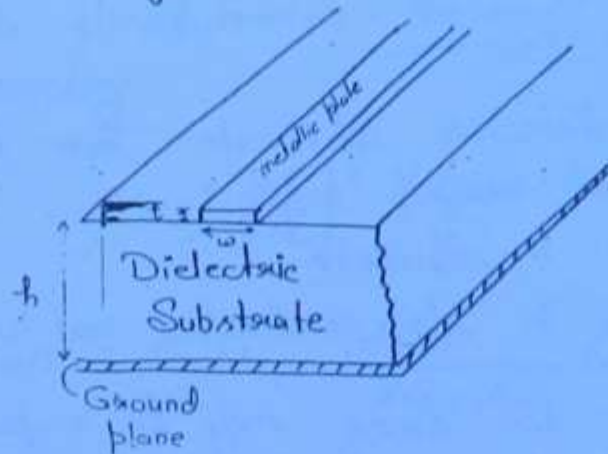
5 Helical Antenna \Rightarrow Circularly polarised wave

\Rightarrow Rotation of polarisation \rightarrow Faraday effect

Microstrip Lines :-

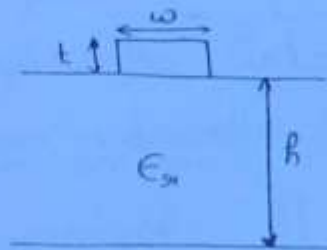
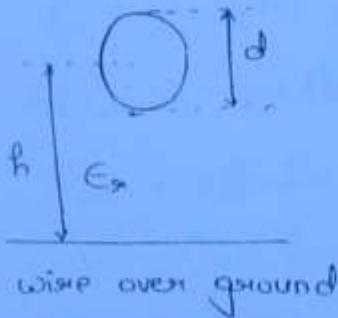
(14)

Conventional open wire transmission lines are not suitable for microwave transmission b/c radiation loss associated with wavelength increases as wavelength decreases then the physical length of conventional line at high freq.



w - width
t - thickness

Char. Impedance :-



for wire over ground

$$Z_0 = \frac{60}{\sqrt{\epsilon_r}} \ln \frac{4h}{d} \quad \text{--- (1)}$$

for $h \gg d$

$$\epsilon_{re} = 0.475 \epsilon_r + 0.67 \quad \text{--- (2)}$$

Given by Digiacomo

$$d = 0.67 w [0.8 + t/w] \quad \text{--- (3)}$$

Given by spring field

from eqn (1), (2) & (3)

$$Z_0 = \frac{87}{\sqrt{\epsilon_r + 1.41}} \ln \left[\frac{5.98h}{0.8w + t} \right]$$

for narrow microstrip line

For wide microstrip line

$$w \gg h$$

V_{gmp}
obj/conv.

$$Z_0 = \frac{h}{w} \sqrt{\frac{\mu}{\epsilon}} = \frac{377}{\sqrt{\epsilon_r}} \frac{h}{w}$$

(142)

Losses in microstrip lines \rightarrow

For non-magnetic dielectric substrate — two types of losses occurs in dominant microstrip mode —

1. Dielectric loss in substrate
2. Ohmic skin loss in strip conductor and ground plane.

The sum of these two losses may be expressed as losses per unit length in terms of an attenuation factor ' α '

$$\alpha = \alpha_d + \alpha_c$$

α_d — dielectric attenuation constant

α_c — ohmic attenuation constant

$$\alpha_d = \frac{\sigma}{2} \sqrt{\frac{\mu}{\epsilon}} \text{ Np/cm}$$

σ — conductivity of dielectric substrate = Ω/cm

dielectric loss tangent

$$\tan \theta = \frac{\sigma}{\omega \epsilon}$$

$$\therefore \alpha_d = \frac{\omega}{2} \sqrt{\mu \epsilon} \tan \theta \text{ Np/cm}$$

Ohmic loss

$$\alpha_c = \frac{8.686 R_s}{Z_0 w} \text{ dB/cm for } \frac{\omega}{h} \gg 1$$

$$1 \text{ Np} = 8.686 \text{ dB}$$

$$R_s = \sqrt{\frac{\pi f \mu}{\sigma}}$$

is surface skin resistance in Ω/area .

$$R_s = \frac{1}{\sigma} \Omega / \text{area}$$

$$S = \frac{1}{\sqrt{\pi f \mu \sigma}}$$

(143)

Radiation loss

It depends on substrate's thickness and dielectric constant & its geometry.

$$\frac{P_{\text{rad}}}{P_t} = 240\pi^2 \left[\frac{h}{\lambda_0} \right]^2 \frac{F(\epsilon_{\text{re}})}{Z_0}$$

$$F(\epsilon_{\text{re}}) = \frac{\epsilon_{\text{re}} + 1}{\epsilon_{\text{re}}} - \frac{\epsilon_{\text{re}} - 1}{2\epsilon_{\text{re}} \sqrt{\epsilon_{\text{re}}}} \ln \frac{\sqrt{\epsilon_{\text{re}}} + 1}{\sqrt{\epsilon_{\text{re}}} - 1}$$

P_{rad} — Radiated power

P_t — total dissipated power

$F(\epsilon_{\text{re}})$ — radiation factor

ϵ_{re} = effective dielectric constant

$\lambda_0 = c/f$ = free space wavelength

Imp. $\boxed{\frac{P_{\text{rad}}}{P_t} = \frac{R_r}{Z_0}}$

R_r = Radiation resistance of an open ckt. microstrip

$$\boxed{R_r = 240\pi^2 \left[\frac{h}{\lambda_0} \right]^2 F(\epsilon_{\text{re}})}$$

Quality factor \Rightarrow

wide micro strip line

$$Q_c = 0.63h \sqrt{\sigma} f_{\text{GHz}}$$

$$Q_d = \frac{\lambda_0}{\sqrt{\epsilon_{\text{re}}} \tan \delta} \approx \frac{1}{\tan \delta}$$

Q_c = related to conductor attenuation constant

Q_d = related to dielectric attenuation constant

parallel microstrip line

(page no. → 485

11-2-1

Liao)

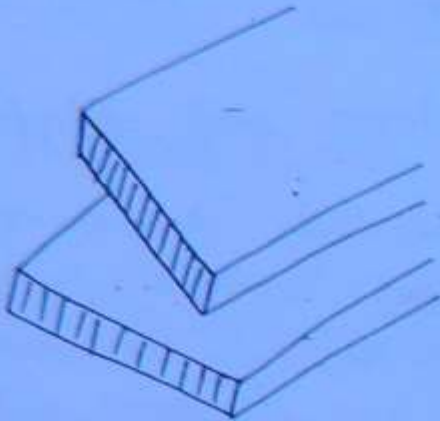
coplanar strip lines. → 488

11-3-1

(144)

Shielded strip lines. → 489

11-4-1



It is similar to a two-conductor transmission line so it can support a Quasi-TEM mode

Distributed Parameters

$$L = \frac{\mu_c d}{w} \quad \text{H/m}$$

μ_c = permeability of conductor

$$C = \frac{\epsilon_d w}{d} \quad \text{F/m}$$

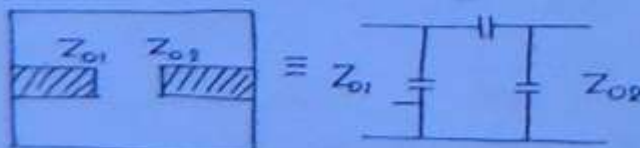
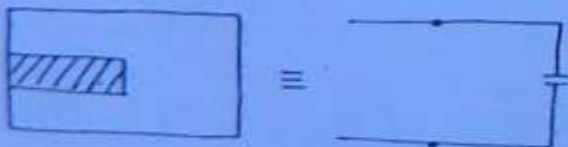
ϵ_d = permittivity of dielectric slab

$$Z_0 = \sqrt{\frac{L}{C}} = \frac{d}{w} \sqrt{\frac{\mu_c}{\epsilon_d}} = \frac{377}{\sqrt{\epsilon_d}} \frac{d}{w}$$

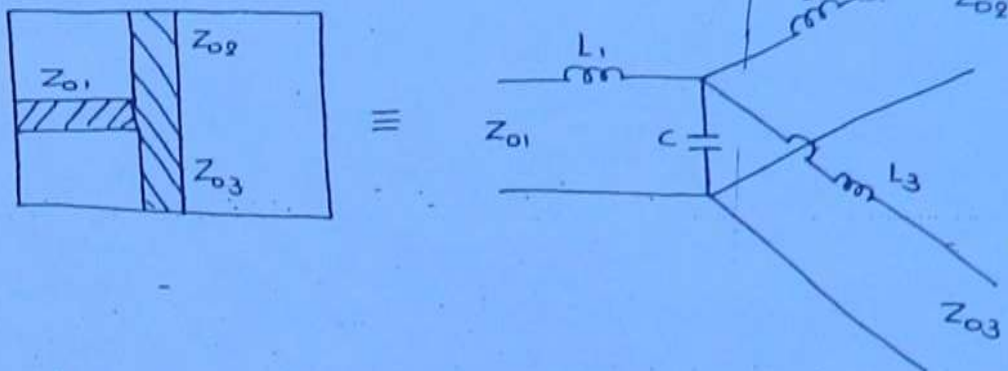
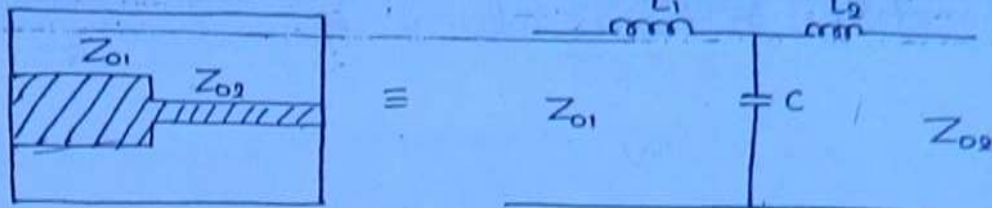
for lossless line

Microwave Discontinuities →

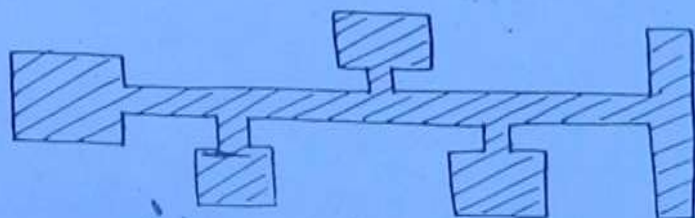
(Microstrip discontinuities)



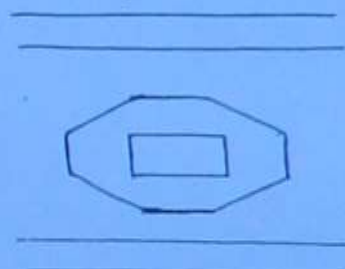
145



conductor Pattern



High pass filter



A-channel dropping filter

S-parameters in terms of Z-parameters →

$$\Delta Z = (Z_{11} + Z_0)(Z_{22} + Z_0) - Z_{12}Z_{21}$$

$$S_{11} = \frac{(Z_{11} - Z_0)(Z_{22} + Z_0) - Z_{12}Z_{21}}{\Delta Z}$$

$$S_{12} = \frac{2Z_{12}Z_0}{\Delta Z}$$

$$S_{21} = \frac{2Z_{21}Z_0}{\Delta Z}$$

$$S_{22} = \frac{(Z_{11} + Z_0)(Z_{22} - Z_0) - Z_{12}Z_{21}}{\Delta Z}$$

S parameters in terms of Y-parameters →

$$\Delta Y = (Y_0 + Y_{11})(Y_0 + Y_{22}) - Y_{12} Y_{21}$$

$$S_{11} = \frac{(Y_0 - Y_{11})(Y_0 + Y_{22}) + Y_{12} Y_{21}}{\Delta Y}$$

146

$$S_{22} = -\frac{2Y_{12} Y_0}{\Delta Y}$$

$$S_{21} = -\frac{2Y_{21} Y_0}{\Delta Y}$$

$$S_{12} = \frac{(Y_0 + Y_{11})(Y_0 - Y_{22}) + Y_{12} Y_{21}}{\Delta Y}$$

The end